

Lecture 2: Surfaces from a manufacturing perspective

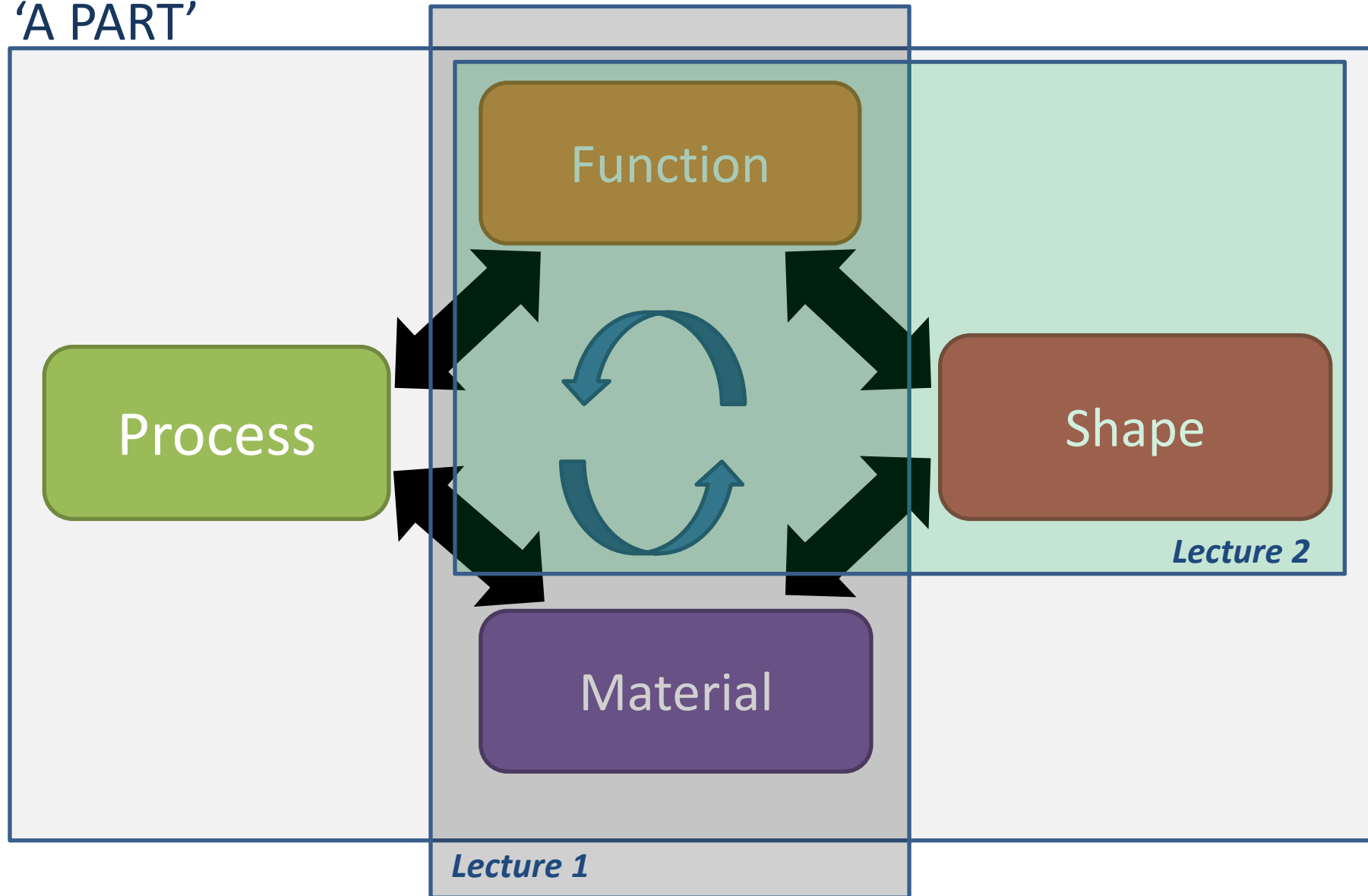
Prof. Yves Bellouard
Galatea Lab, STI/IEM



Today's learning objectives

- **Importance** of surfaces in manufacturing
- How do we **define / characterize** a surface?
 - Geometrical parameters, texture
 - Characterizations methods
 - Physical properties

'A PART'



Discussion in class (5 min)

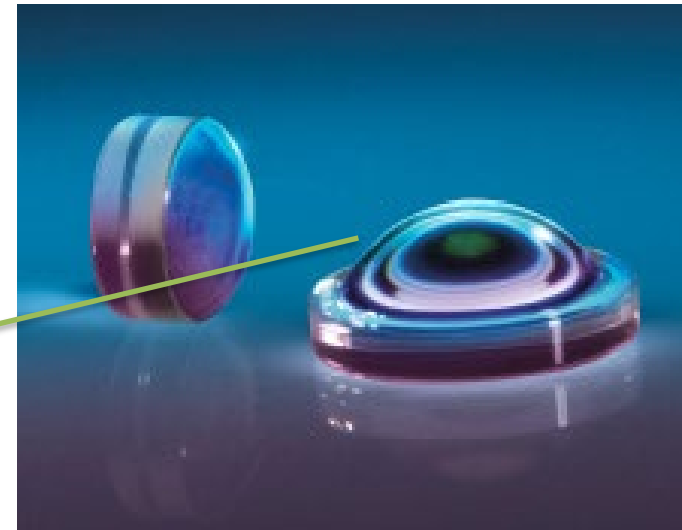
What functions can be associated with a surface?

Surface & functions...



(bizlaunchblog.com)

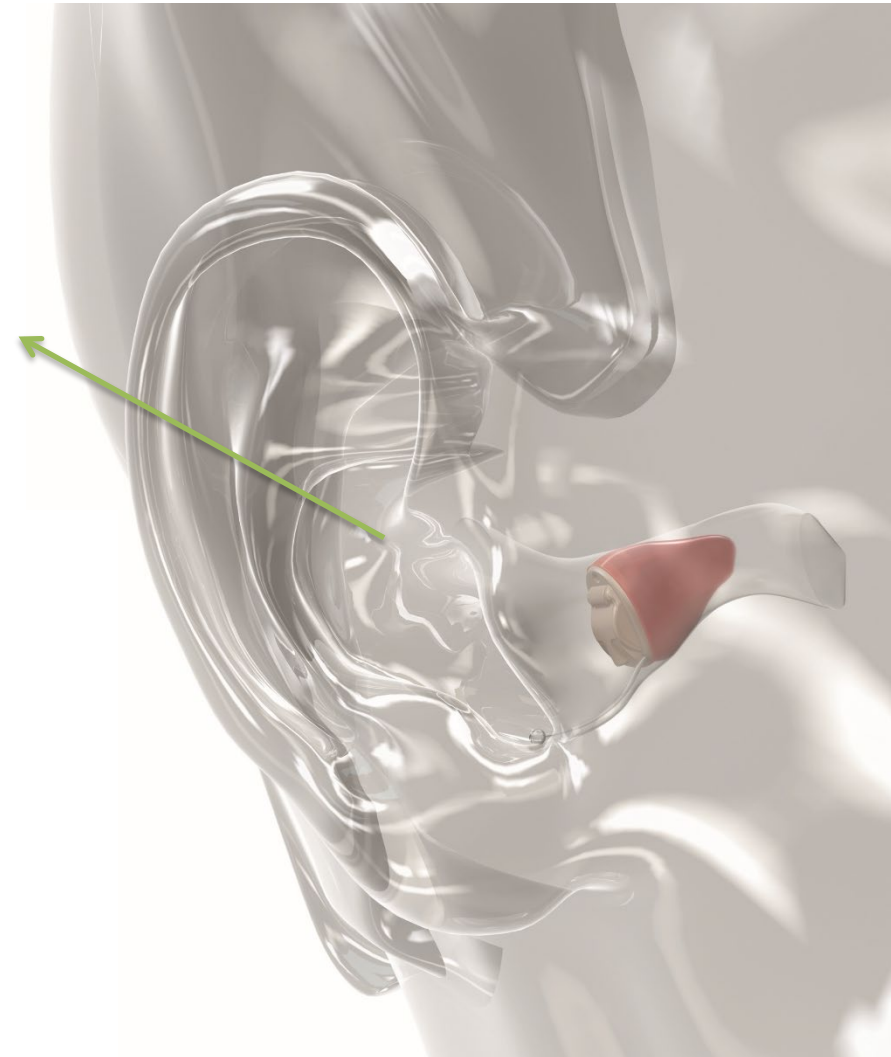
- Transparent
- Scratch resistant
- Others..



- Transparent
- Specific and precise shape
- 'The shape is the function'

Surfaces & functions...

Soft
Skin-friendly (non allergenic)

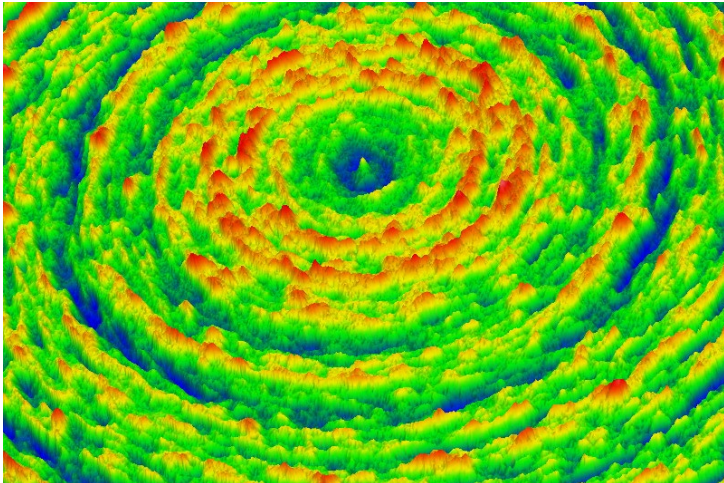
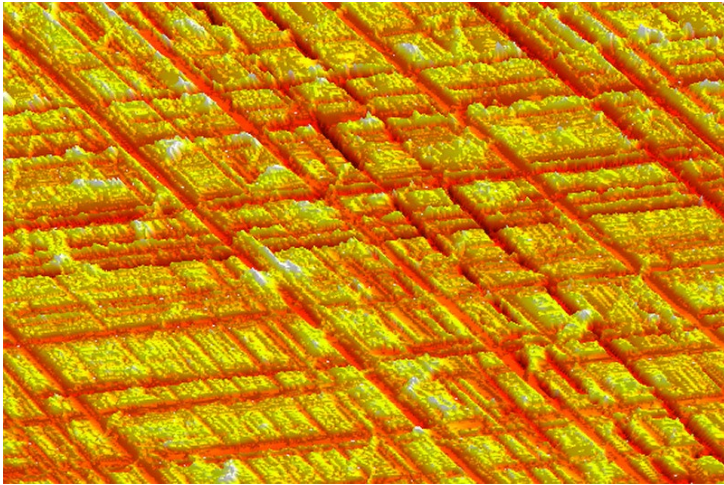


(Phonak, Nano)

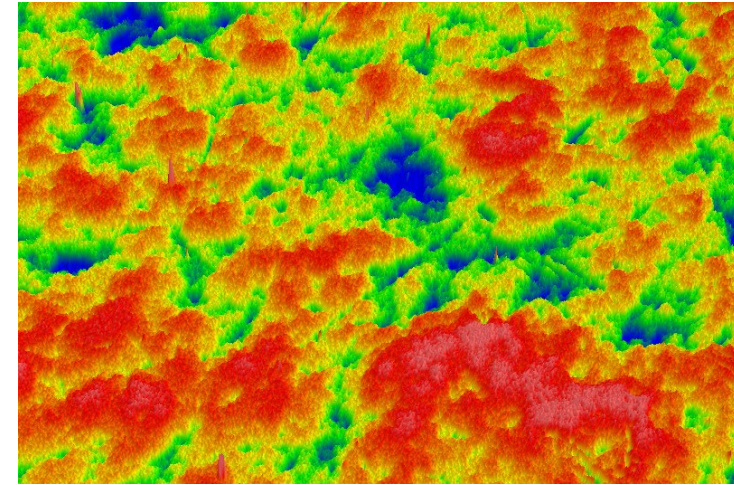
Surface and functions...



Illustration of surface textures at the microscale

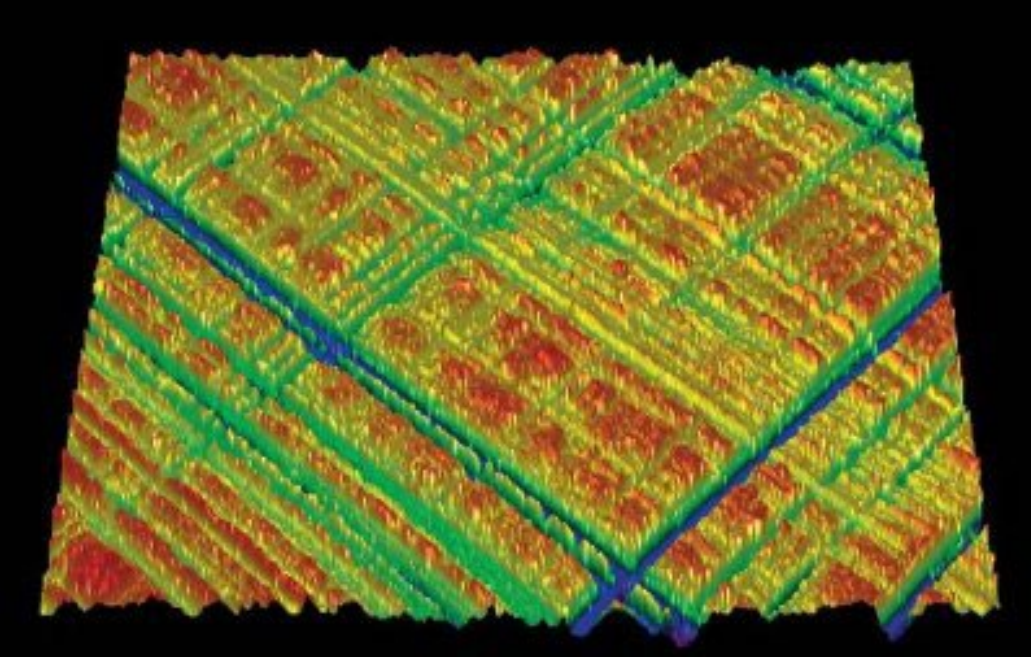


Textured



Somewhat random

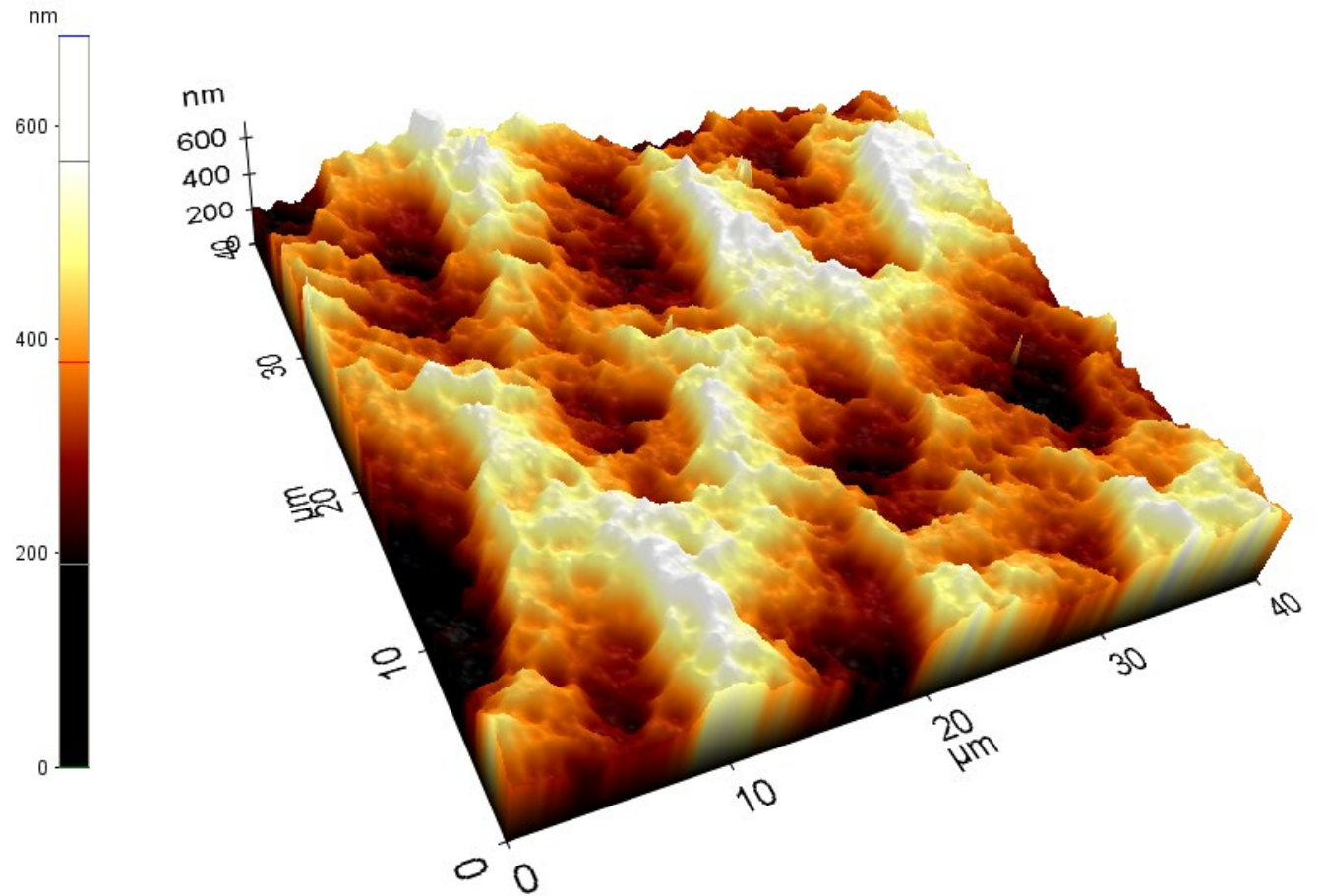
Examples of different surface finish leading to different textures (cross-hatch, turned, grounded)



(azom.com)

(Exercise with Gwyddion)

A complex 3D problem!



Surfaces: key questions

- **How to translate a functional requirement into a physical surface requirement?**
 - Ex. 'optically transparent' = typ. roughness $R_a < 10 \text{ nm}$, why is that?
- **What are essential physical properties of a surface?**
 - Ex. hydrophobic = contact angle with water $> 90 \text{ deg}$
- **How to characterize a surface? (Metrology)**
 - Ex. define roughness, waviness, etc.

Properties of surfaces and their characterization

- **Topography characterization**

- Roughness
- Waviness
- Profile

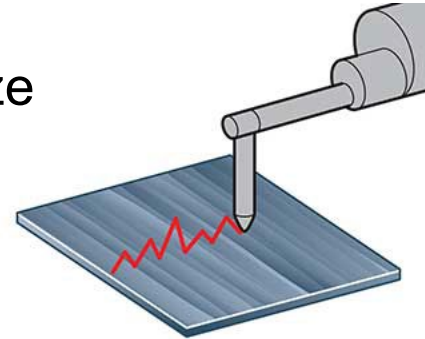
- **Physical properties**

- Wettability (Hydrophobic, hydrophilic)
- Mechanical Hardness
- *Others (chemical, optical, etc.)*

How do we measure surfaces?

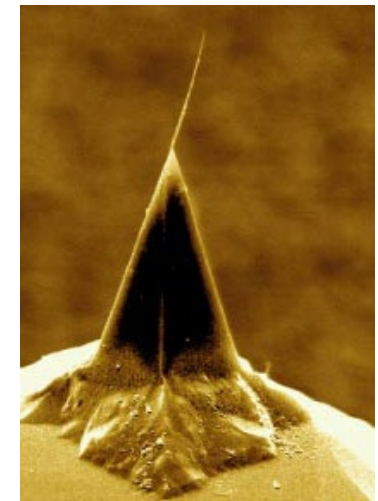
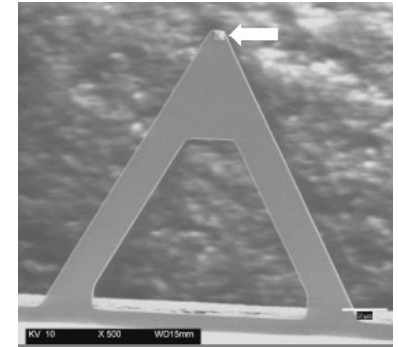
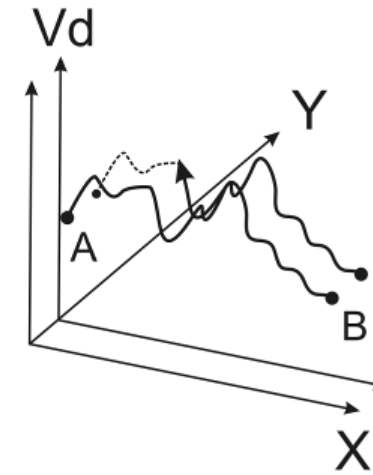
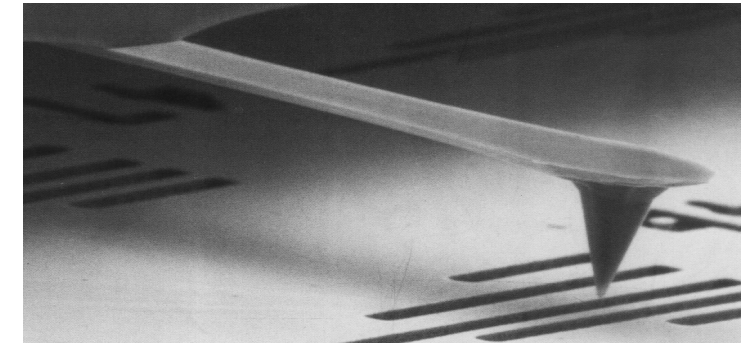
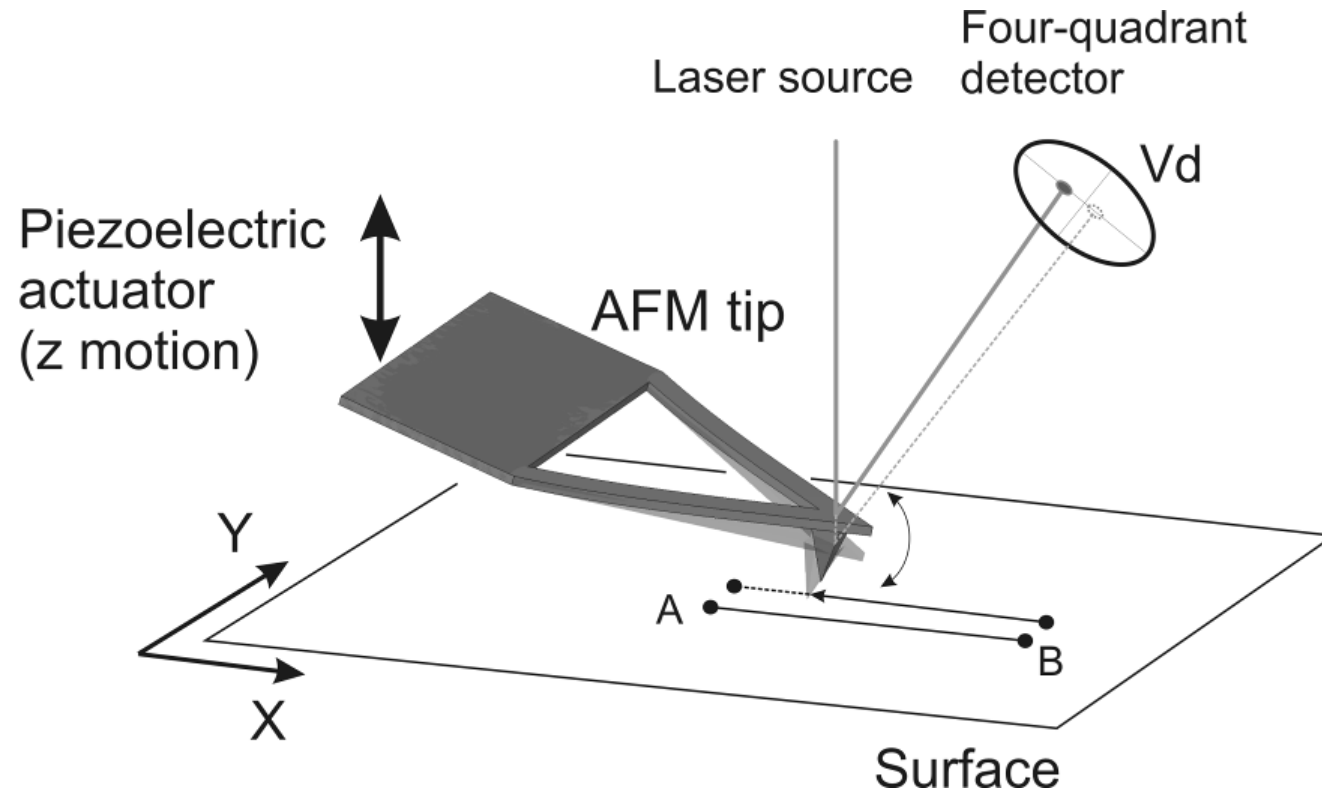
Three main methods

- **Optical-based profilometry techniques** – large surface imaging
 - Confocal microscopy / high-depth of field, limited lateral spatial resolution (diffraction limit)
 - Phase shift interferometry / high resolution along the optical axis (< a few nm), limited lateral spatial resolution (diffraction limit)
 - Digital Holography Microscopy (DHM), etc.
- **Direct contact methods (stylus)**
 - Resolution depends on the actual stylus size
 - Large surface area can be measured
 - Commonly use in industry
 - Contact method
- **Atomic force microscopy (AFM)** – limited surface imaging (typ. $50 \times 50 \mu\text{m}^2$)
 - Contact and non-contact measurement
 - High resolution (nanoscale down to atomic level in certain conditions)
 - Physical interaction with the specimen



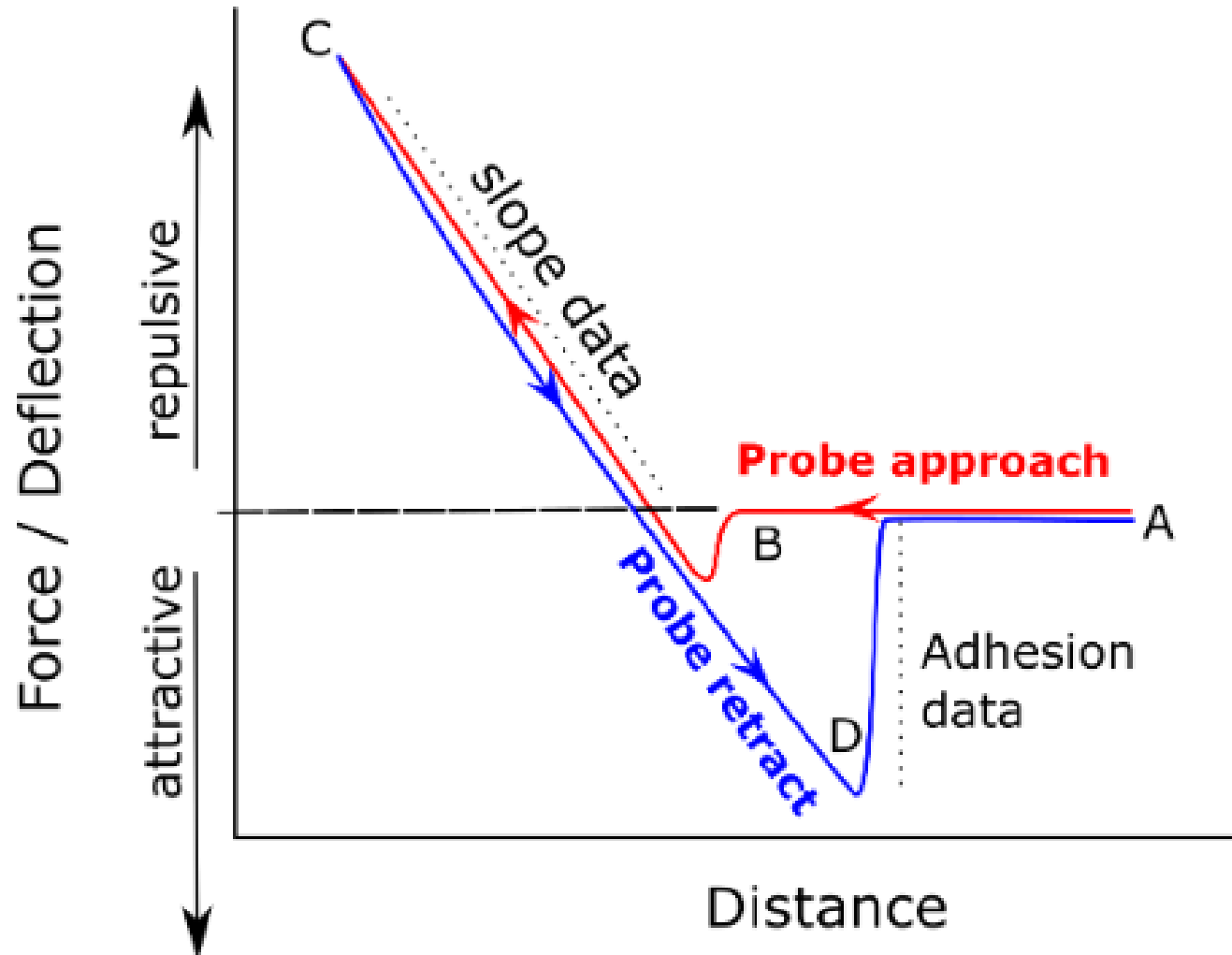
(Illustration Mitutoyo)

Measuring surface forces at a **nano-scale** level: “Atomic Force Microscope”



Invented in 1986, Binnig, Gerber, Quate (IBM Zurich Lab)
1986 / (STM) Nobel prize G. Binnig, H. Röhler (IBM Zurich Lab)

Typical interaction force for an AFM

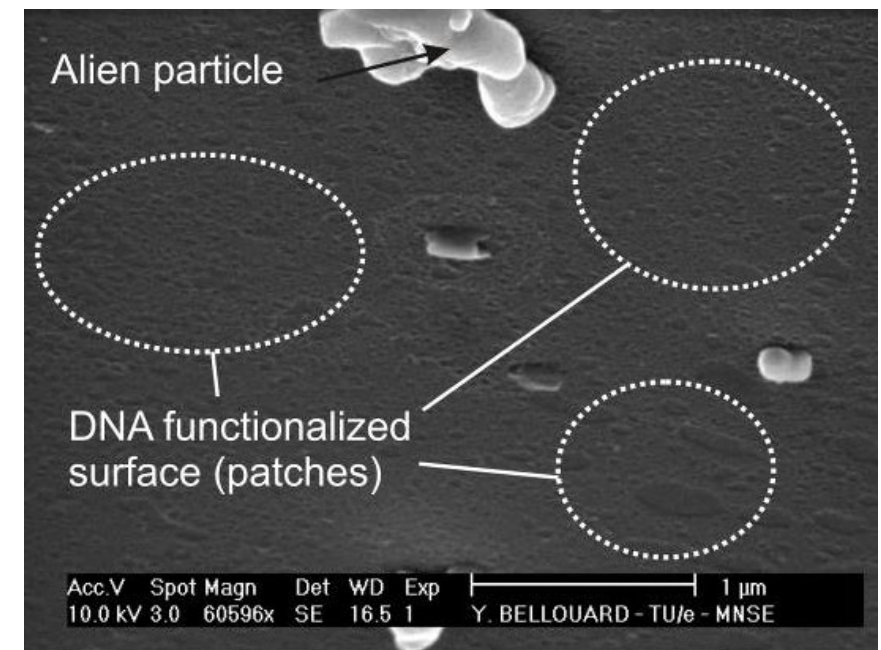
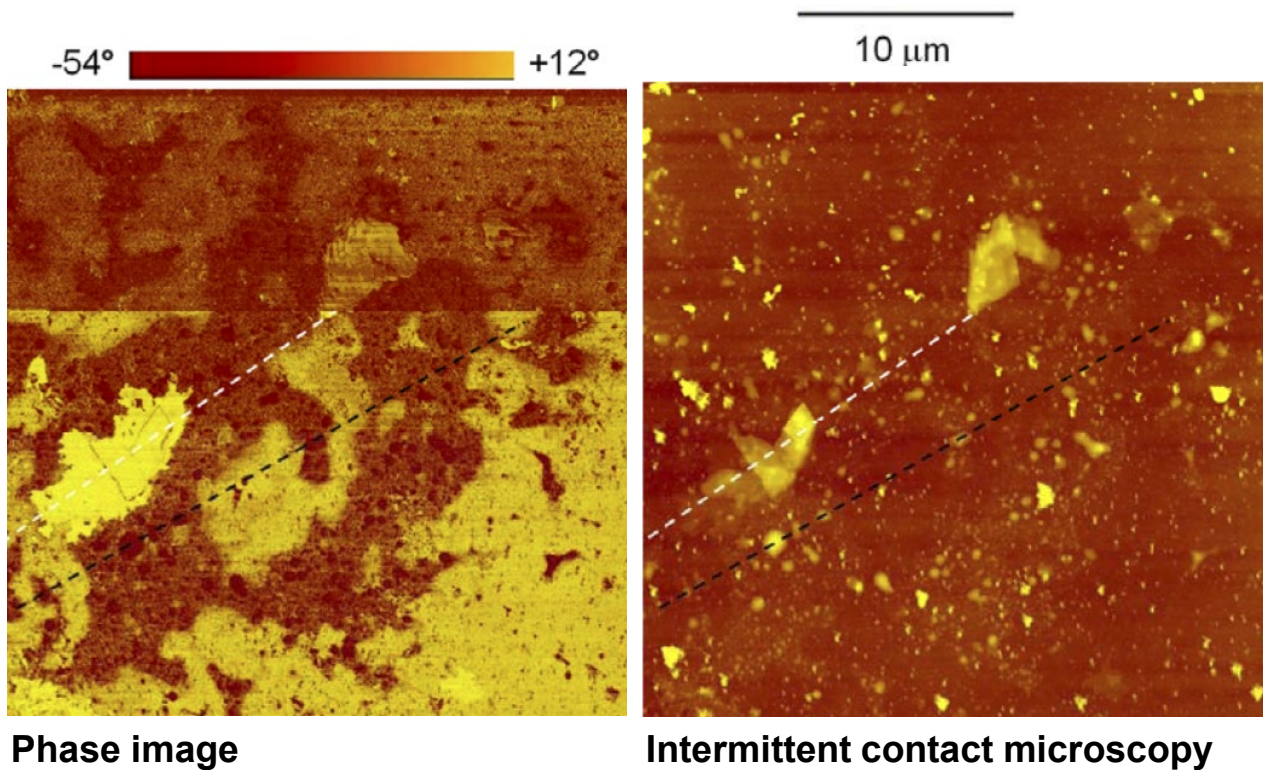


- Force/deflection force provides information about the physics of the surface.
- Specific probes can be used to retrieve rich information, such as thermal transfer, conductivity, etc.
- **An AFM can provide more than just the topography**

(source: AFMWorks)

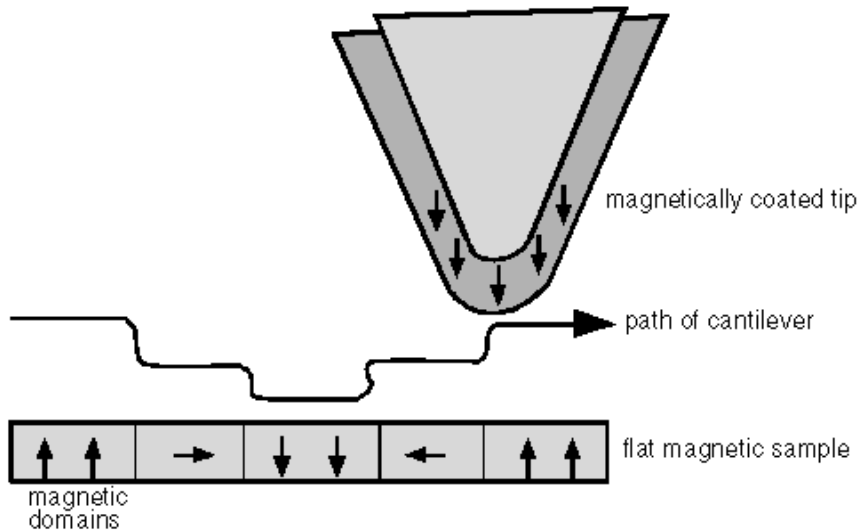
Illustration 1: DNA molecules on a silica fiber

- Atomic Force Microscopy (Phase imaging)



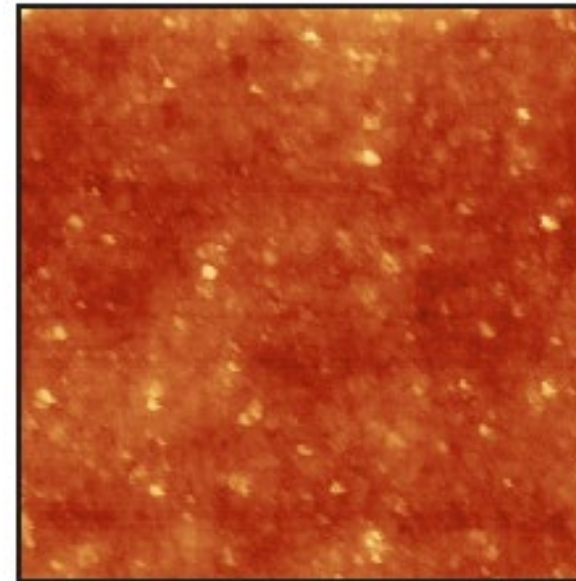
Source: GOLEM project, TU/e (Madani-Grasset, Bellouard)

Illustration 2: Magnetic Force Microscopy



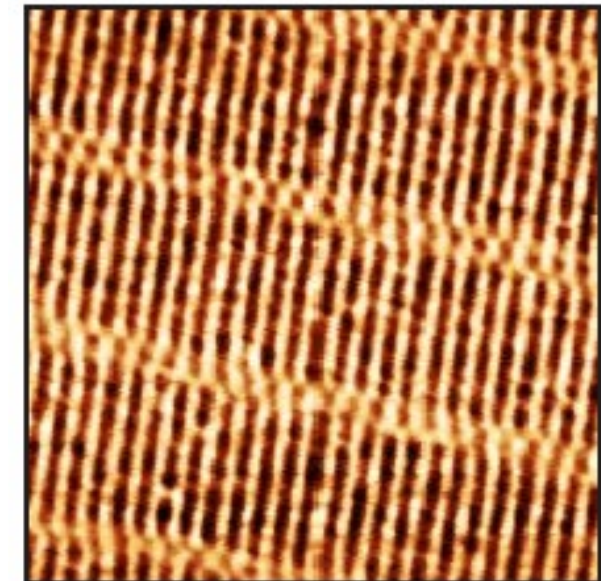
- Ferromagnetic tip: Co, Cr
- Noncontact mode
- van der Waals force: short range force
- Magnetic force: long range force; small force gradient
- Close imaging: topography
- Distant imaging: magnetic properties

Topography
surface
information



AFM image, Zip Disk 40 x 40 μm

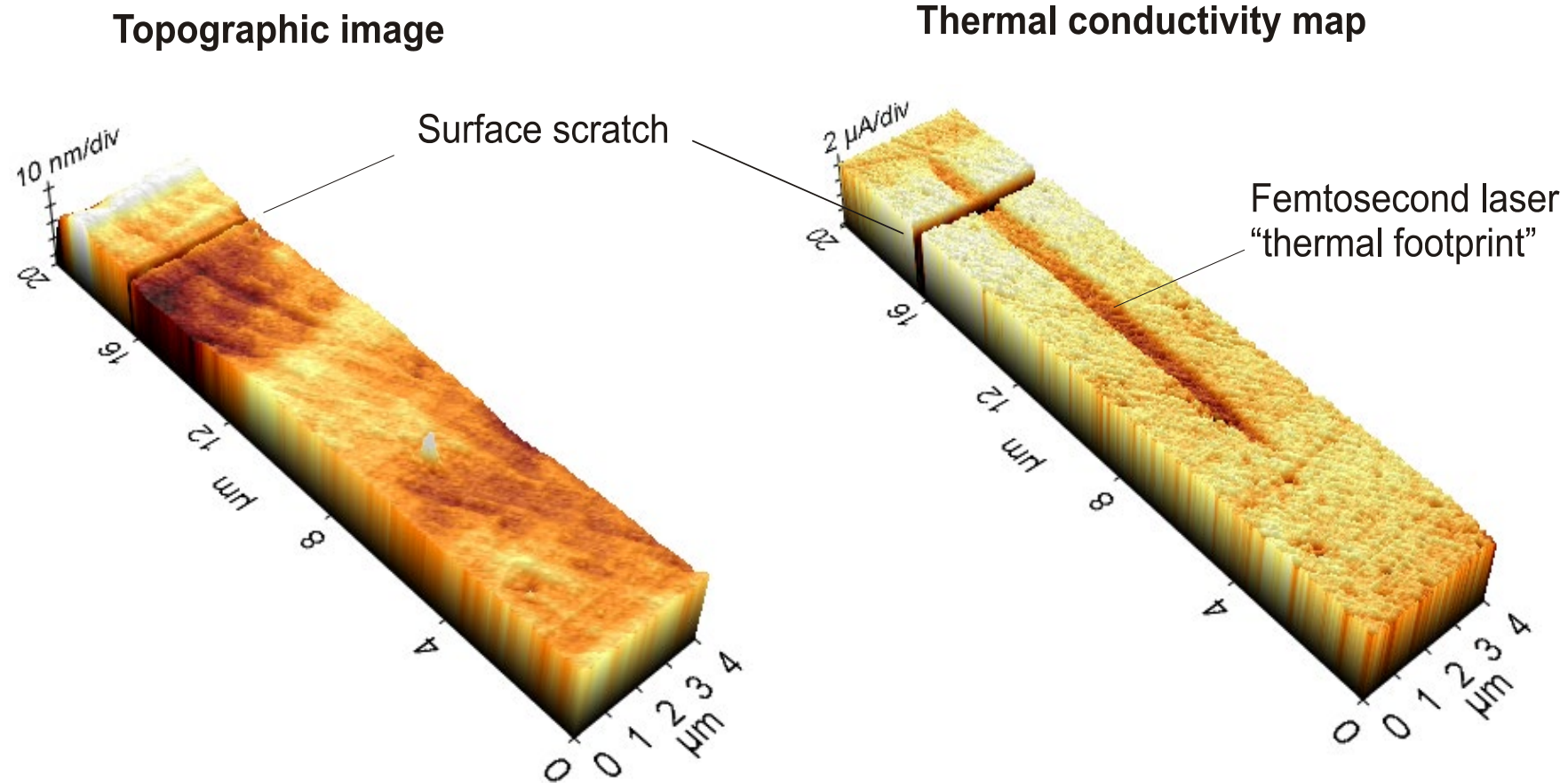
Functional
surface
information



MFM image, Zip Disk 40 x 40 μm

Source : AFM workshops (TM)

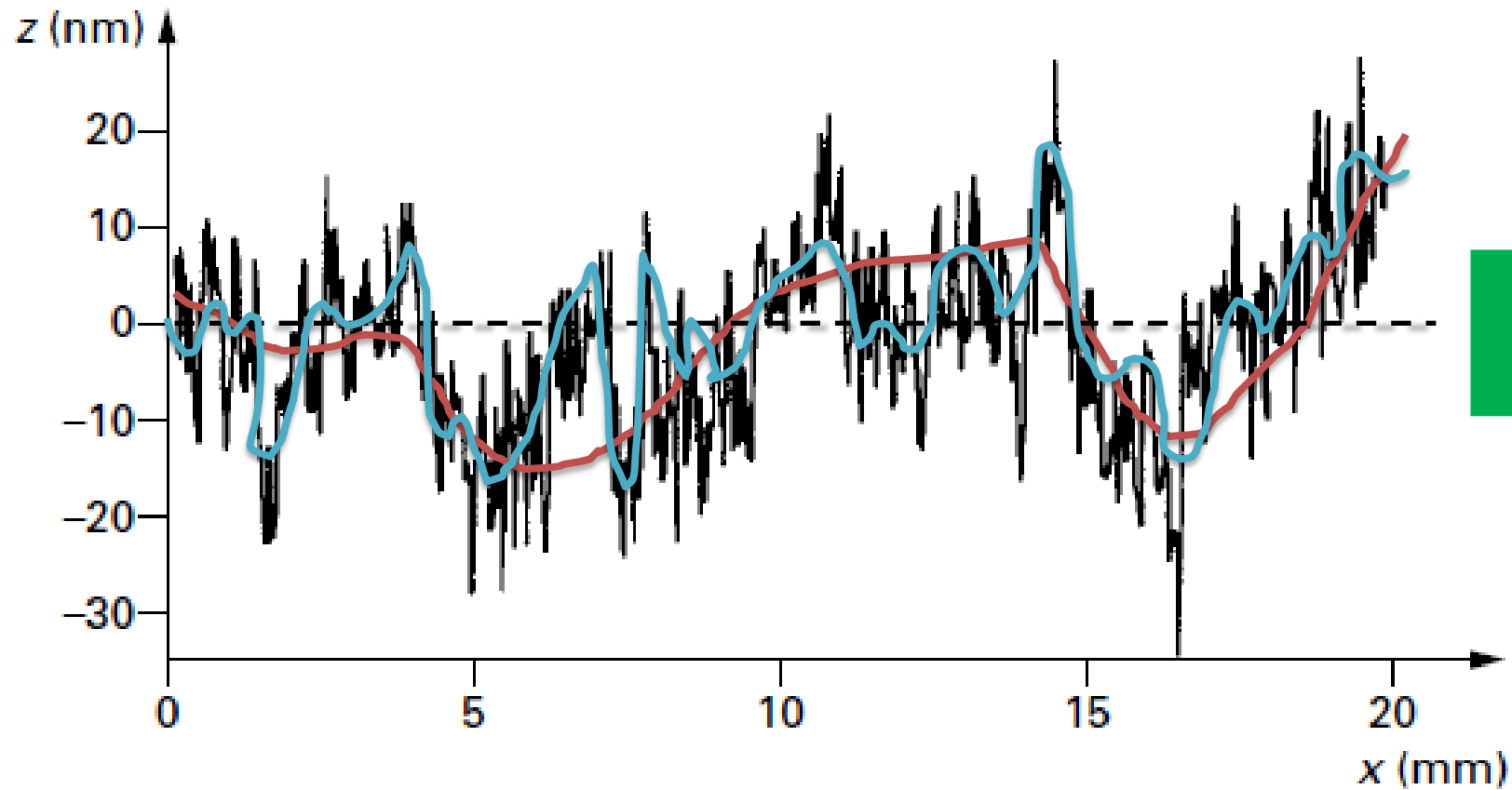
Illustration 3: Waveguide in a glass substrate



Y. Bellouard et al, Appl. Phys. Lett. 89, 161911 (2006).

‘Geometrical characteristics’ / Topography

Problem statement

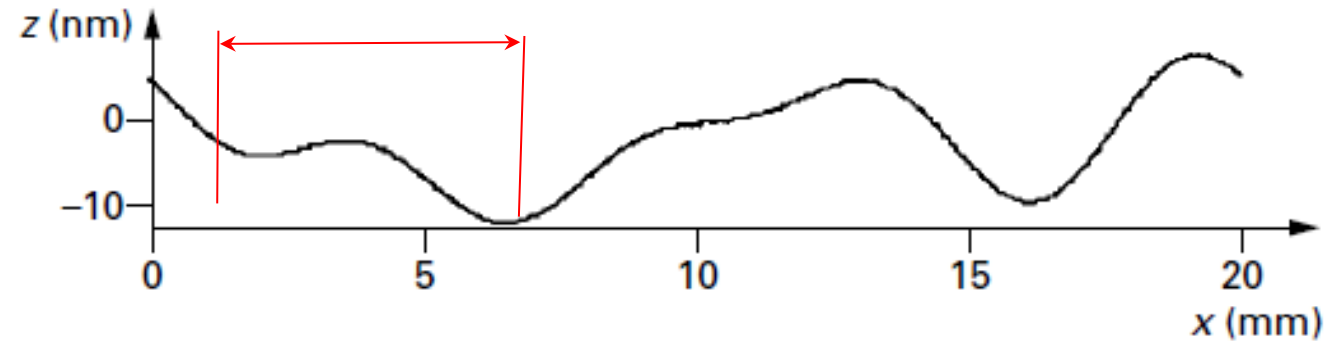


Signal
processing
methods

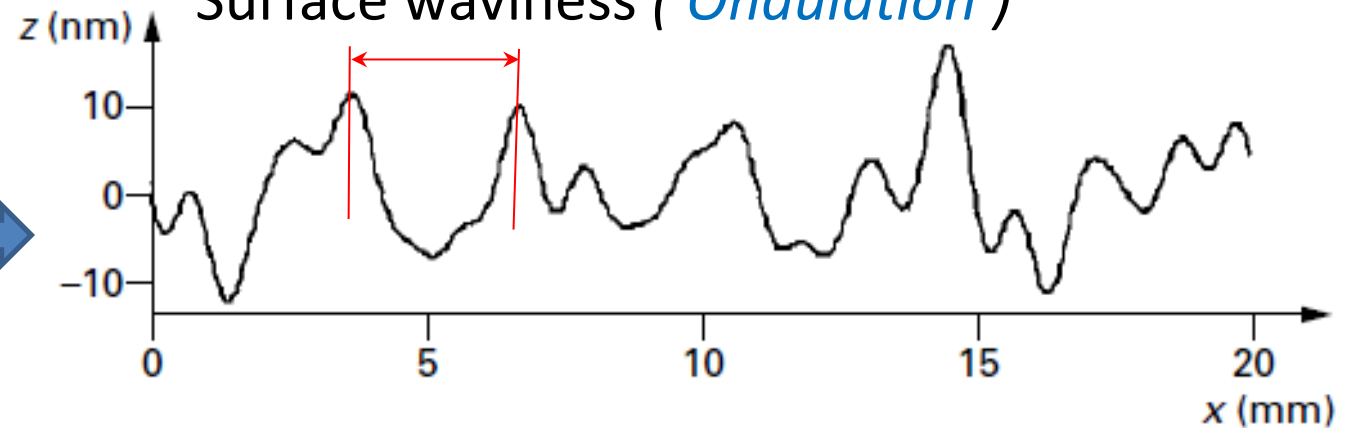
Spectral
decomposition



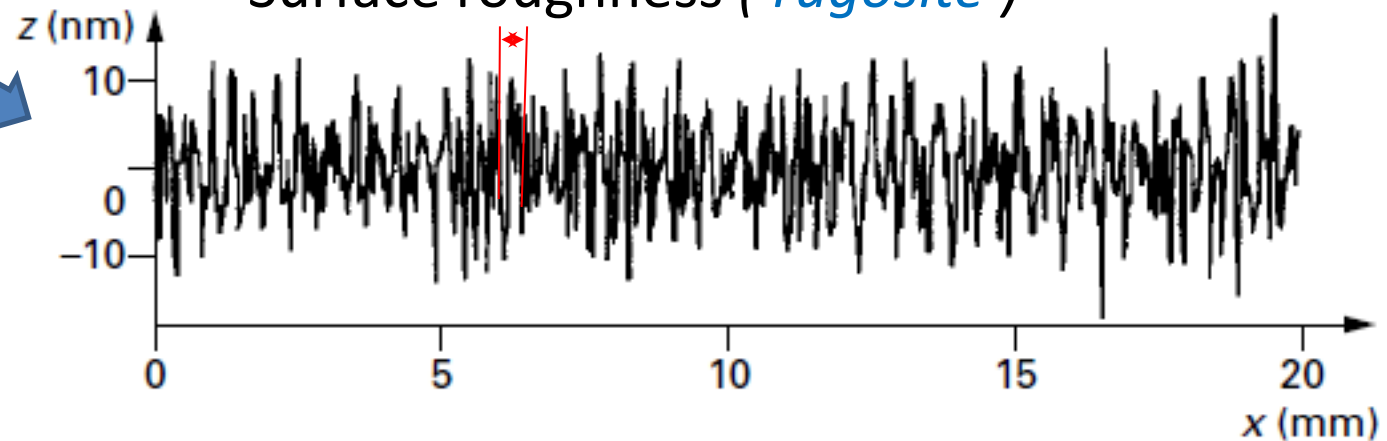
Surface profile deviation (*'Ecart de forme'*)



Surface waviness (*'Ondulation'*)



Surface roughness (*'rugosité'*)



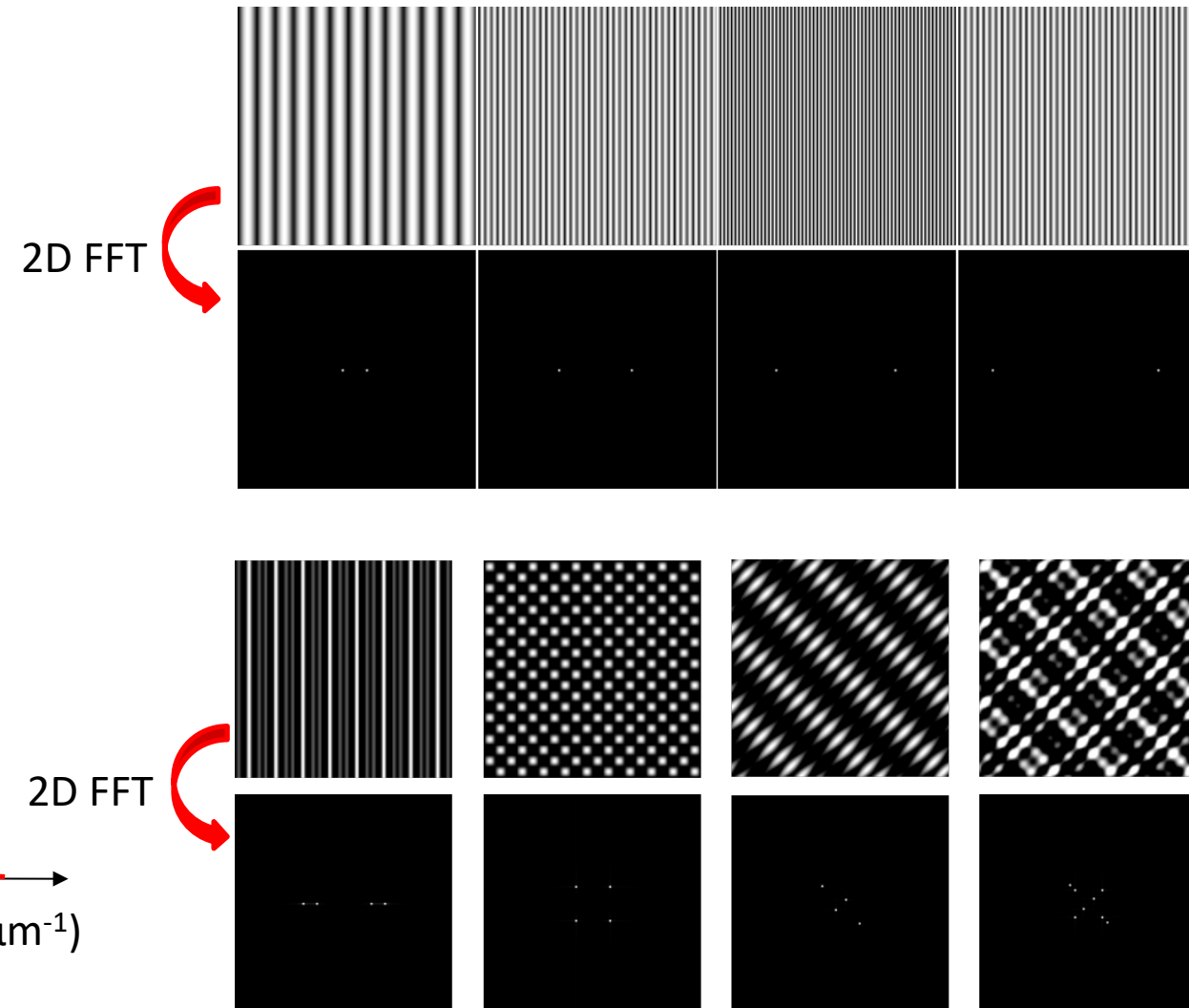
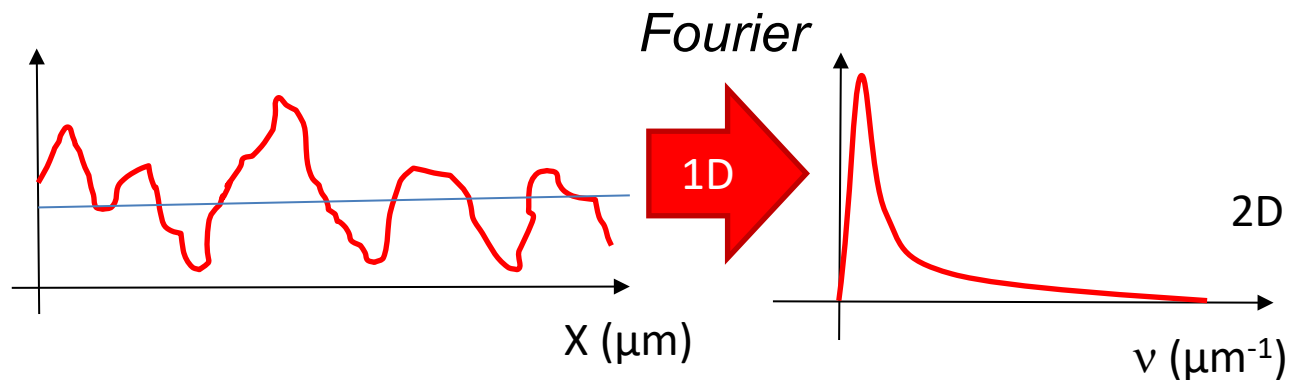
Towards higher spatial wavelength



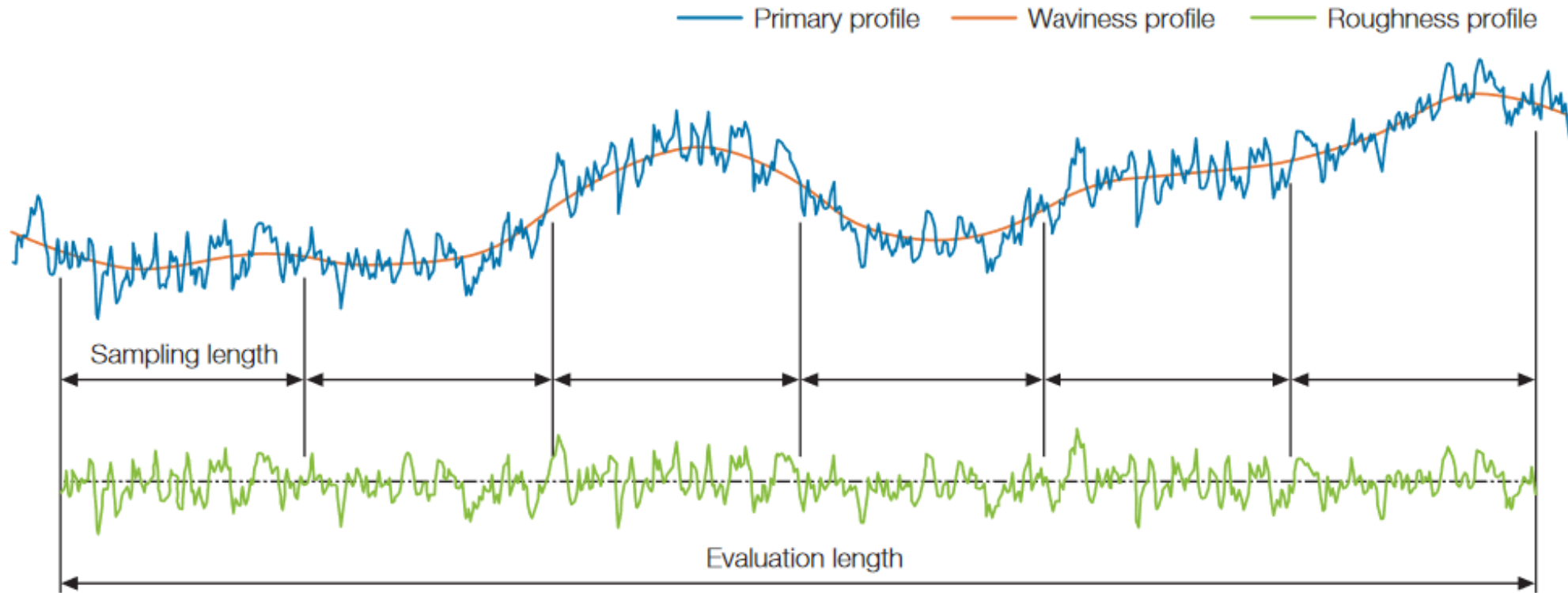
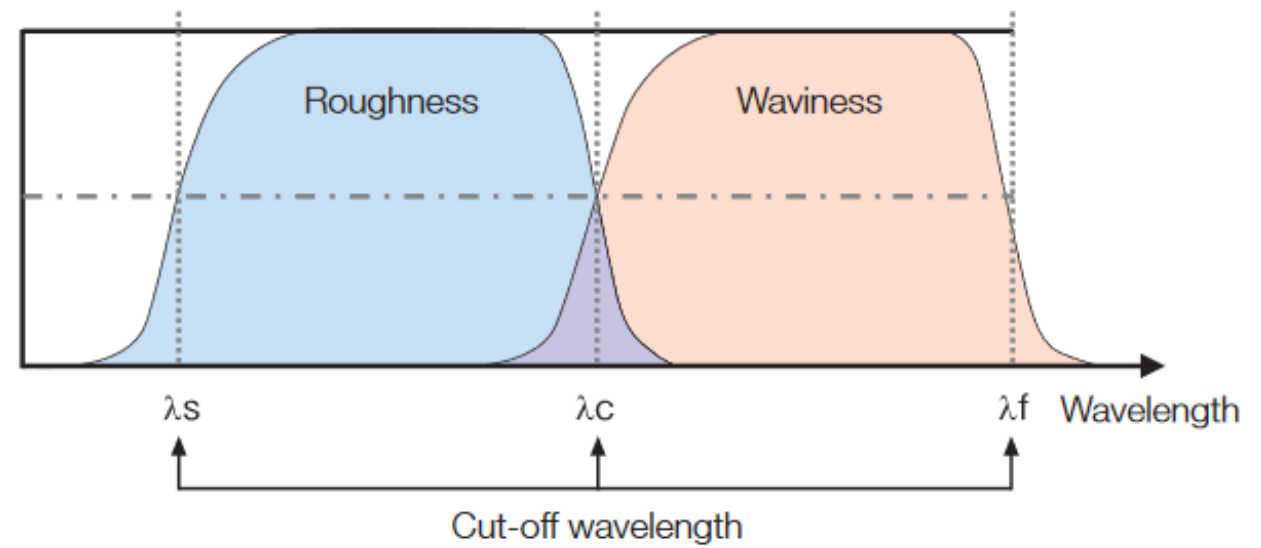
Fourier analysis in the spatial domain

- Concept of spatial frequency
- 2D-Fourier transform

$$S(\nu, \omega) = \int_{-\infty}^{+\infty} \int_{-\infty}^{+\infty} s(x, y) e^{-2\pi(\nu x + \omega y)}$$



Cut-off frequency



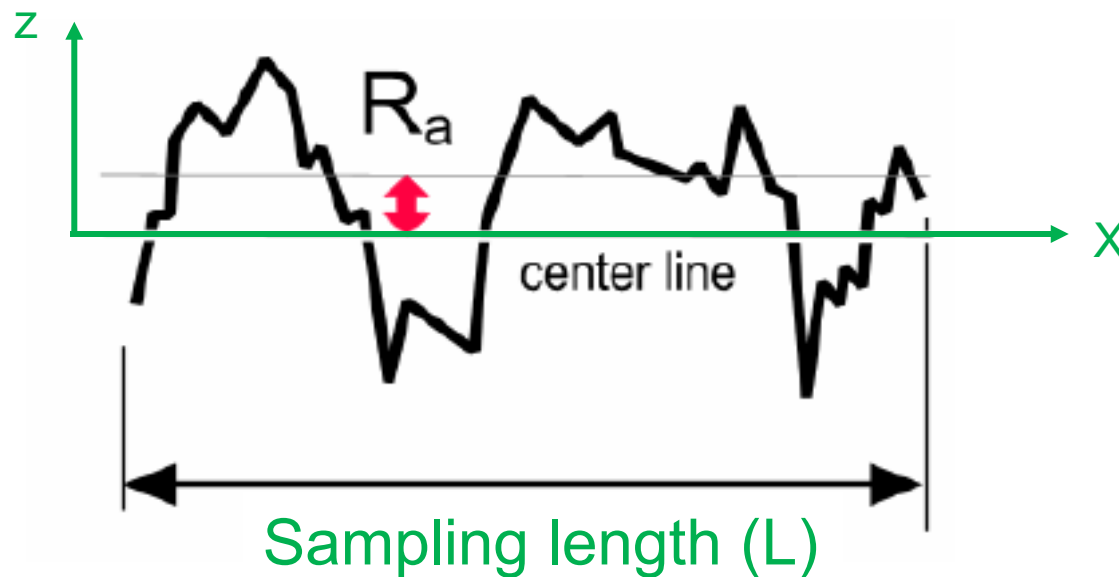
(adapted from Olympus corporation)

Why measuring/defining a surface topology?

- **Surface topography can have a strong impact on the part behavior!**
- Part manufacturing reproducibility / Process control: it tells us about how the process is evolving / evidence of tool wears, etc.
- Wear state of a surface
- Conformability of a surface with respect to desired functionalities:
 - *Load capacity*
 - *Bearing / lubrication properties*
 - *Optical properties*
 - *Thermal properties, ...*
- It is a signature of a manufacturing process

A common surface metric: the arithmetic average (R_a)

- A statistical parameters: arithmetic average
- Very used in industry!
- Often the only one you hear about...



Sampling length

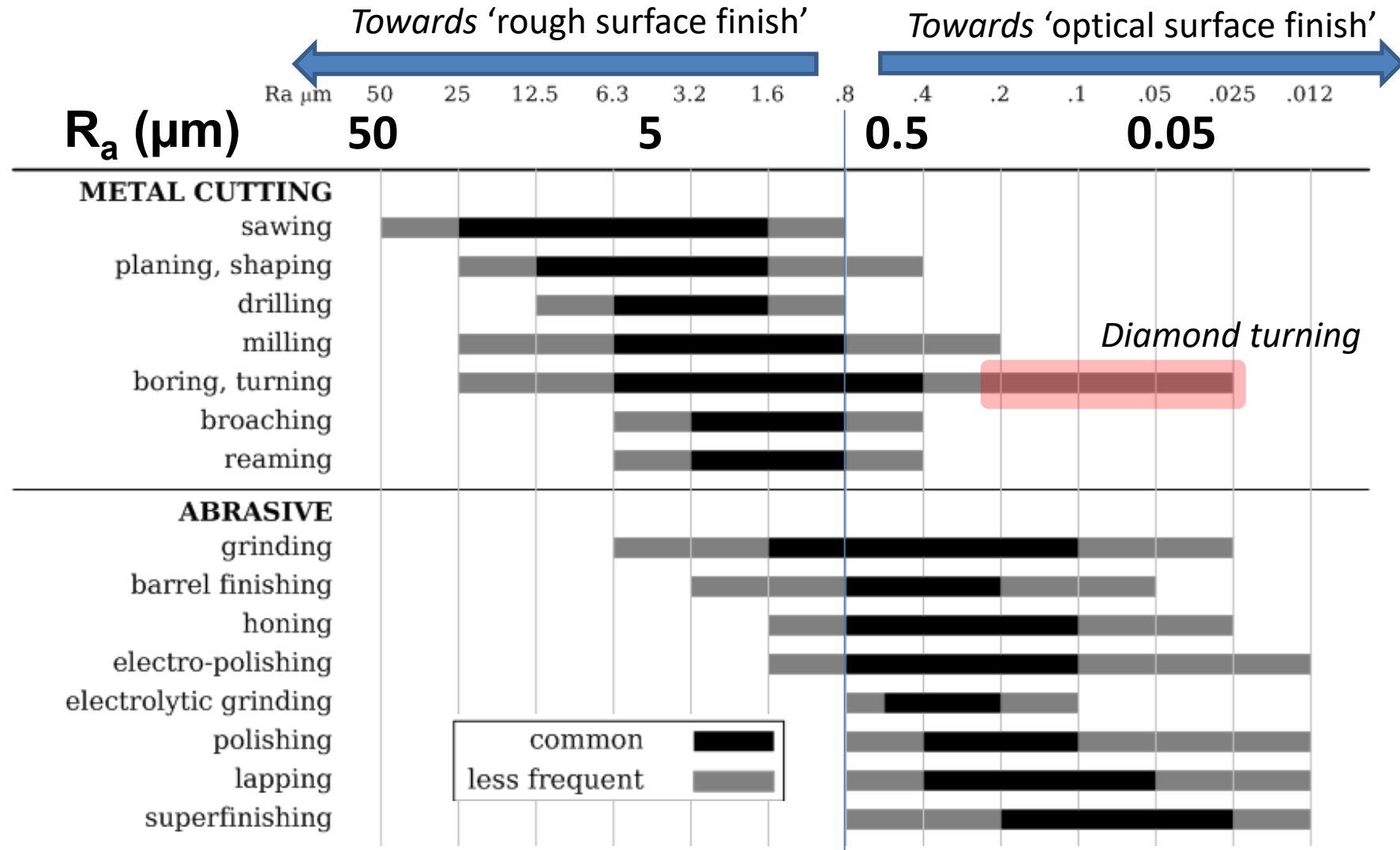
$$R_a = \frac{1}{L} \int_0^L |z(x)| dx$$

Profile amplitude

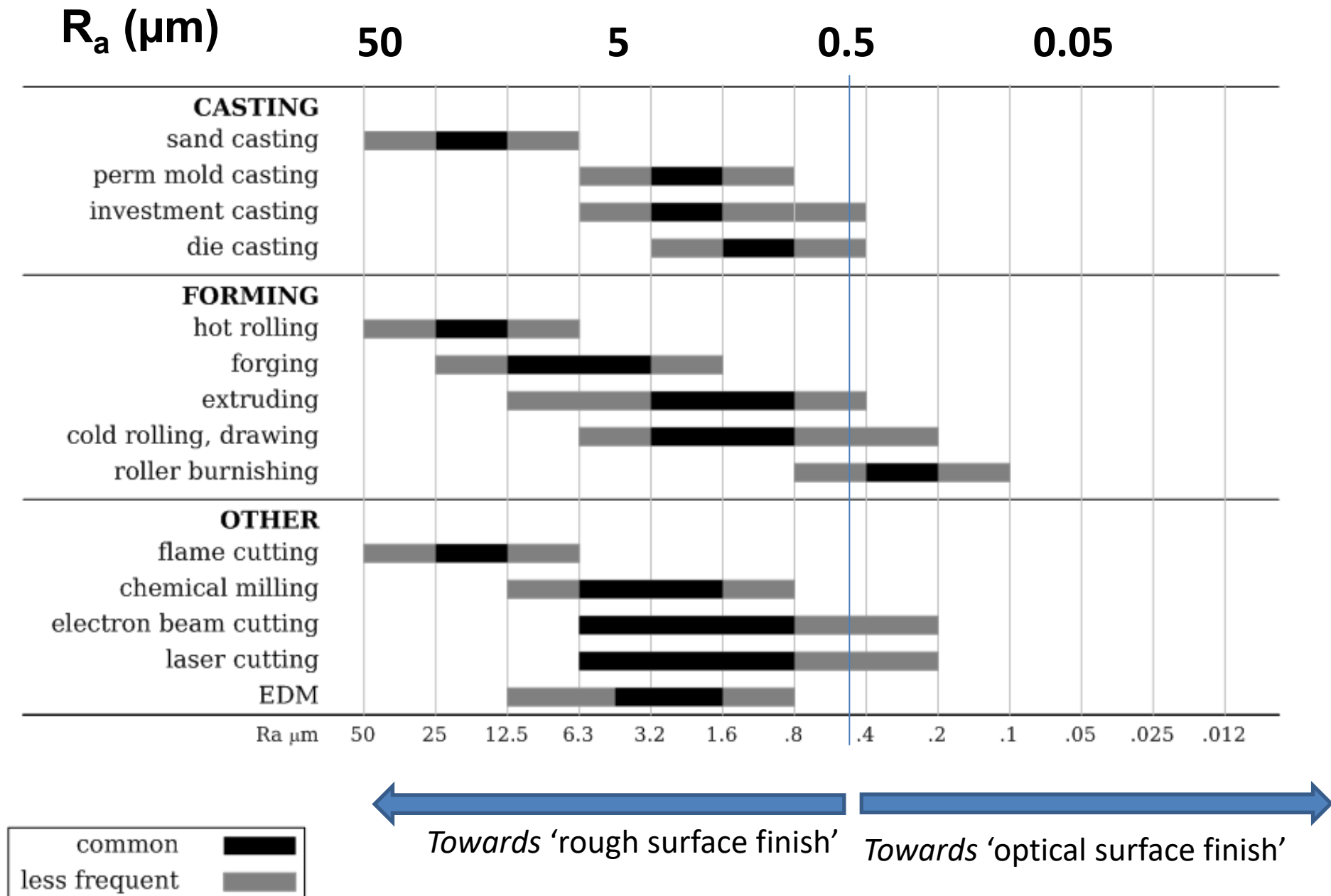
RMS roughness: $R_q = \sqrt{\frac{1}{L} \int_0^L z^2(x) dx}$

(illustration adapted from Zygo)

Typical surface finish for various manufacturing processes



(adapted from Emok, 2008)



(Adapted from Emok, 2008)

Same surfaces?



$$R_a = 3.05$$



$$R_a = 3.08$$



$$R_a = 3.04$$

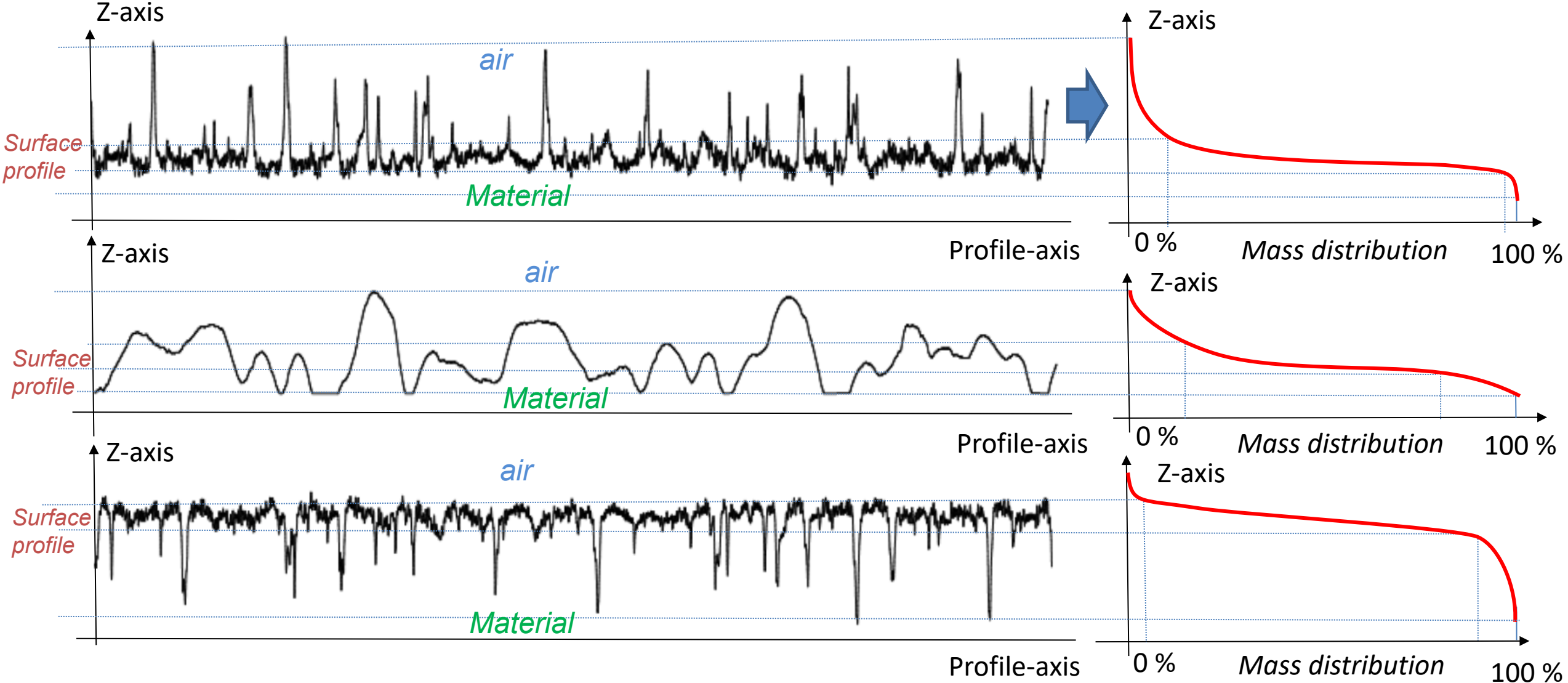
(Adapted from Mitutoyo, 'surface analysis')

Arithmetic averages (Ra or Rq) contains limited information

- Ra (Rq) are **informative** not sufficient to fully describe a surface.
 - It does not say much about the density of peaks
 - It does not tell anything about the shape of the peaks
 - Possible textures
- Manufacturing processes (wether by adding or removing materials) produce a typical surface topology that cannot be only characterized by the Ra.
- Additional surface metrics?

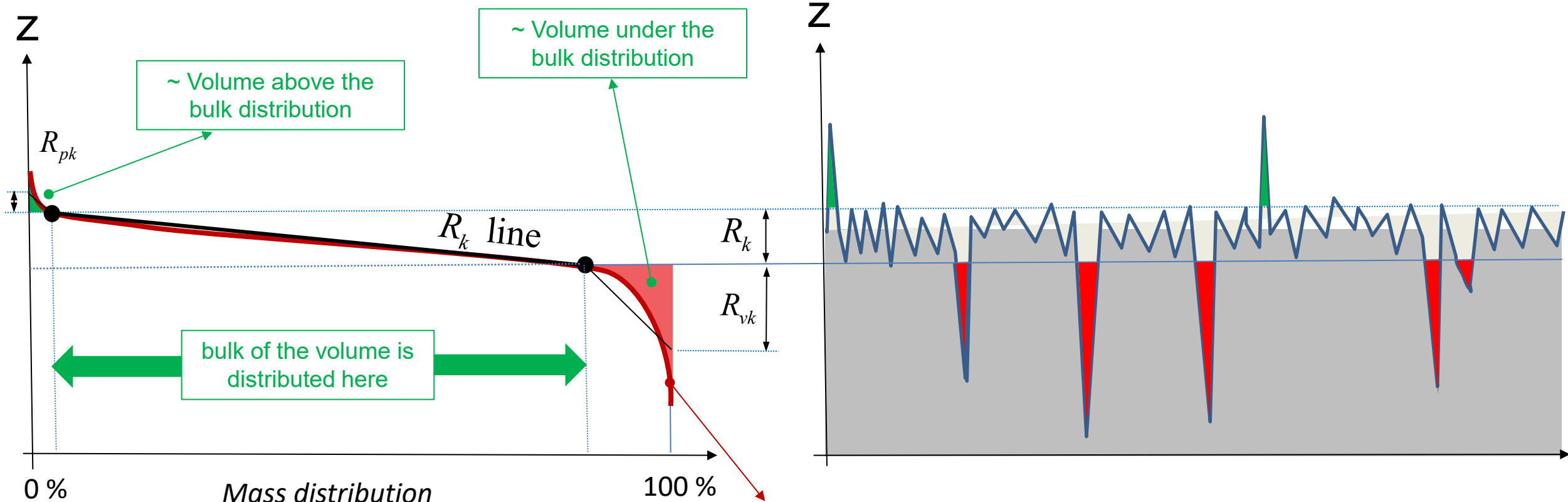
Tribology – Lubrication/Hermetic sealing

Materials ratio curve ('Abbott-Firestone' curve): Concept



Interpretation

- Useful for understanding the properties of sealing / bearing surfaces
- Volume above to ensure peak less surface (abrasive mode)
- Volume below are useful for estimating valleys available for lubricant retention, heat dissipation, etc.



The curve tells how is the mass distributed as a function of the depth z

How surface topology parameters correlate with surface functionalities?



© Hergé/Moulinart 2006

Illustration 1: surface roughness and mechanical strength

Influence of roughness on mechanical properties: example

- Intuitive reasoning:** Lower roughness = more contact points, higher surface strength?

$\sigma^2 = \frac{1}{L} \int_0^L Z^2 dx$

‘Plasticity index’
(<1, ‘elastic behavior’; >1, ‘plastic behavior’)

Contact radius Contact points

	σ (μm)	β (μm)	σ/β	N	$N/(\sigma/\beta)^{1/2}$	ψ	
						A	B
Fine Polishing	0,028	2 400	10^{-5}	9 000	0,073	0,16	0,027
Grinding	0,13	800	$1,6 \times 10^{-4}$	6 000	0,061	0,66	0,11
Turning	–	60	0,05	3 400	0,045	11,7	1,9

A: Steel / Stainless steel

B: Steel / Nitrued steel
(surface treatment)

Examples taken from G. Béranger, H. Mazille,
Techniques de l'Ingénieur

Illustration 2: surface roughness and optical reflectance

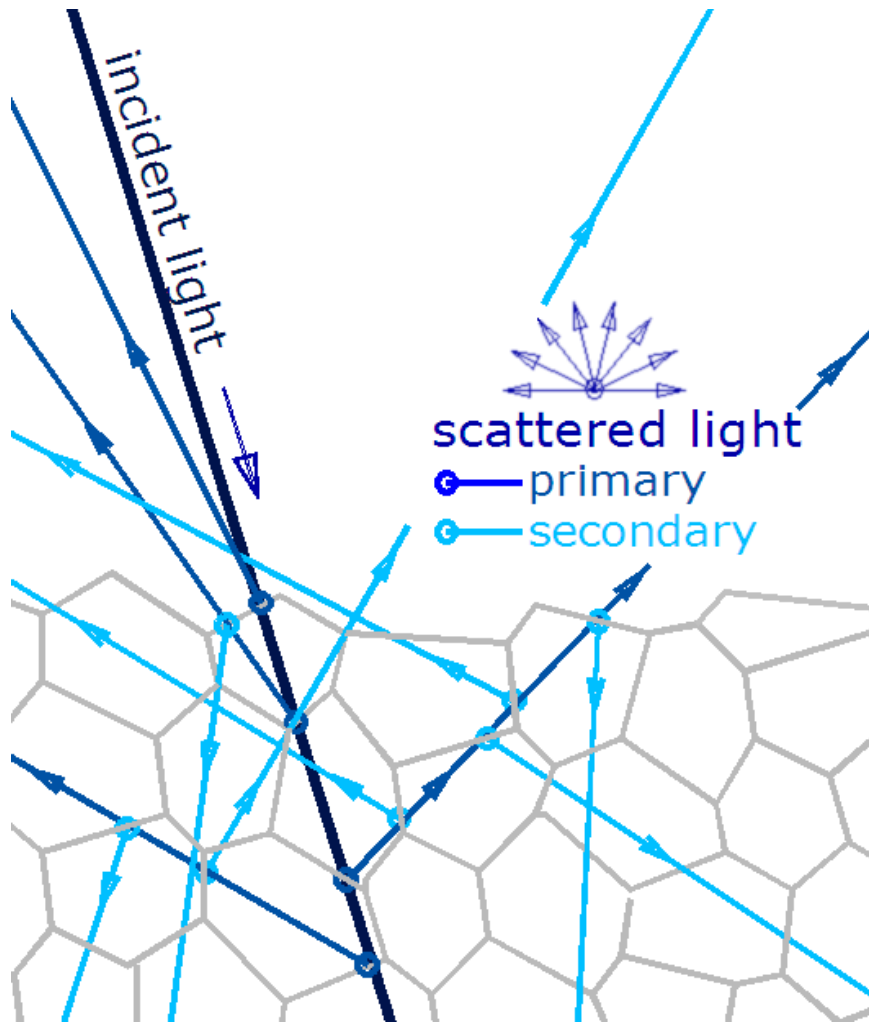
A 'visual' example: relation between roughness and optical properties

Diffusive
surface

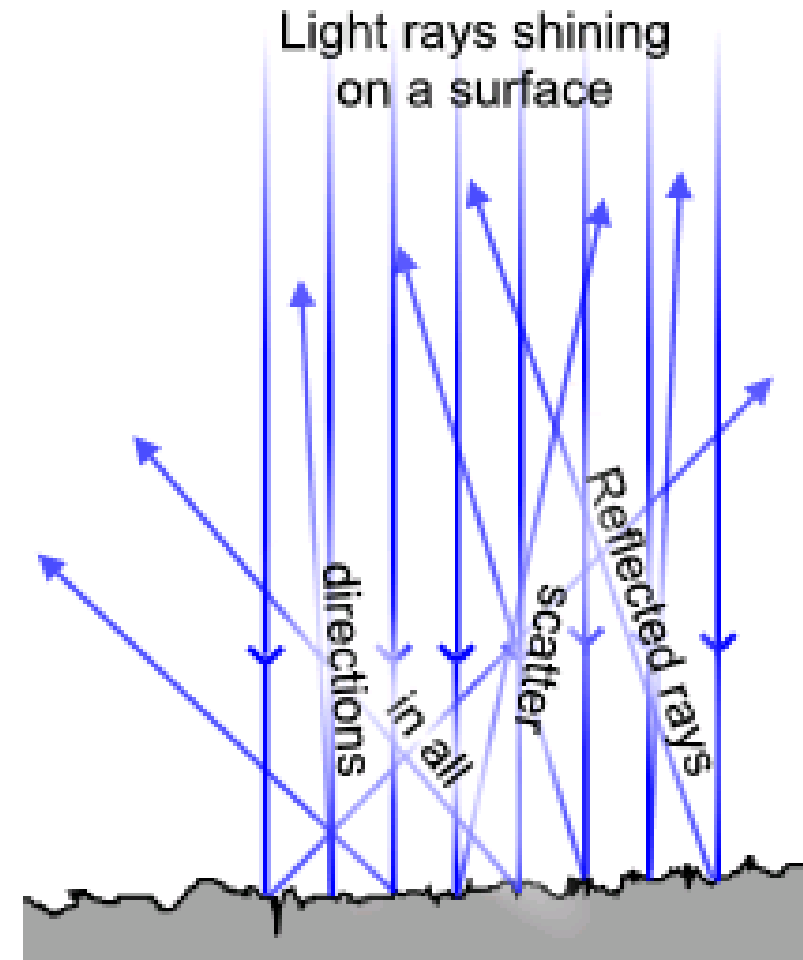


Non-Diffusive
Surface
(**specular**
reflection-transmission)

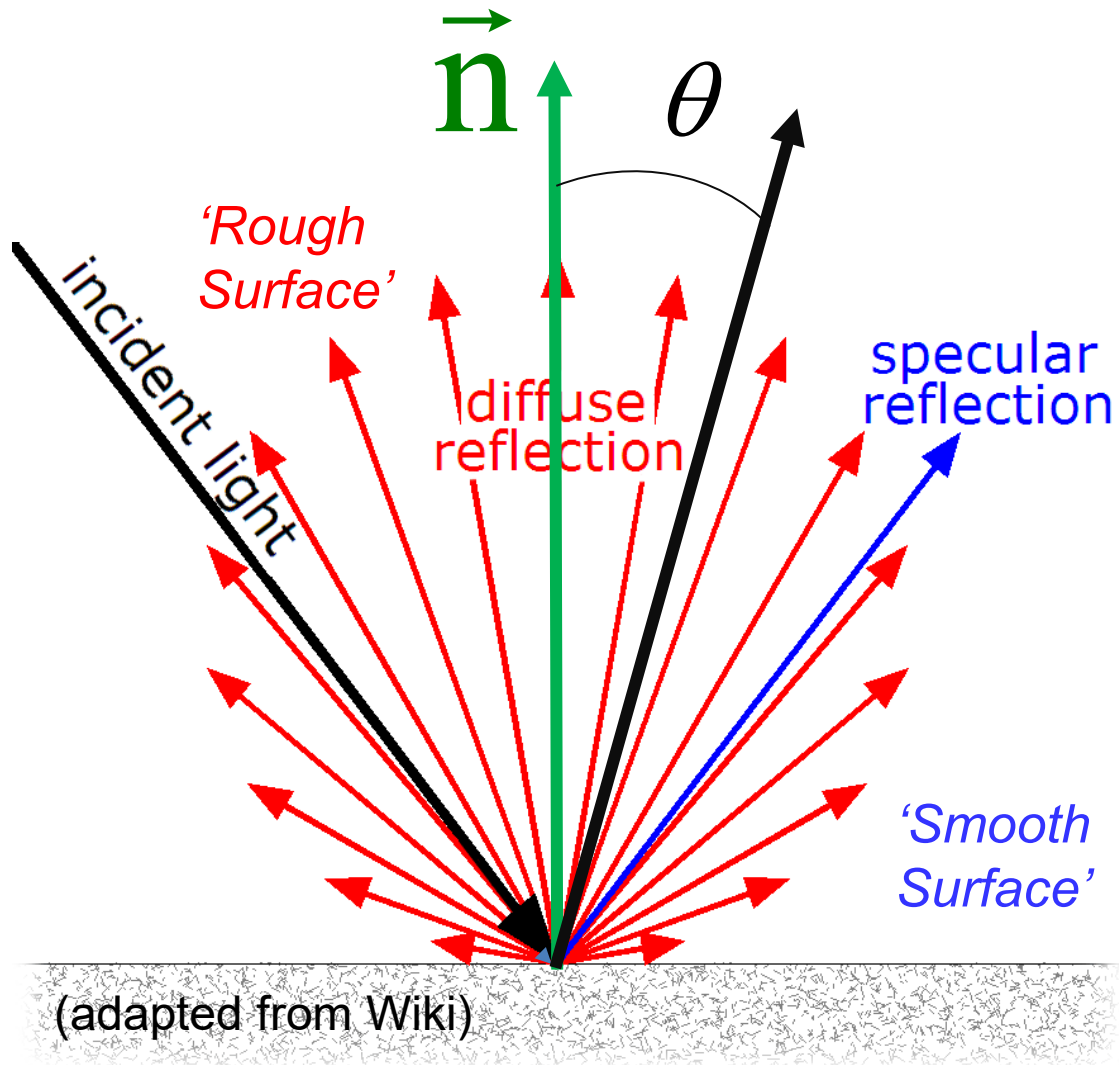
Phenomenological understanding of diffusion effects



(source Wiki)



Diffuse reflection: Lambert model



$$I_d(\theta) \propto I_0 \cos \theta$$

The diffuse reflection at an angle from the normal of the surface is proportional to the cosine of this angle.



*Johann Heinrich
Lambert (1728–1777)*

How 'smooth' should a surface be?

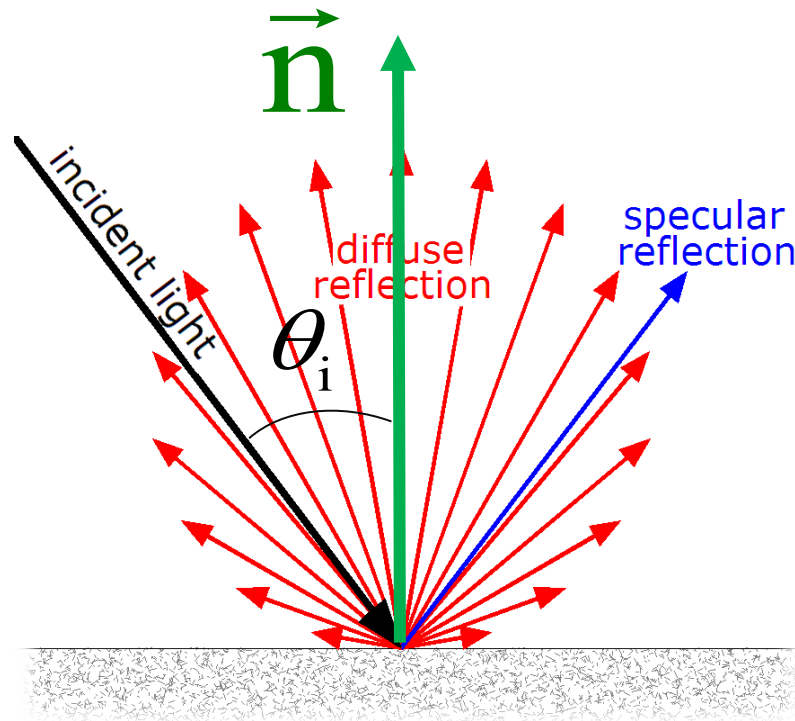
Bennett and Porteus model

Total
scattered
reflection

$$R_s(R_q) = R_0 \left(1 - e^{-\left[4\pi \left(\frac{R_q}{\lambda} \right) \cos \theta_i \right]^2} \right)$$

Theoretical
reflectance

Ratio of the
roughness versus
wavelength

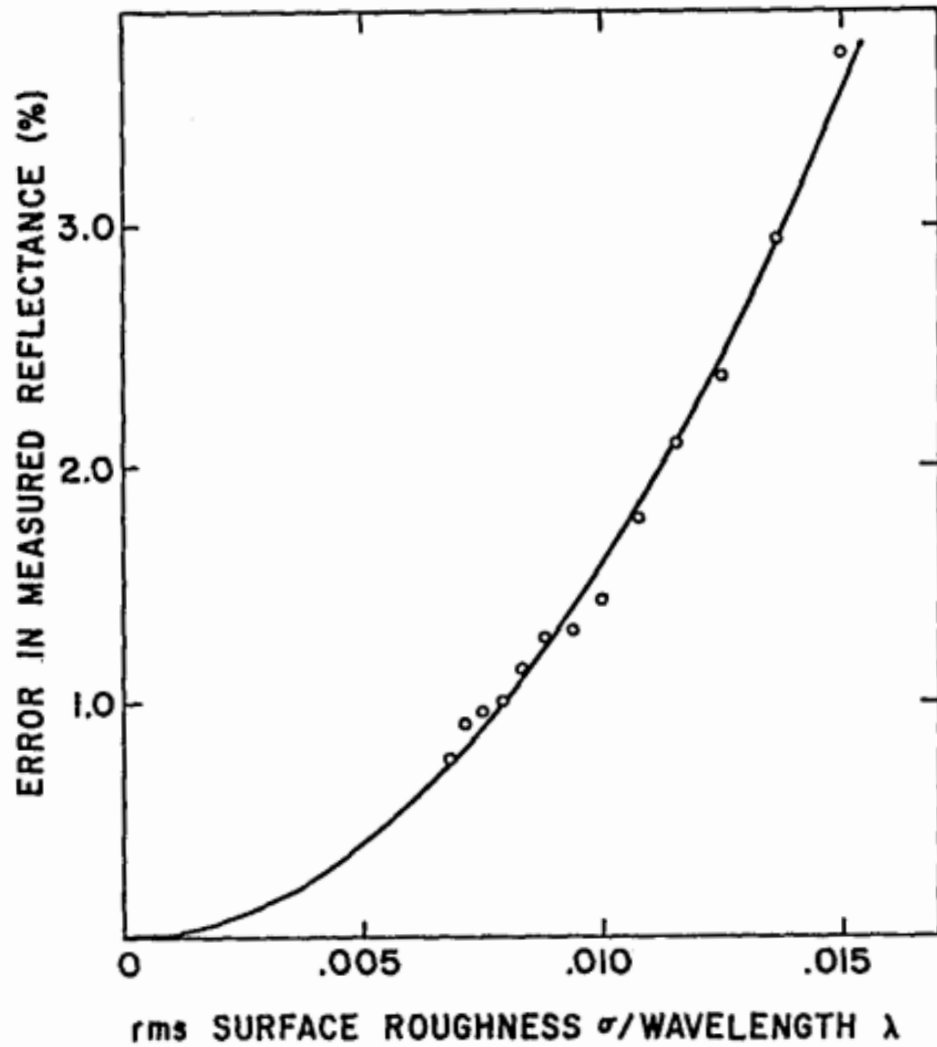


Bennett & Porteus, "Relation Between Surface Roughness and Specular Reflection at Normal Incidence," JOSA 51, 123 (1961)

Observations

- Optical scattering is proportional to reflectance \Leftrightarrow surfaces that reflects light will scatter more light than transmissive surfaces.
- Scattered intensity is related to R_q
- Shorter wavelengths scatters more than longer ones.
- Light scatters more at normal incidence than grazing incidence

Importance

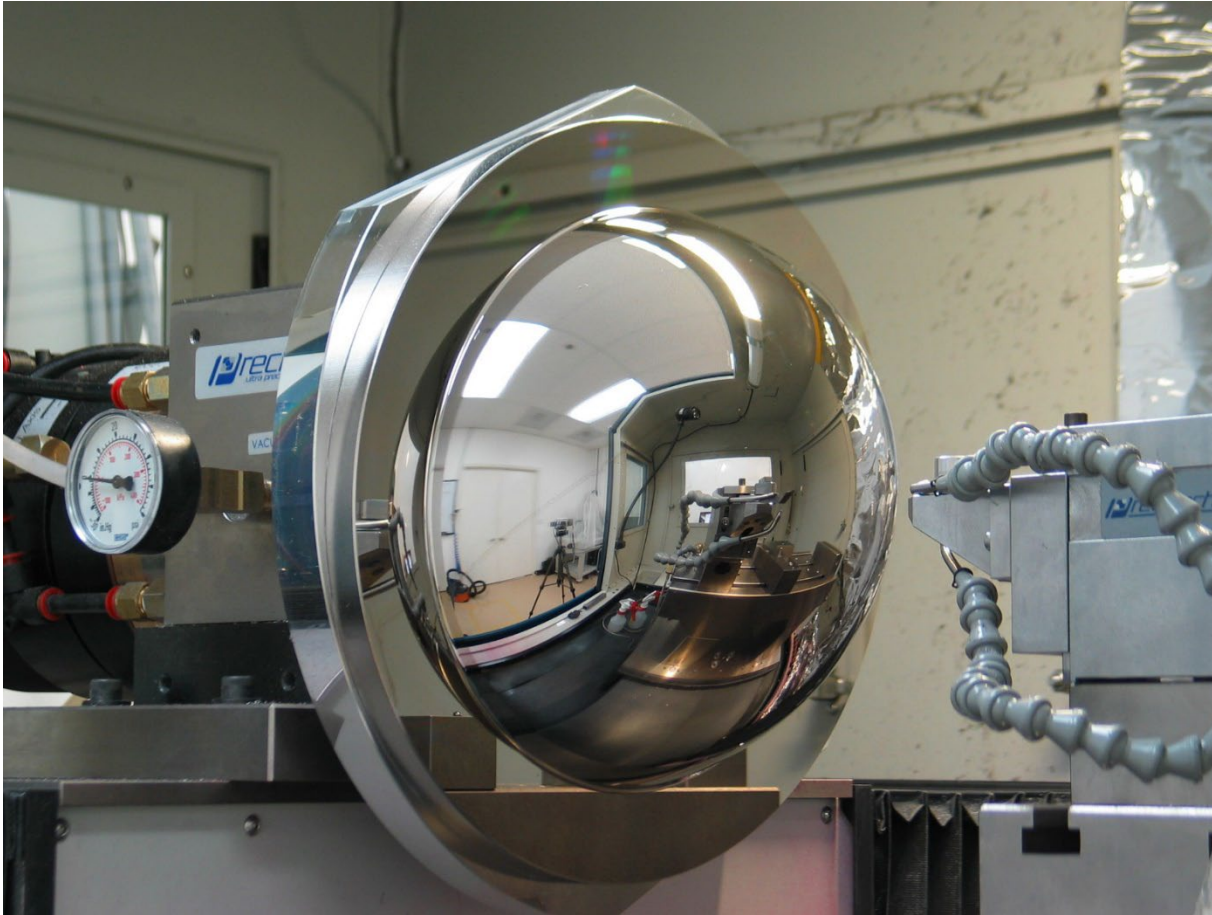


$R_q = 25$ nm scatters about 10% @ 500 nm !

Single Point Diamond turned surfaces can achieve $R_q = 5$ nm

Bennett & Porteus, "Relation Between Surface Roughness and Specular Reflection at Normal Incidence," JOSA 51, 123 (1961)

About diamond turning...



Source : NiPro

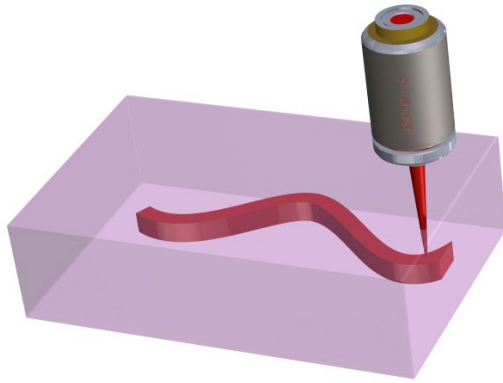
YouTube illustration from Thorlabs:

https://youtu.be/6iRohl_jaYg

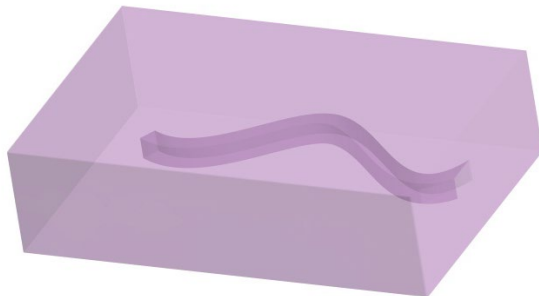
Illustration 3: effect of surface properties on fracture mechanics

3D machining illustration: two-step laser manufacturing

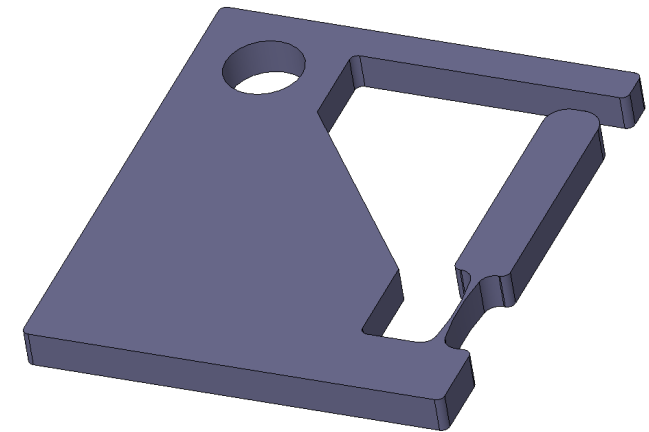
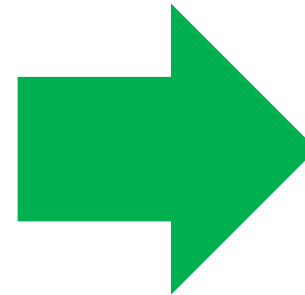
1/ Femtosecond laser exposure (**no ablation**)



2/ Chemical etching (**'development step'**)



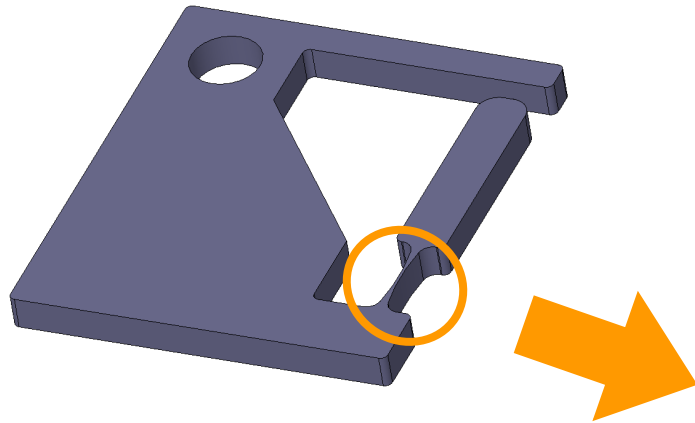
Arbitrarily shaped parts



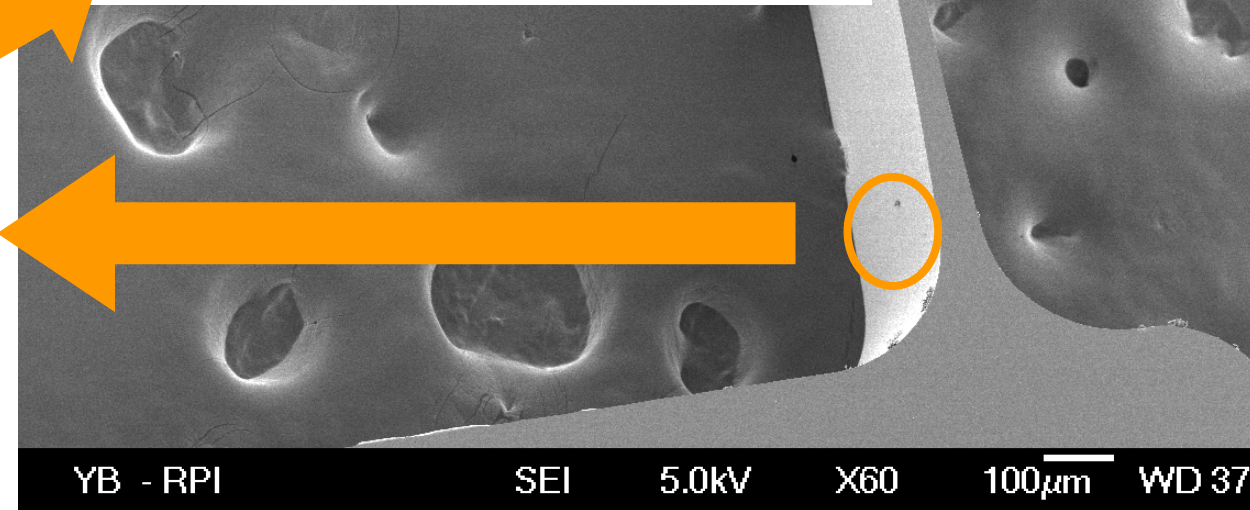
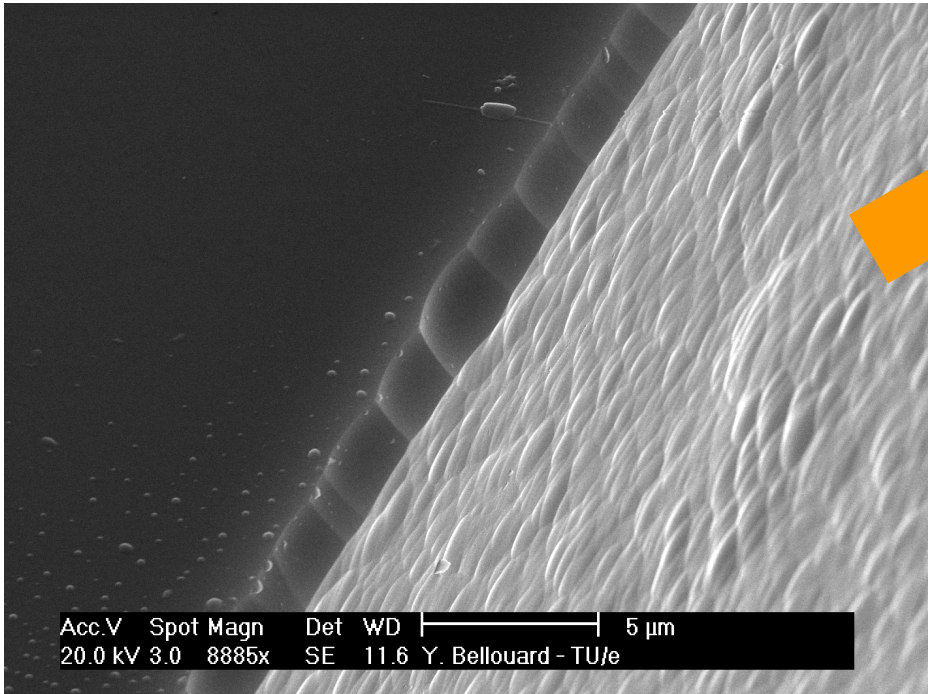
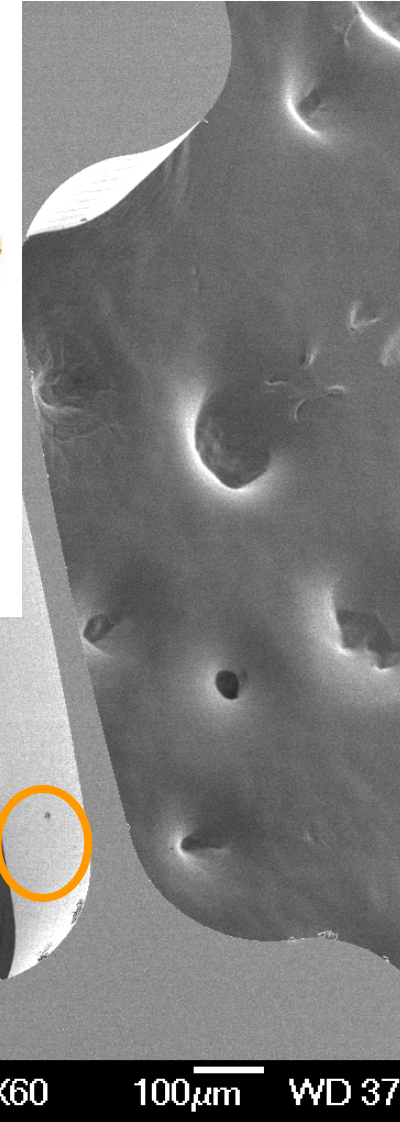
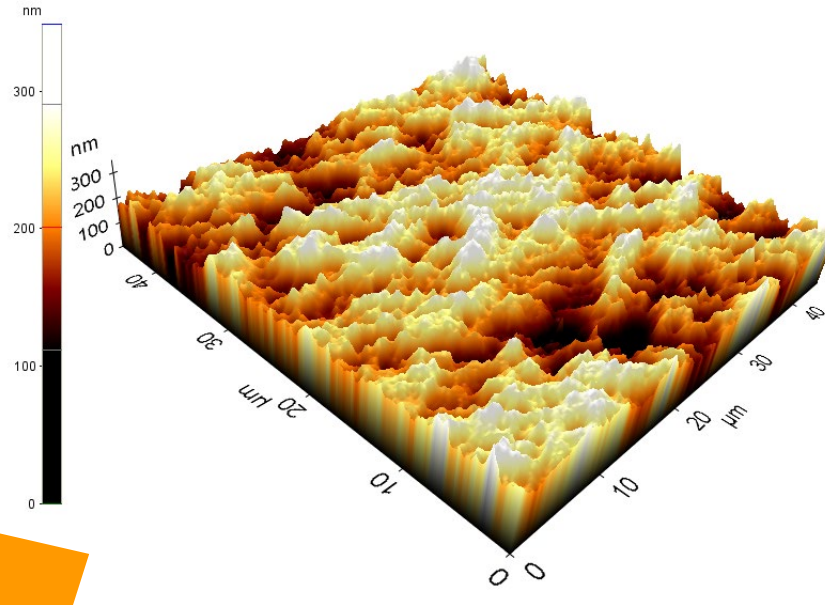
We will discuss it more in the laser-manufacturing lectures!

Y. Bellouard, A. Said, M. Dugan, P. Bado, Optics Express, 12, 2120-2129 (2004).

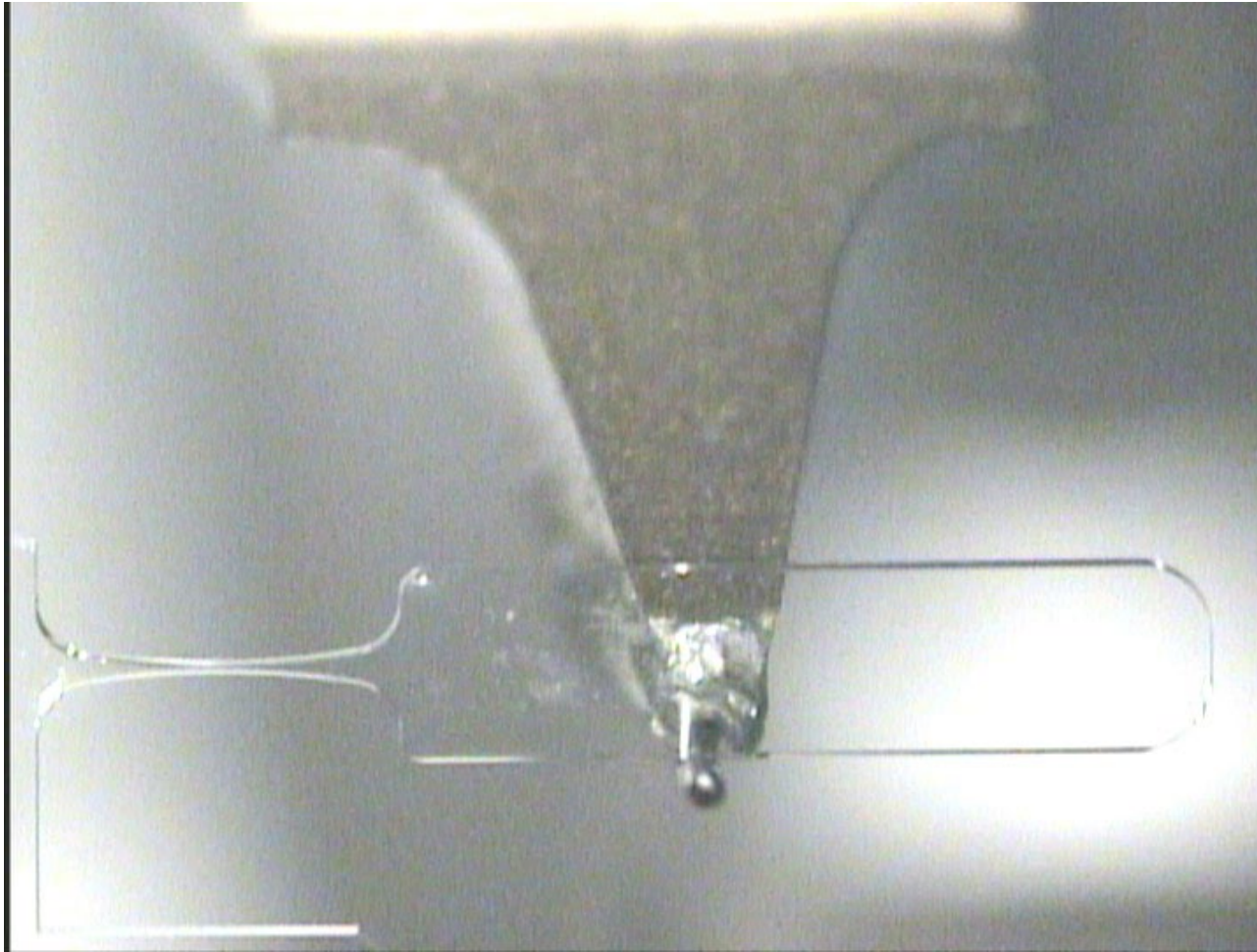
Micro-manufacturing illustration



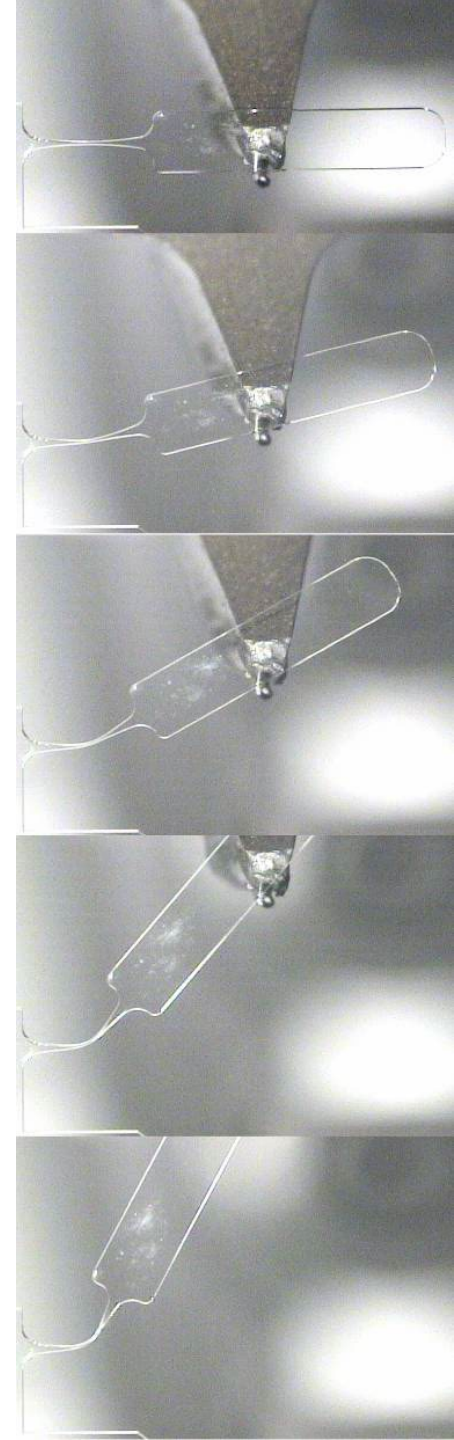
Roughness R_q (RMS) $\approx 200 - 300$ nm



Glass flexure strength depends on etching time...

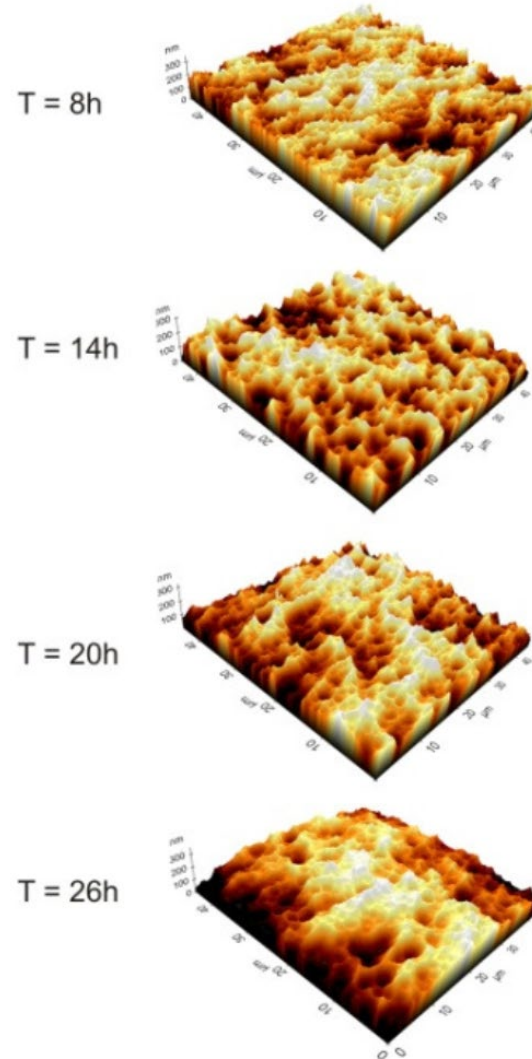
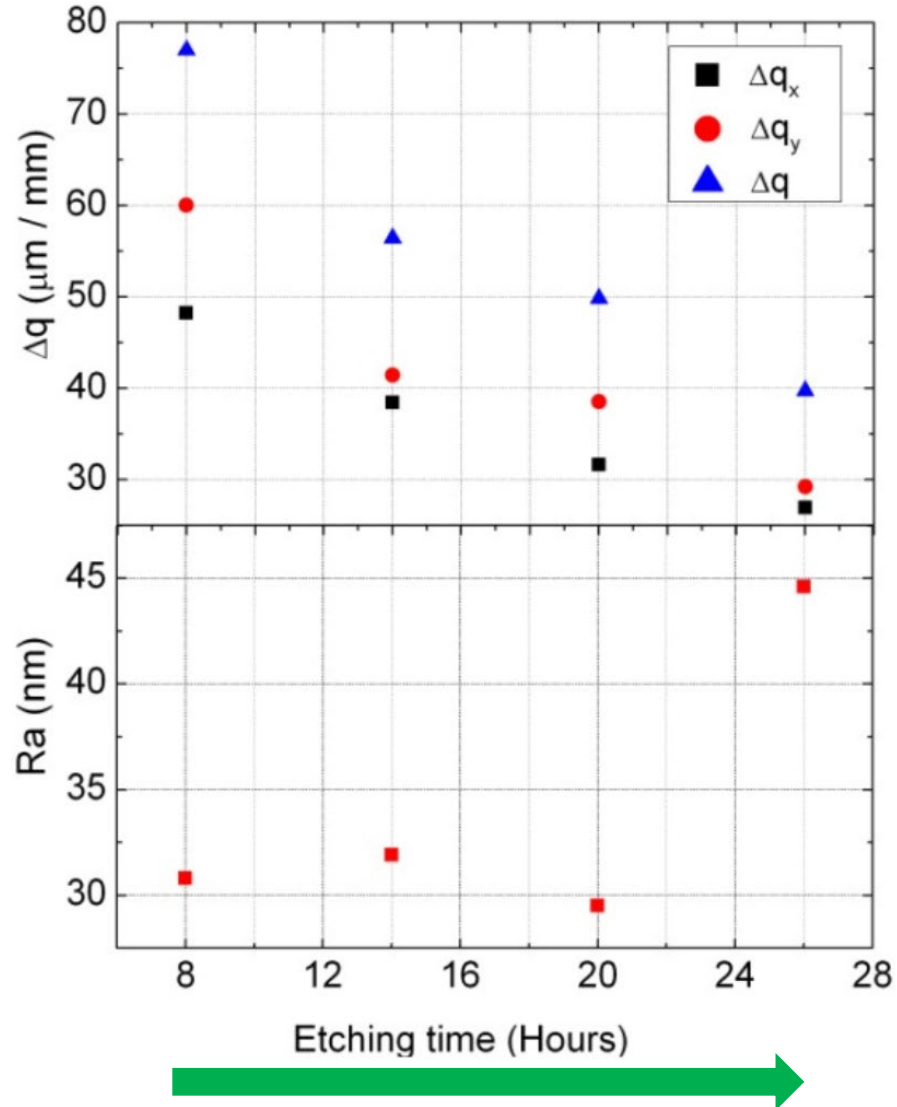


*Stress locally
well above 2 GPa!*



Observation: The more we etch, the higher the strength. Why is it such?

Interpretation using surface parameters, hybrid parameters



RMS hybrid parameter

$$\Delta_q = \sqrt{\frac{1}{L} \int_0^L \left(\frac{dy}{dx} \right)^2 dx}$$

Sampling length

Derivative of the profile ~ Density of peaks

The arithmetic average roughness (Ra) **is not changing**, but the density of peak **decreases** (Δ_q)



Less peaks > Lower stress concentration > lower probability for glass failure

**Example of a surface functional properties
characterization: the hardness of a surface**

Physical properties: hardness

- How do we quantify it?

Various metrics: **Vickers** (VH), Brinell, Rockwell, Knoop.

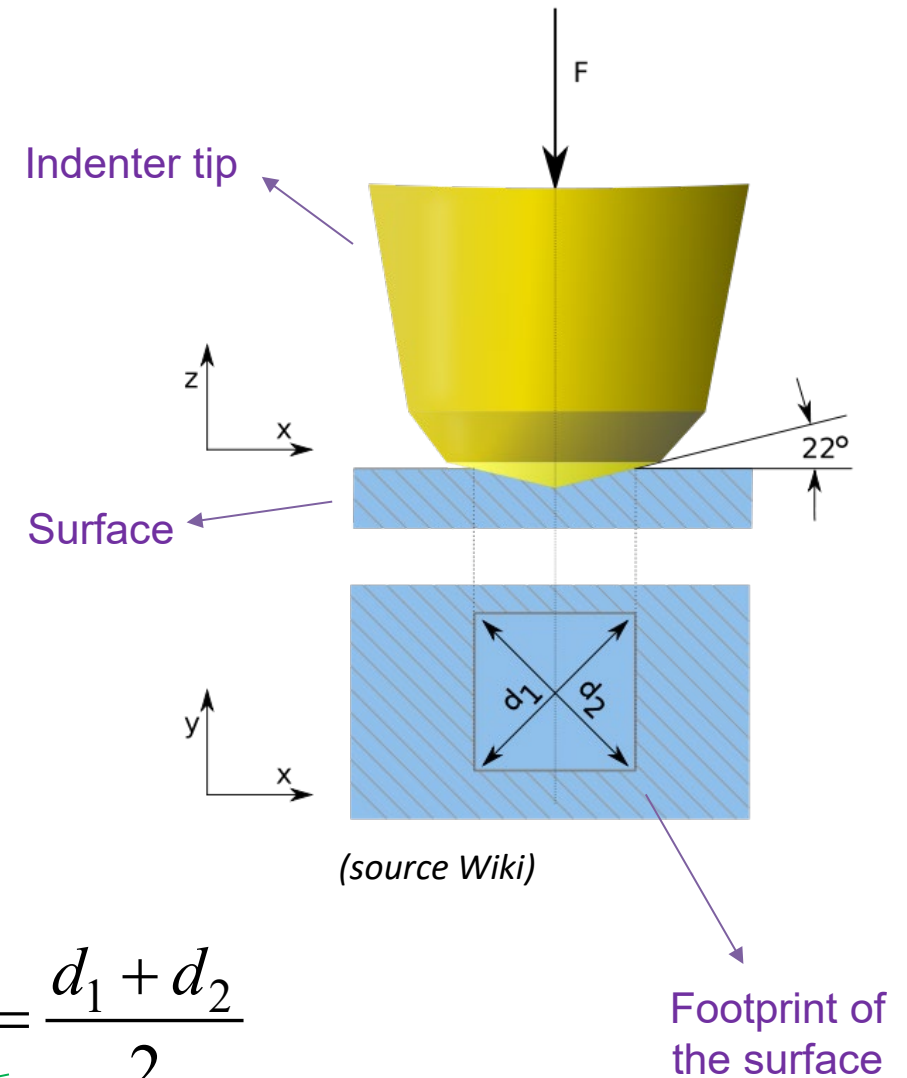
Most used!

Vickers hardness

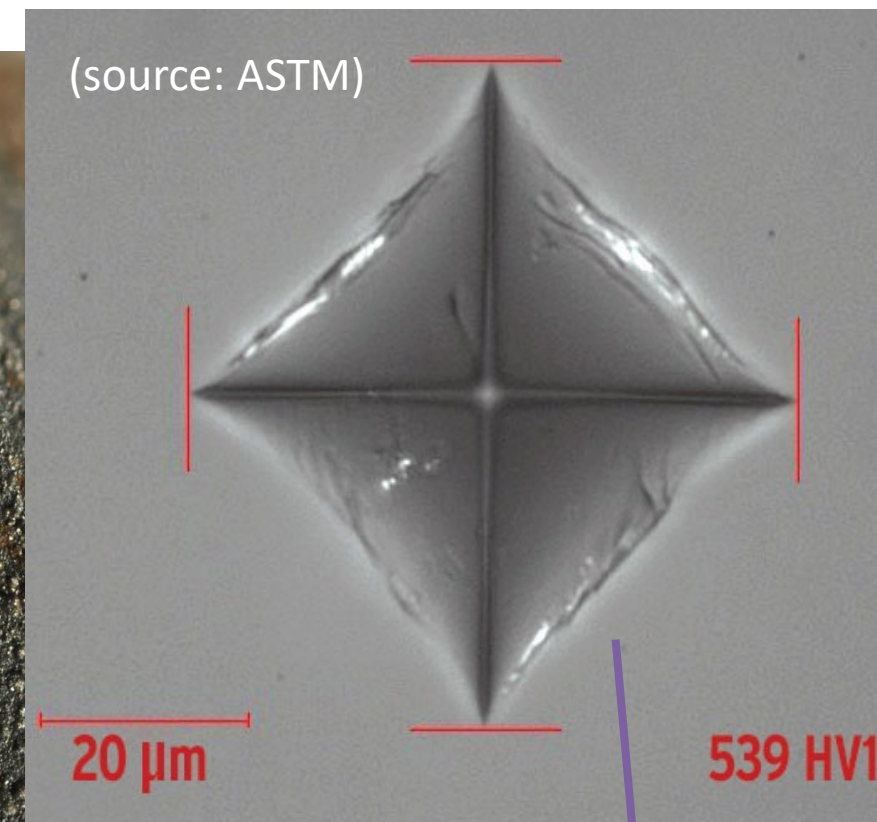
Applied force

$$HV = C \left(\frac{F}{d^2} \right) \text{ with } C = 0.0189 \text{ and } d = \frac{d_1 + d_2}{2}$$

Geometry of the indenter



In SI unit: **MPa**, but also expressed in HV (kgf/mm²) ... (just divide by 9.807)

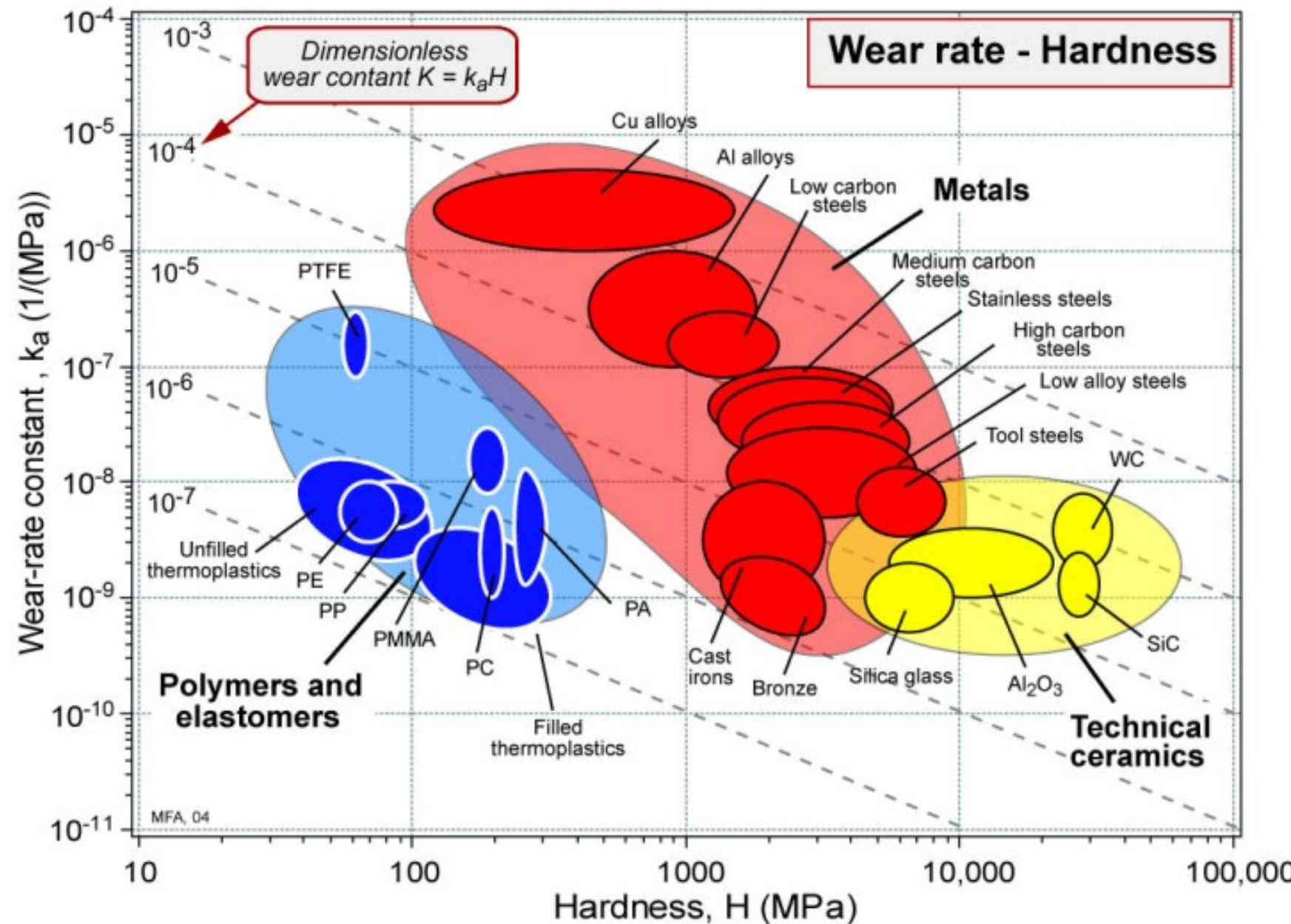


Indenter
footprint on the
surface

Source R. Tanaka - http://www.flickr.com/photos/fluor_doublet/6864844960/

Hardness versus wear rate plot

Perhaps counter-
intuitive: the higher
the hardness does
not necessarily
mean the most
wear-resistant!

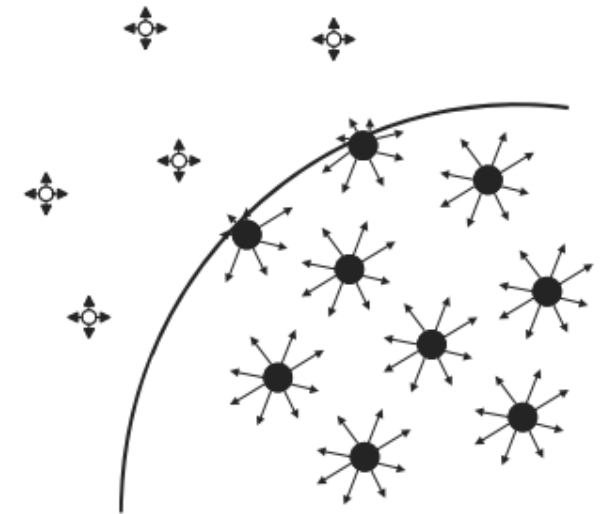
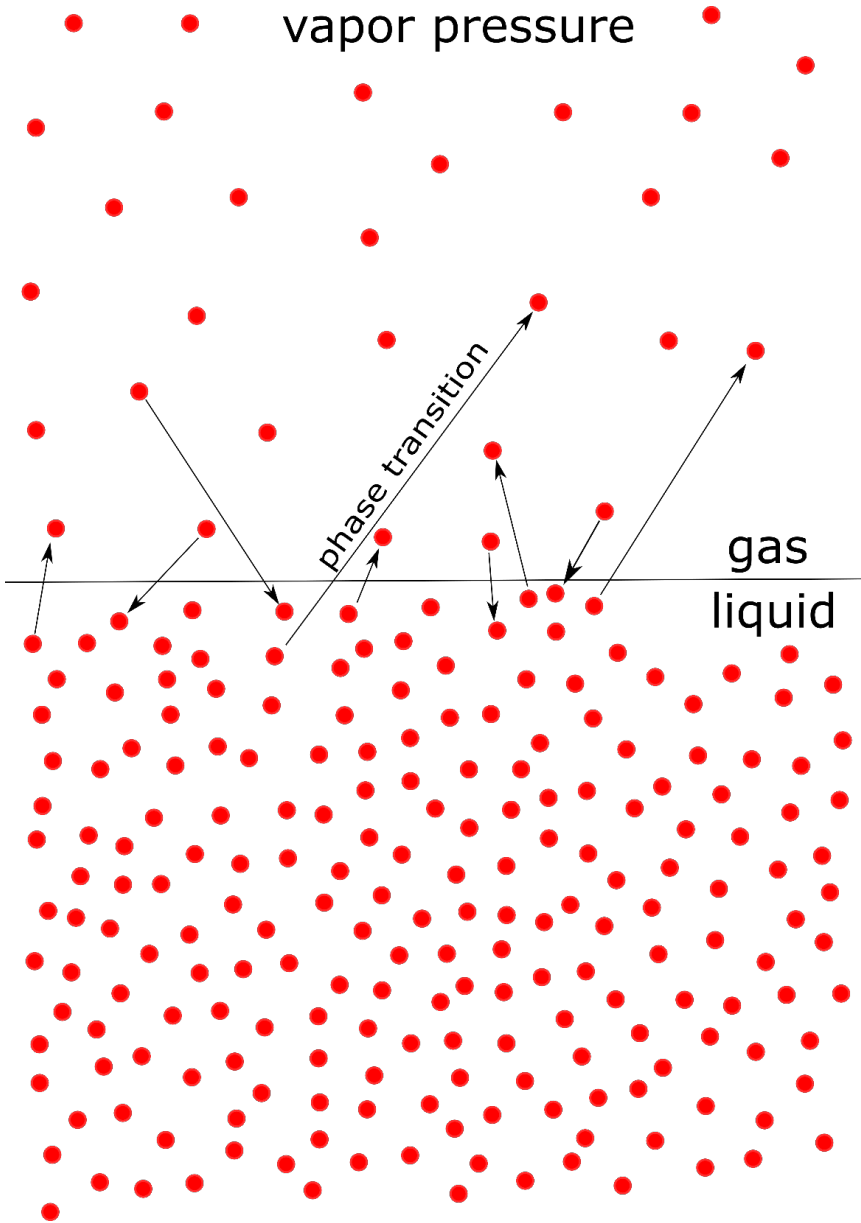


(source Ahsby)

Example of a surface functional properties characterization: wetting properties of a surface

Surface Tension

- Molecules of a liquid attract each others
 - Hydrogen bonding forces for polar molecules
 - Van der Waals forces for other molecules



*Imbalance of this attractive force at an interface leads to **surface tension***

Important definition: Surface Tension

Surface tension has units of **N/m (J/m²)**. If S is the total surface area of an interface and γ is the surface tension, then the total **energy stored** in the interface is

The diagram shows the equation $E = \gamma S$ in the center. Three green arrows point from the terms in the equation to their respective units: one from γ to 'Surface tension N/m (J/m²)', one from E to 'Energy (J)', and one from S to 'Surface (m²)'.

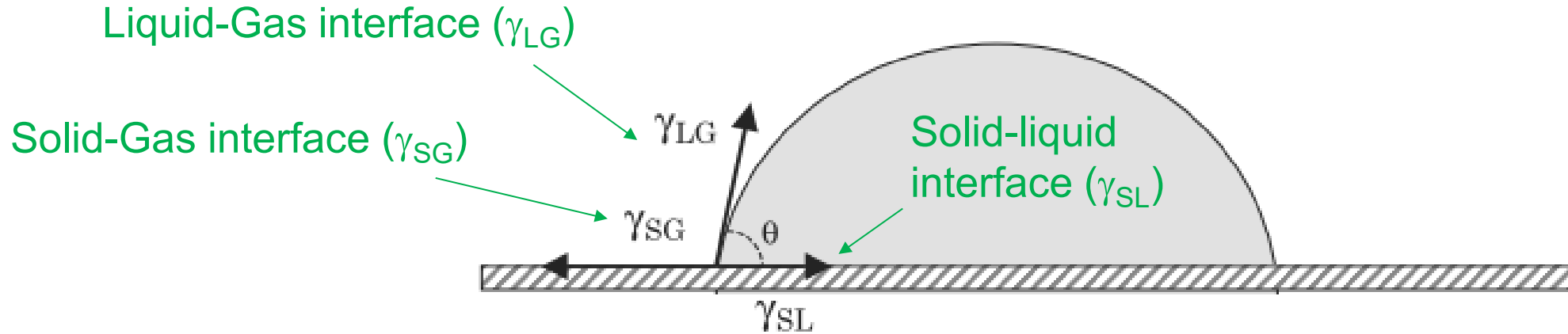
$$E = \gamma S$$

Surface tension N/m (J/m²)

Energy (J)

Surface (m²)

Wettability: Young's law



The **contact angle** at the intersection of three interfaces is entirely determined by balancing the **surface tensions** of each interface. ('Equilibrium of forces')

$$\gamma_{\text{Liq-Gas}} \cos \theta = \gamma_{\text{Sol-Gas}} - \gamma_{\text{Sol-Liq}}$$

*If $\theta > 90$, the surface is said to be '**hydrophobic**'*

*If $\theta < 90$, the surface is said to be '**hydrophilic**'*

Contact angle generally depends on the wetting history!

- Hysteresis in wetting
- Surface are not perfect and has defects
- The liquid has a certain mass / contacts may deform, etc.
- Concept of **advancing** and **receding** angles

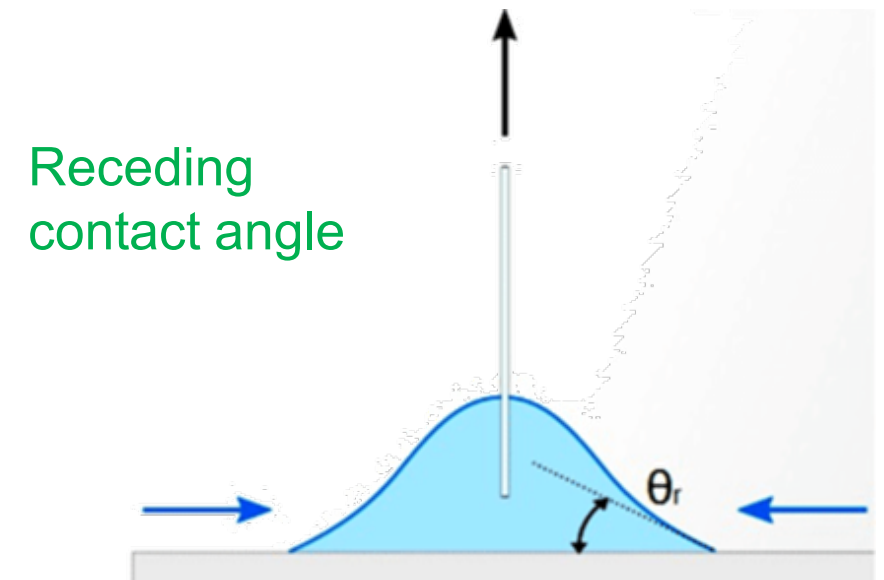
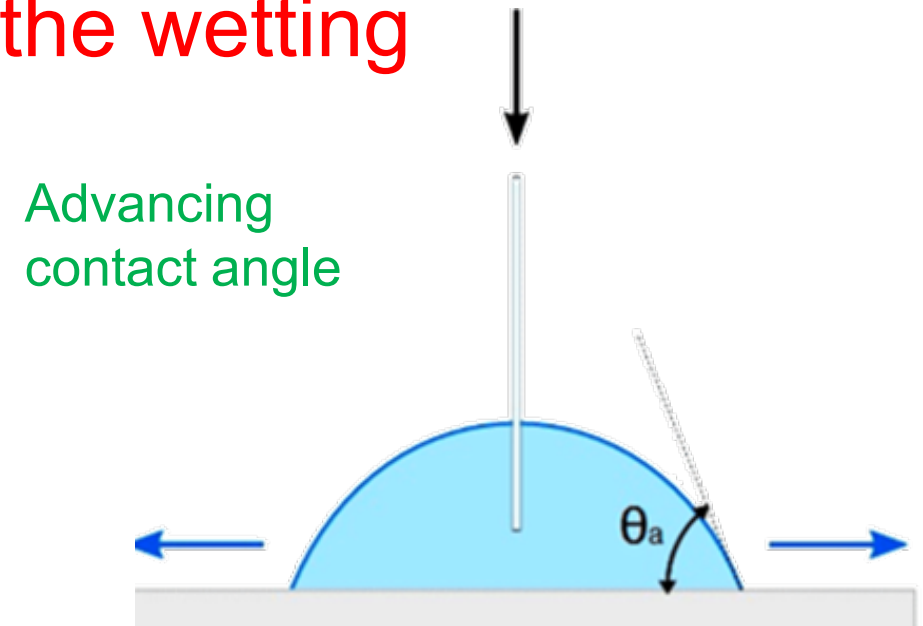
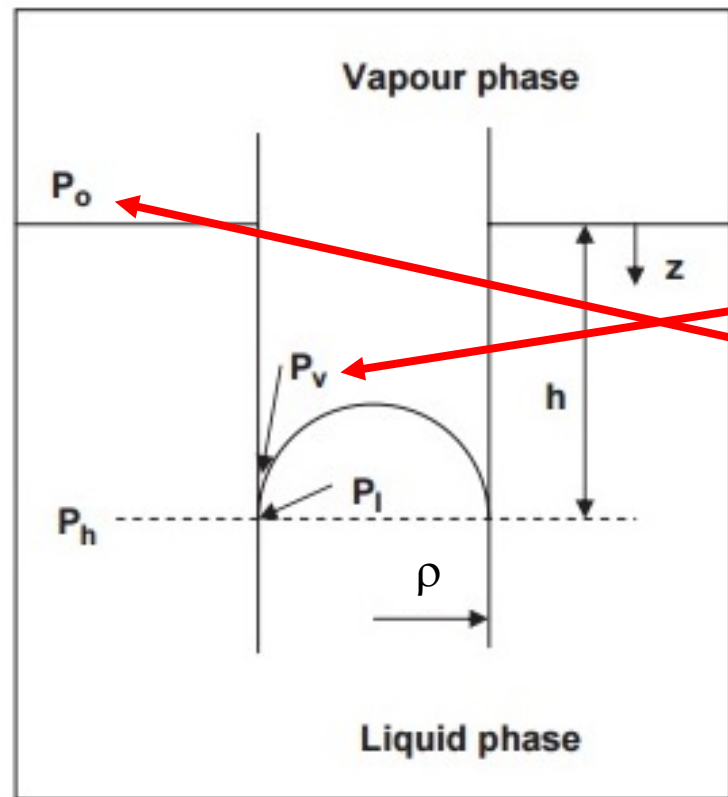


Figure: Fabio, Villa et al. (2014). doi: 10.1615/IHTC15.nmt.009823.

Change in vapor pressure due to contact angles

- Kelvin equation



(source Wiki)

$$\ln \frac{p_v}{p_0} = \frac{2\gamma V_m}{\rho R T}$$

Diagram illustrating the Kelvin equation, showing the relationship between the change in vapor pressure and the curvature of the meniscus. The equation is:

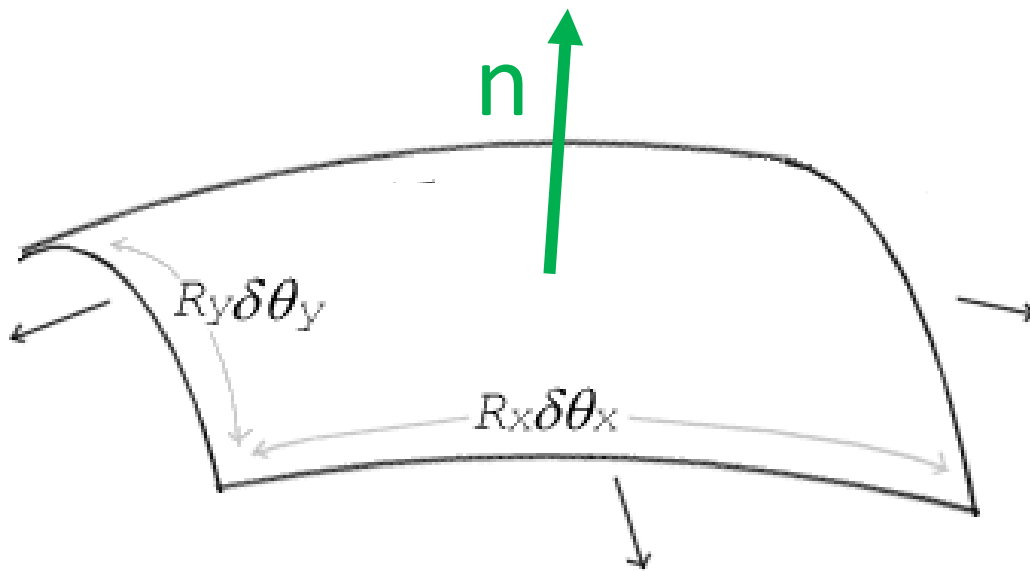
$$\ln \frac{p_v}{p_0} = \frac{2\gamma V_m}{\rho R T}$$

Labels and their corresponding variables in the equation:

- Surface tension (γ)
- Molar volume (V_m)
- Saturated vapor pressure (p_0)
- Meniscus radius (ρ)
- Universal gas constant (R)
- Temperature (T)

Laplace-Young equation

- States the difference of pressure at the interface between a gas and a liquid



Normal to the surface

Mean curvature

Surface tension

Difference of pressure
across the interface

$$\Delta p = \gamma (\vec{\nabla} \cdot \vec{n}) = \gamma \left(\frac{1}{R_x} + \frac{1}{R_y} \right) = 2\gamma H$$

Principal radii

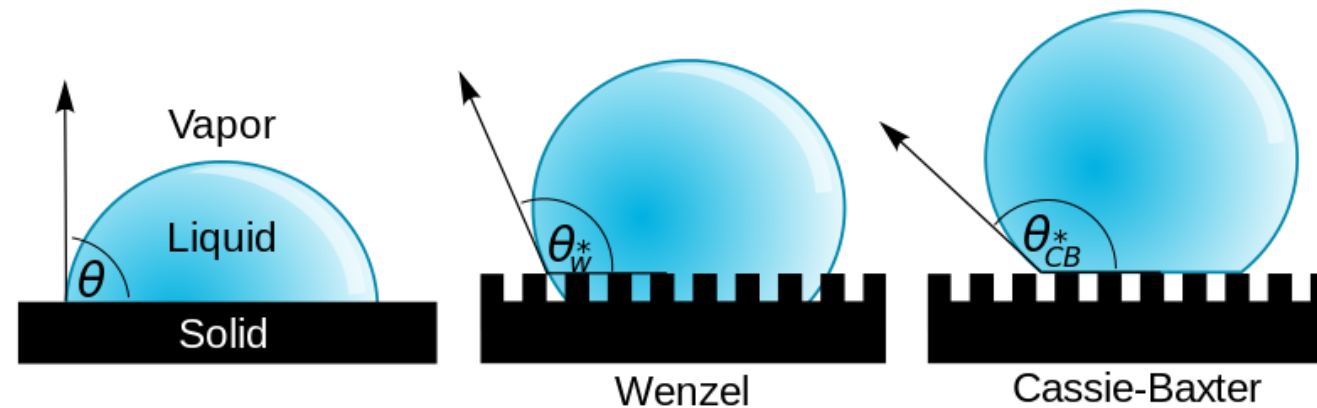
Illustration on how processing can be used to
engineering surface at the nano-scale

Walking on water...



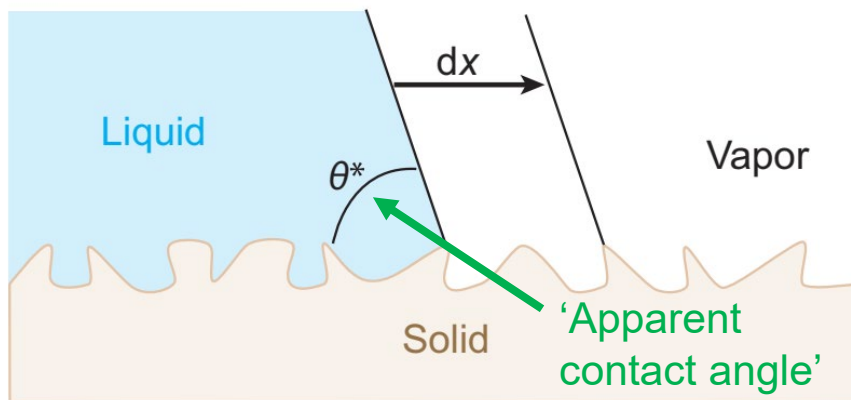
Bush JWM, Hu D, Prakash M. 2008. The integument of waterwalking arthropods: form and function.
Adv. Insect Physiol. 34:117–92

Engineered hydrophobic surfaces/effect of roughness: how it works?



(source: Vladsinger, Wiki)

Wenzel: **assume** that the liquid continuously 'wet' the rough surface.

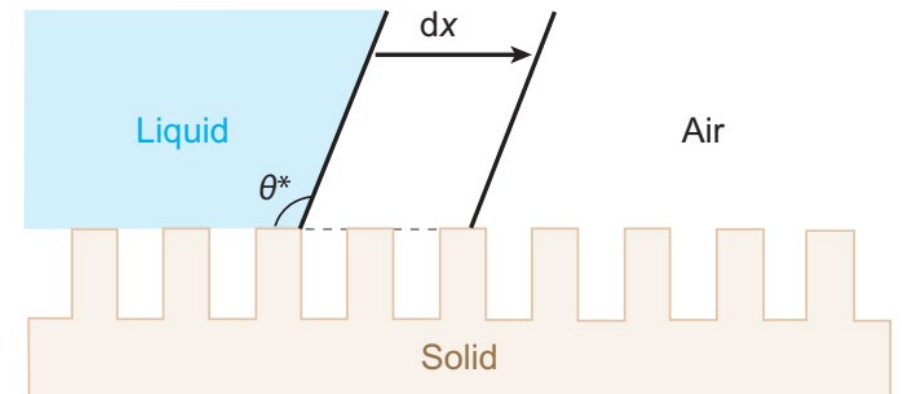


(source: David Quéré, ESPCI)

$$\theta^* \neq \theta$$
$$\cos \theta^* = r \cos \theta$$

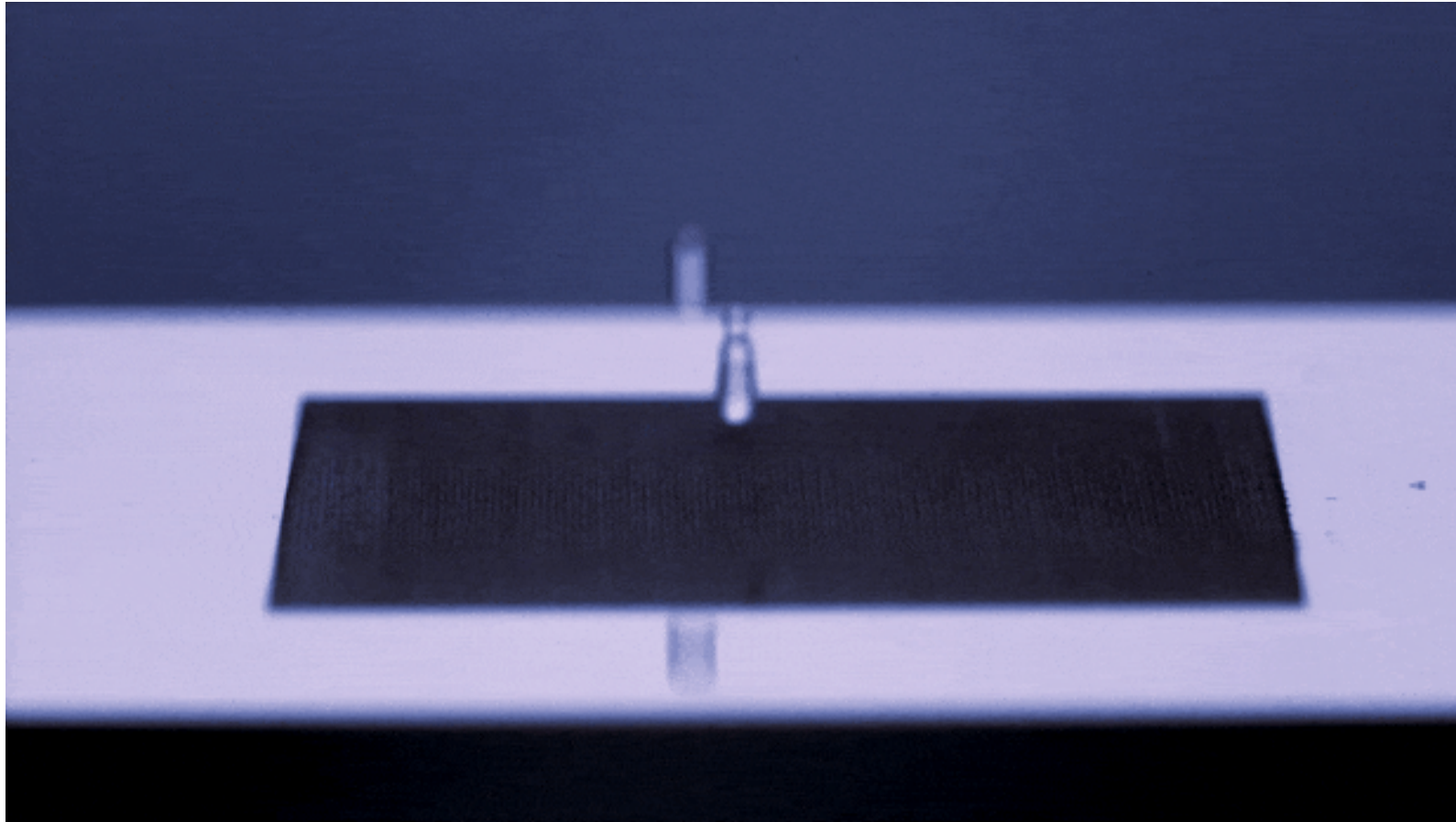
↑
'roughness factor' > 1

Cassie-Baxter: **assume** that the presence of air-liquid interface.



(source: David Quéré, ESPCI)

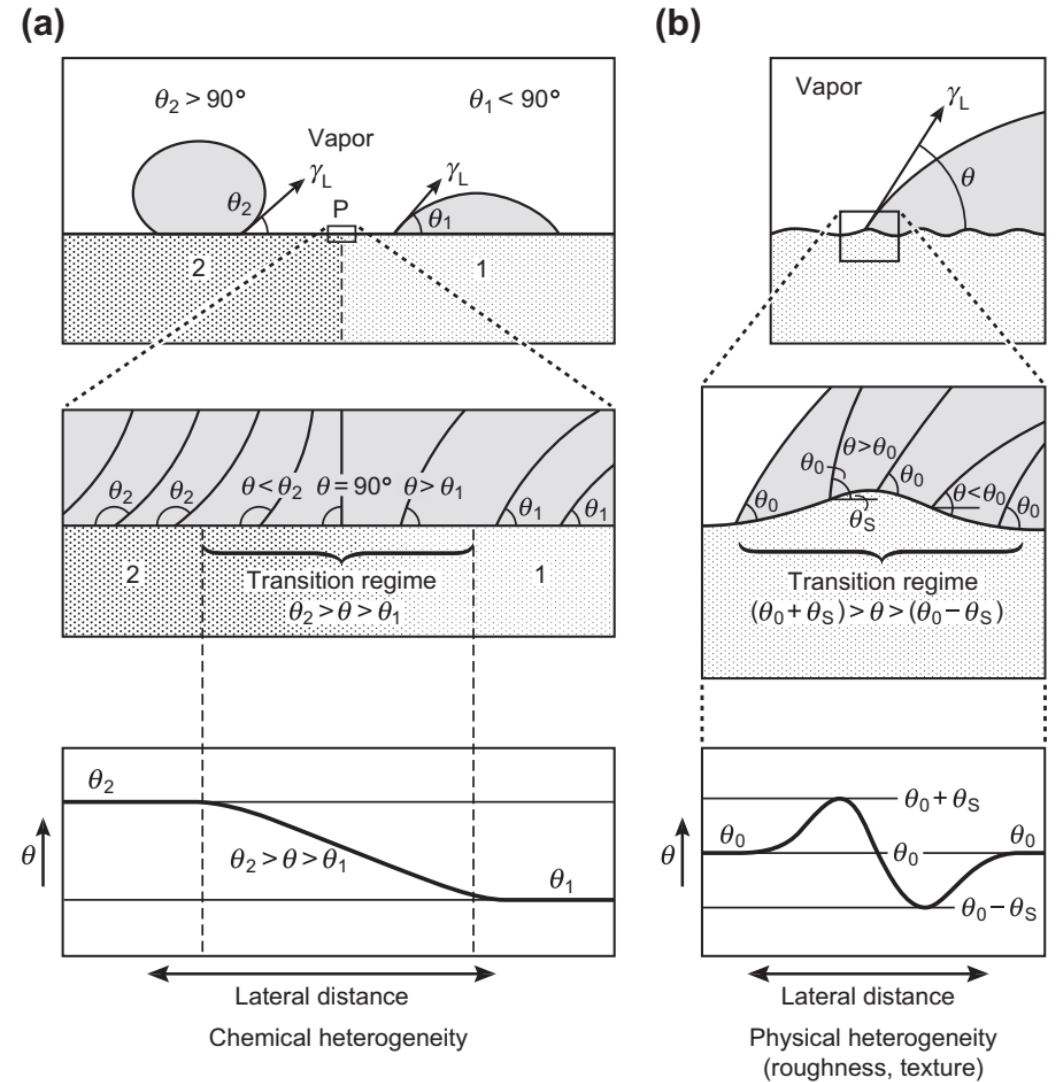
What about manufacturing? Engineered surfaces?



(source: Univ. of Rochester, Prof Guo)

https://youtu.be/FLegmQ8_dHg

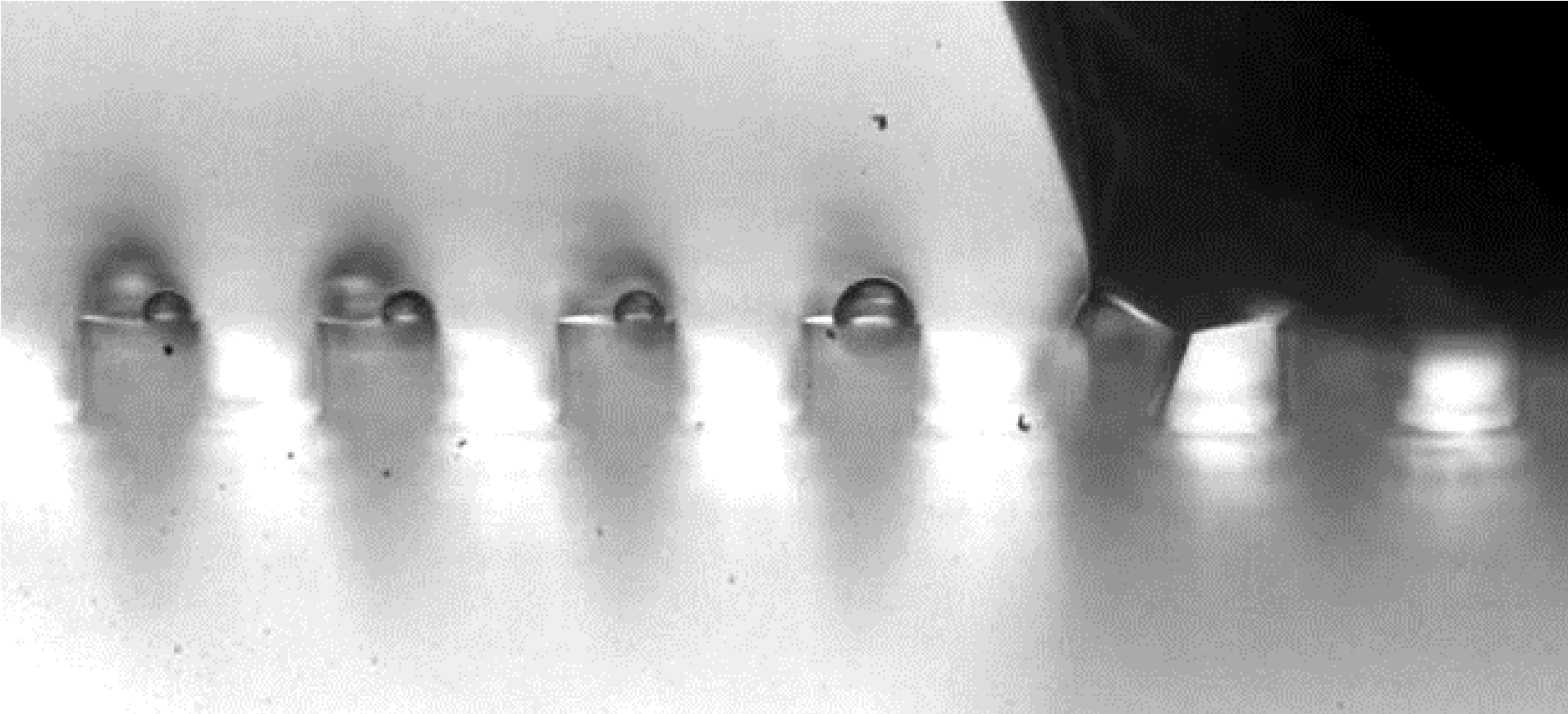
Wettability gradient



(Source D-MAVT / ETHZ)
<https://youtu.be/puYo9w4cuOc>

(source: J. Israelachvili, Adhesion and Wetting Phenomena)

Illustration of research at EPFL



(Courtesy Prof. Kolinsky, EMSI) / PNAS
<https://doi.org/10.1073/pnas.2008683117>

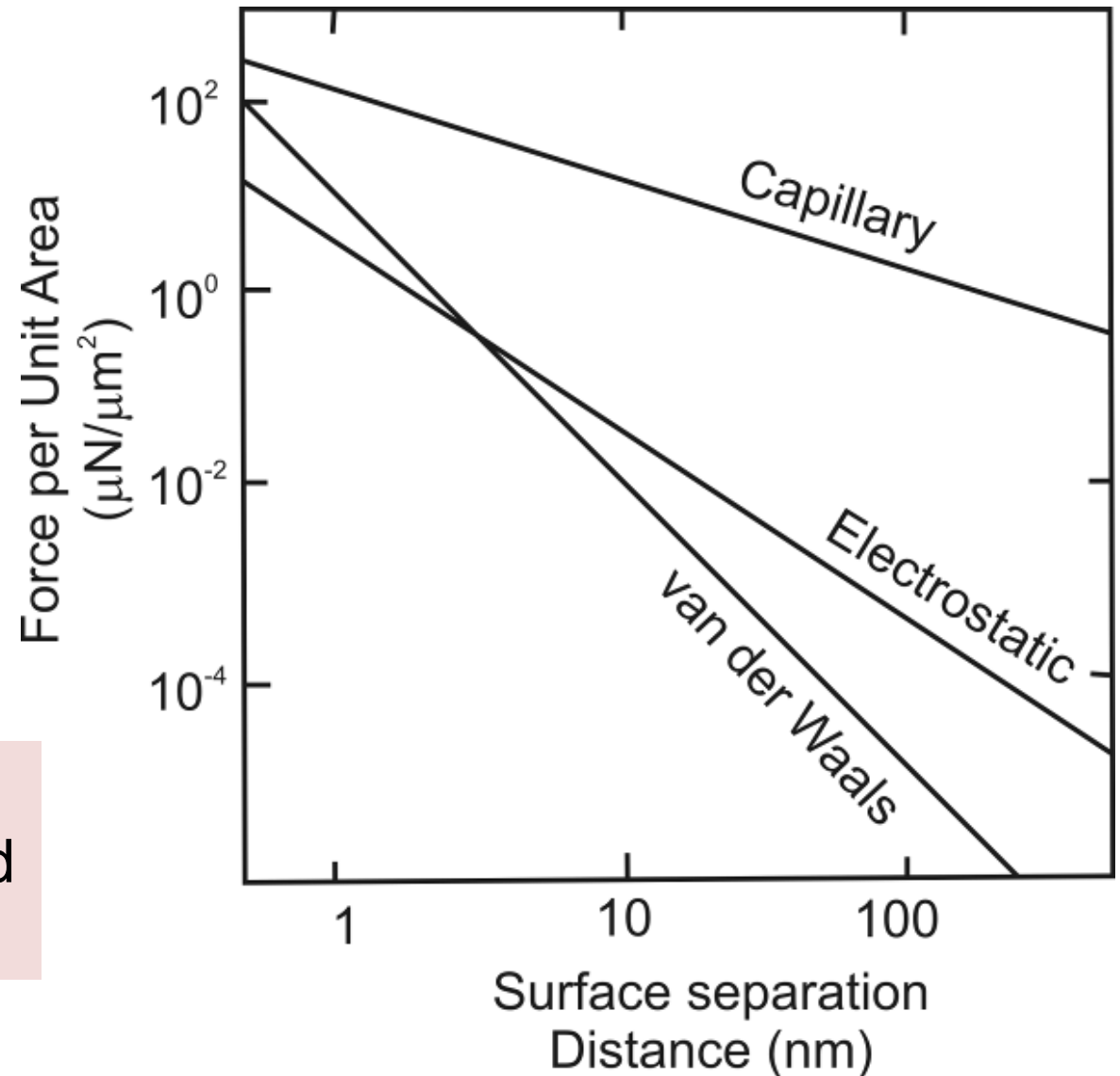
Illustration of a droplet 'walking on soft pillars'
being deformed by surface tension.

Adhesion properties of surfaces

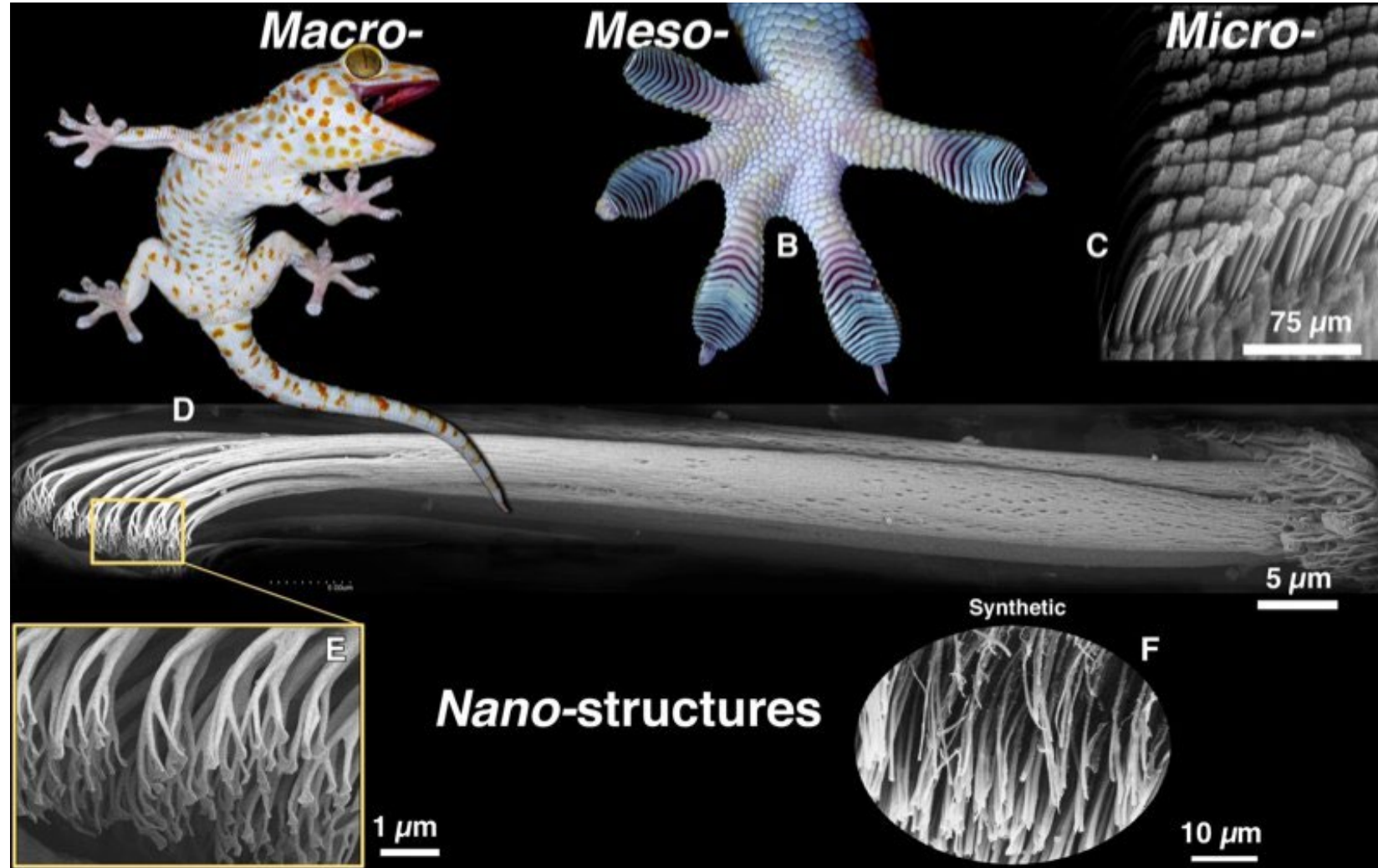
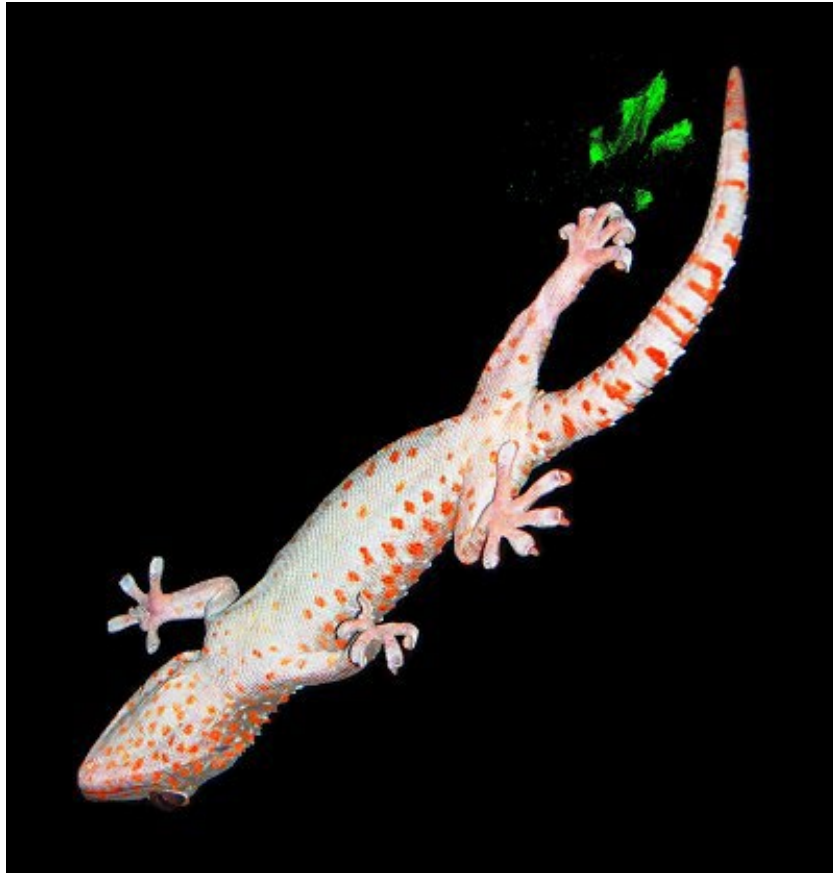
Adhesion force: 'illustrative' comparison

- Example for two SiO_2 surfaces ($U=1\text{V}$, $AH = 1.7\text{eV}$, $\gamma = 73\text{ dyne/cm.}$)

The nature of the adhesion forces changes with the type of surfaces and the surface separation distance!

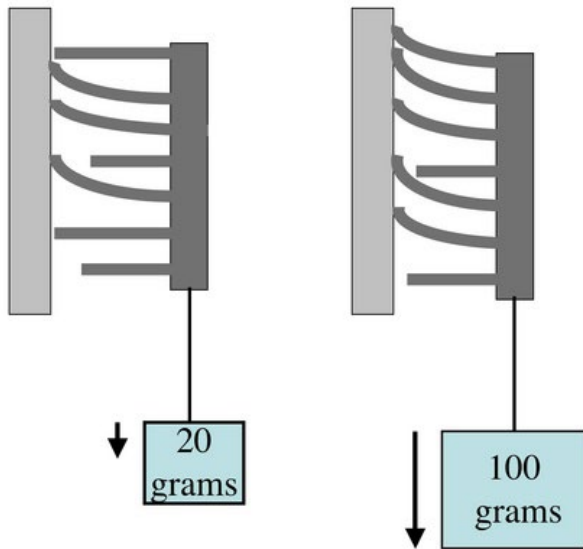


From the Gecko mystery... (a multiscale interaction)

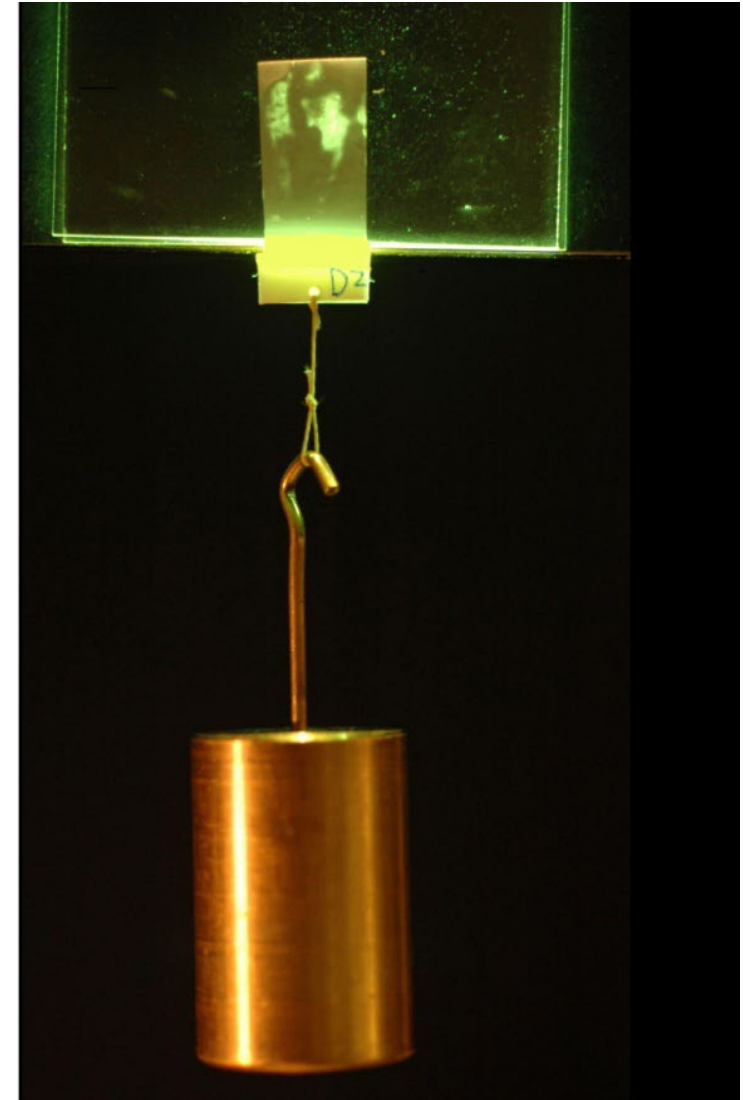
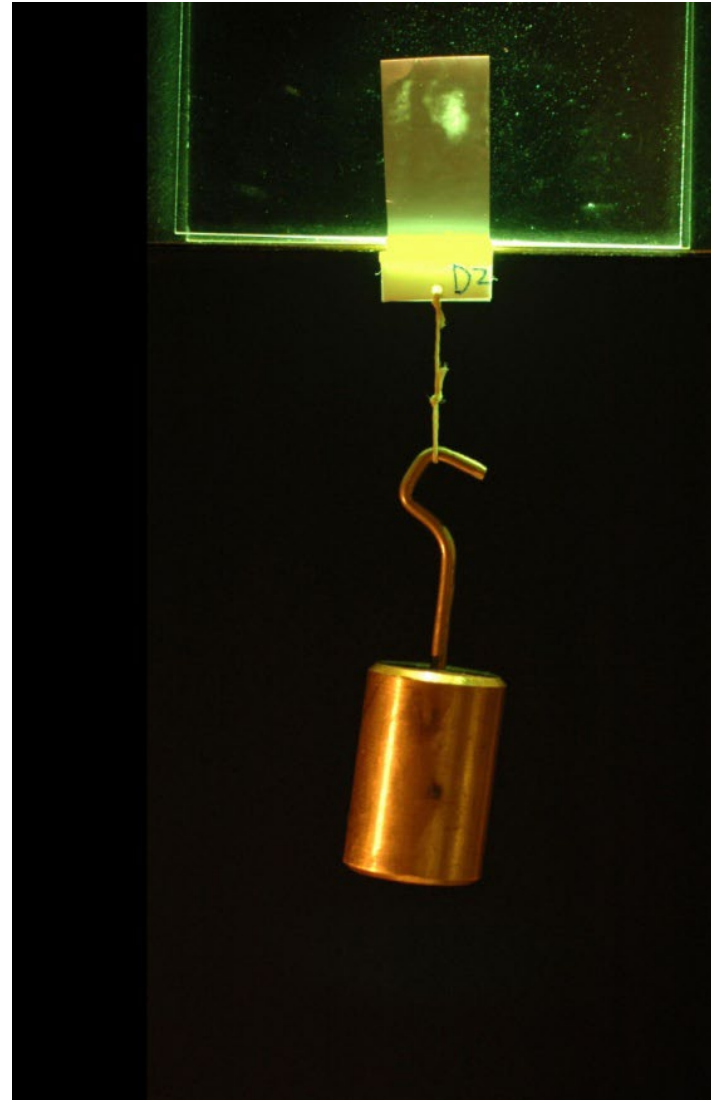


(pictures source: K. Autumn, Lewis & Clark College, USA)

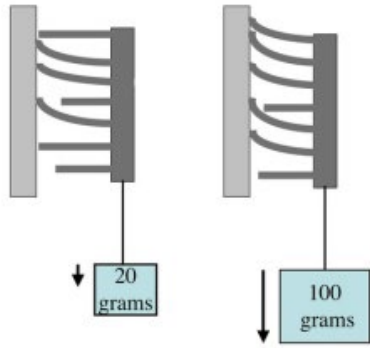
To new adhesive principles....



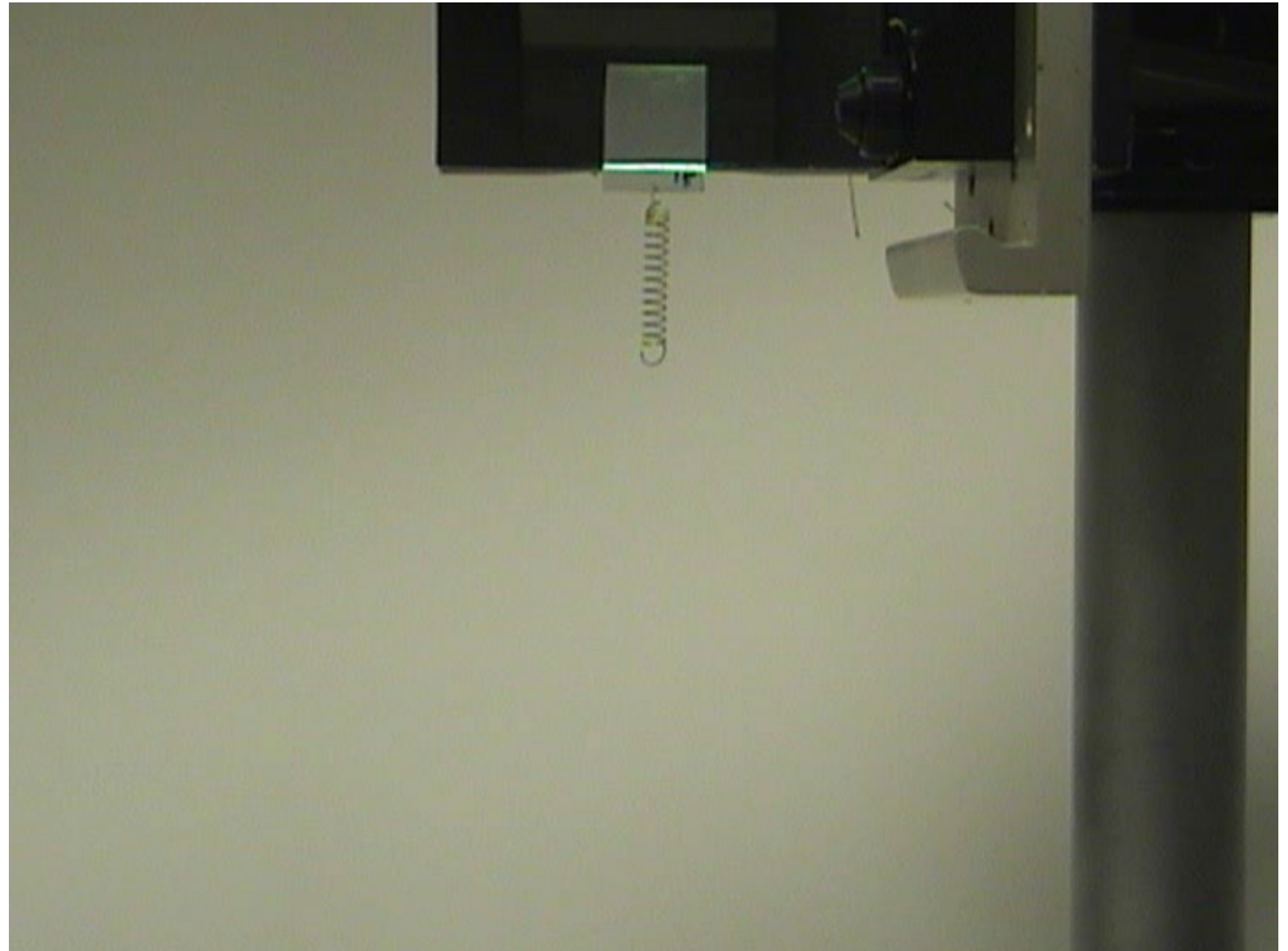
(source: Ron Fearing, UC, Berkeley)



To new adhesive principles....



(source: Ron Fearing,
UC, Berkeley)



In industry: The optical contacting method

- Surface are so smooth that van der Waals surfaces prevails (sub-nm contact distances)



Source:

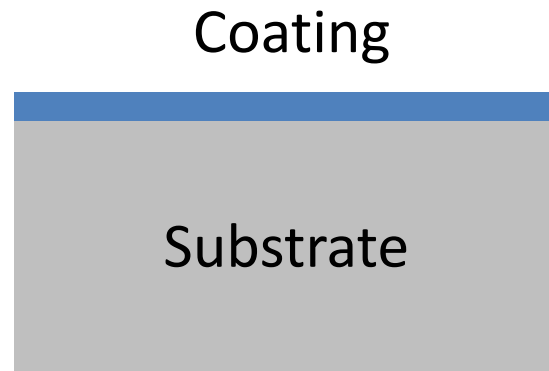
https://youtu.be/se3K_MWR488

<https://youtu.be/hxGMA0nxdEU>

A few words about surface treatment

Surface treatments: coatings

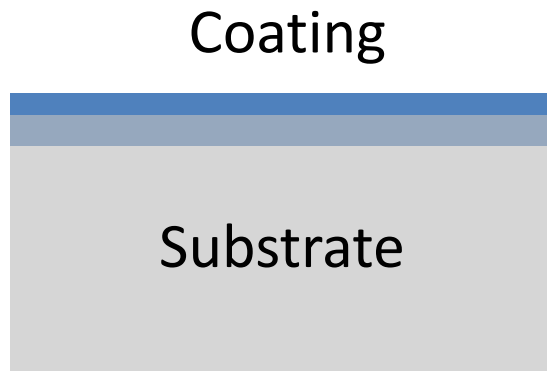
- ✓ **Two separate materials**, the substrate and the coating
- ✓ The coating **does not react** with the substrate
- ✓ Lot of available processes to deposit a coating



- **‘Through a liquid phase’** : Electrolysis, Chemical, Painting, etc.
- **‘Dry method’**: Physical Vapor Deposition, Chemical Vapor Deposition
- **‘Thermal’**: flame, plasma, arc, explosive, etc.
- **‘Beam assisted’**: laser, implantation, etc.
- ... and many others...

Surface treatments: conversion methods / reacting methods)

- ✓ **Two materials**, the feed-material reacts with the substrate to form a new compound.
- ✓ Localized chemical reaction



- **‘Electrochemical conversion’** : anodizing of aluminum, titanium, zirconium... / Coloration of steel / Sulfurization in salt bath, etc.
- **‘Chemical conversion’**

Examples

Anodized aluminum



(source Wiki)

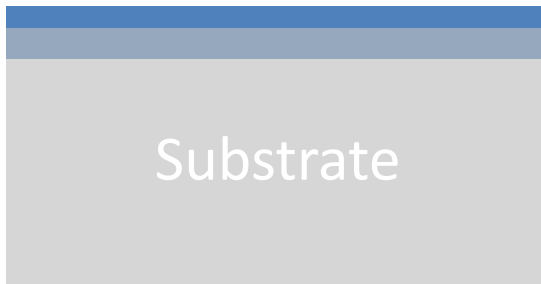
Dye + anodization



Surface treatments: thermo-chemical

- ✓ **Two materials**, the feed-material diffuses into the substrates (and may or may not form a new compound).
- ✓ Diffusion process

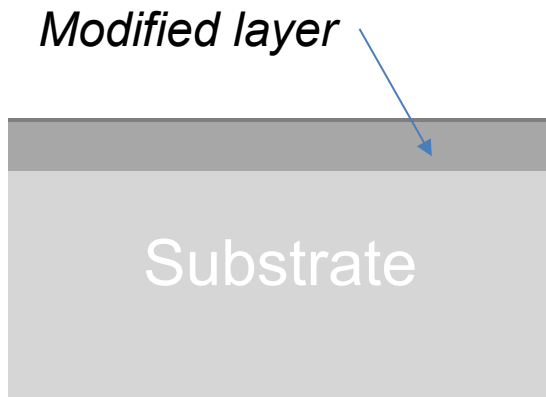
Coating



- **‘Metal/ metalloid diffusion’** : chrome (‘chromisation’), tantalum, vanadium, ...; ion mixing, laser-induced mixing,...; cementations, carbonitration, etc.

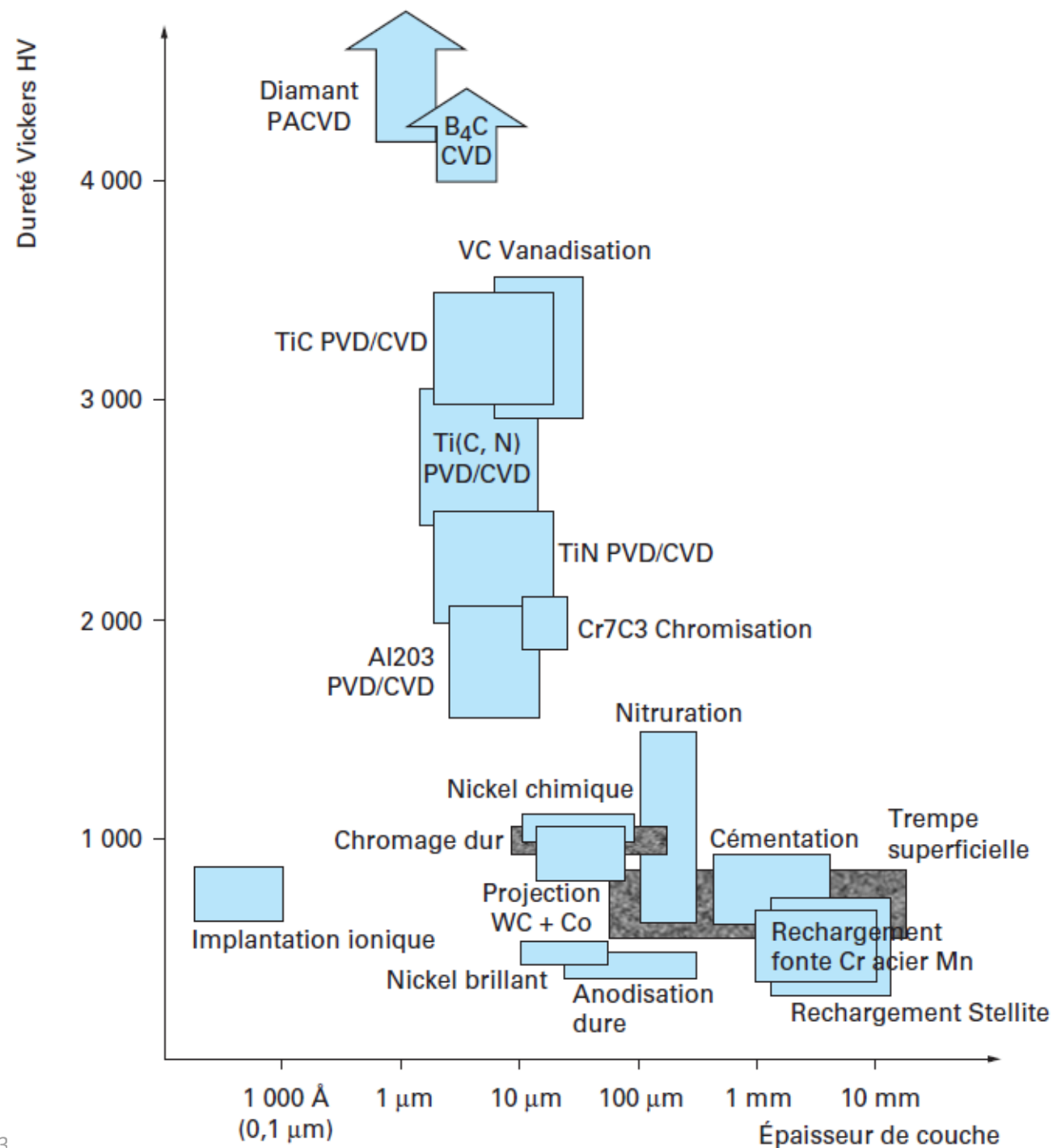
Surface treatments: thermal and mechanical, textured localized transformation

- ✓ **One material only** - the substrate
- ✓ **Local** process of mechanical hardening ('écrouissage'), thermal annealing, texturing.



- **Mechanical hardening** : hardening, shock peening ('grenailage'), laser-shock peening, etc.
- **Localized thermal treatment** : local quenching, flame, laser-annealing, ...
- **Nanoscale texturing**: laser-induced ripples, ...

Surface treatments to improve the hardness



(Source R. Gras,
Techniques de l'ingénieur)

Wrap-up

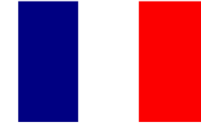
Key points to remember

- Importance of surface topological information and physical properties.
- Relation between surface and functionality
- How topography affects functional properties
- How do we measure the topography surfaces
 - Surface metrology principles
 - Roughness, waviness
 - Abbott-Firestone curves (bearing ratio)
- Role of manufacturing in engineering surfaces



'Lexique manufacturing'

English (UK) > French

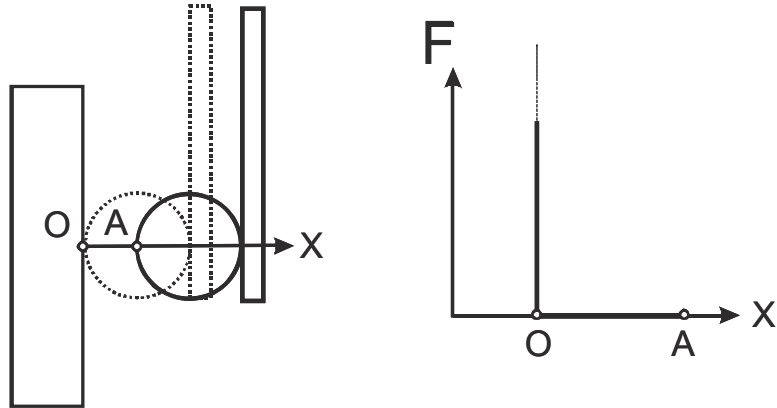


- Waviness: *Ondulation de surface*
- Roughness: *Rugosité*
- Toughness: *Tenacité*
- Wear: *Usure*
- Anodized: ~ *Eloxé** (néologisme vient de 'Electricly oxidized') / *Anodisé*
- Dye: *Colorant*
- Diffusivity: *Diffusivité*
- Scattering: *Lumière diffuse*
- Specular reflection: *Réflexion spéculaire*
- Grazing incidence: *Incidence rasante*
- Coatings: *Couches minces déposées*
- Diamond turning: *Tournage pointe diamant*

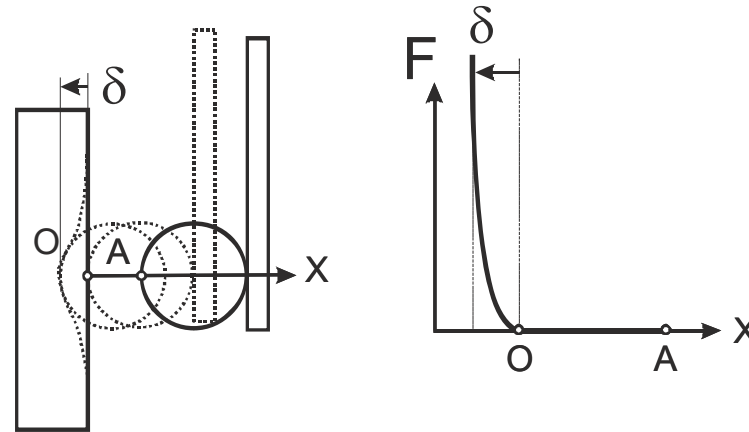
Annex on adhesion properties (to explore the topic further)

Physics of adhesion (introduction)

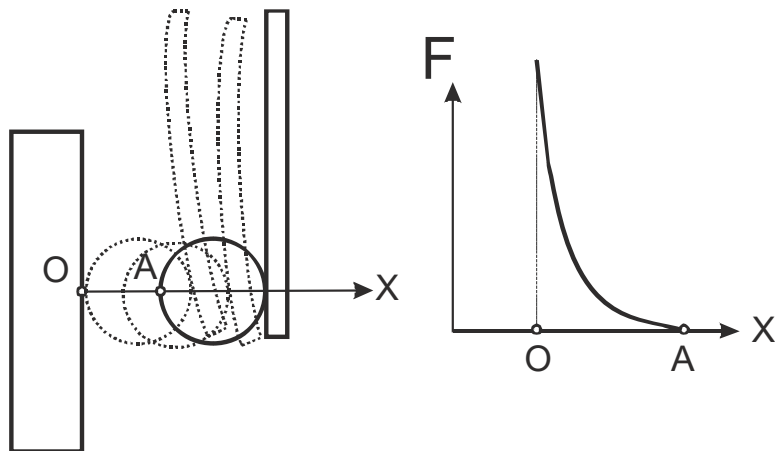
1. *Without surface forces*



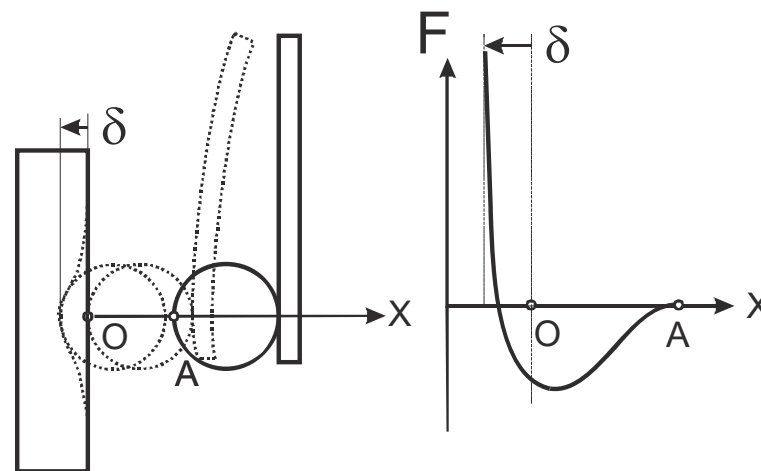
2.



3. *With surface forces*



4.



Measuring surface forces

- 'Large surface'
- Atomically smooth < nm roughness
- Typ. force resolution. 10^{-8} N

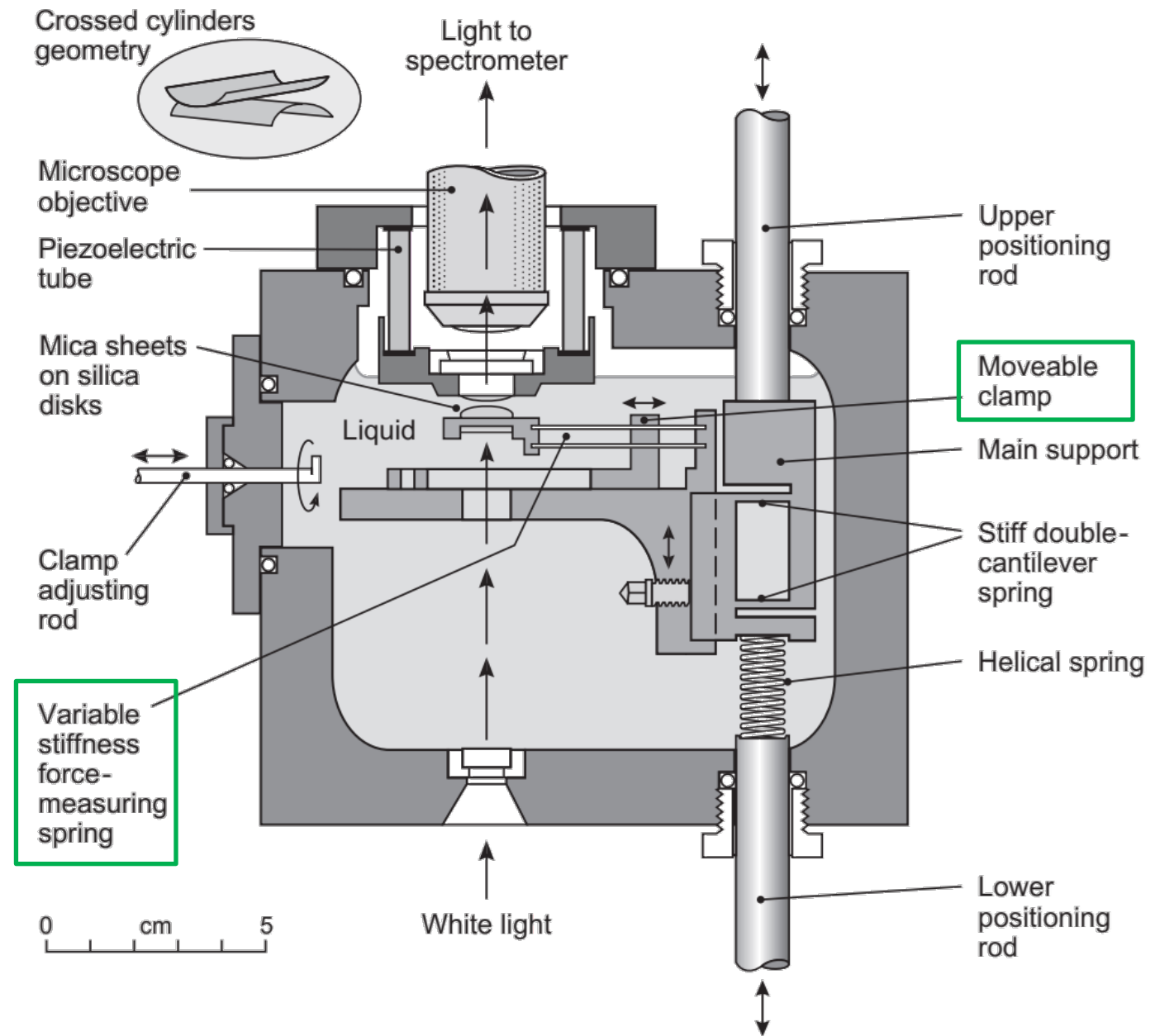
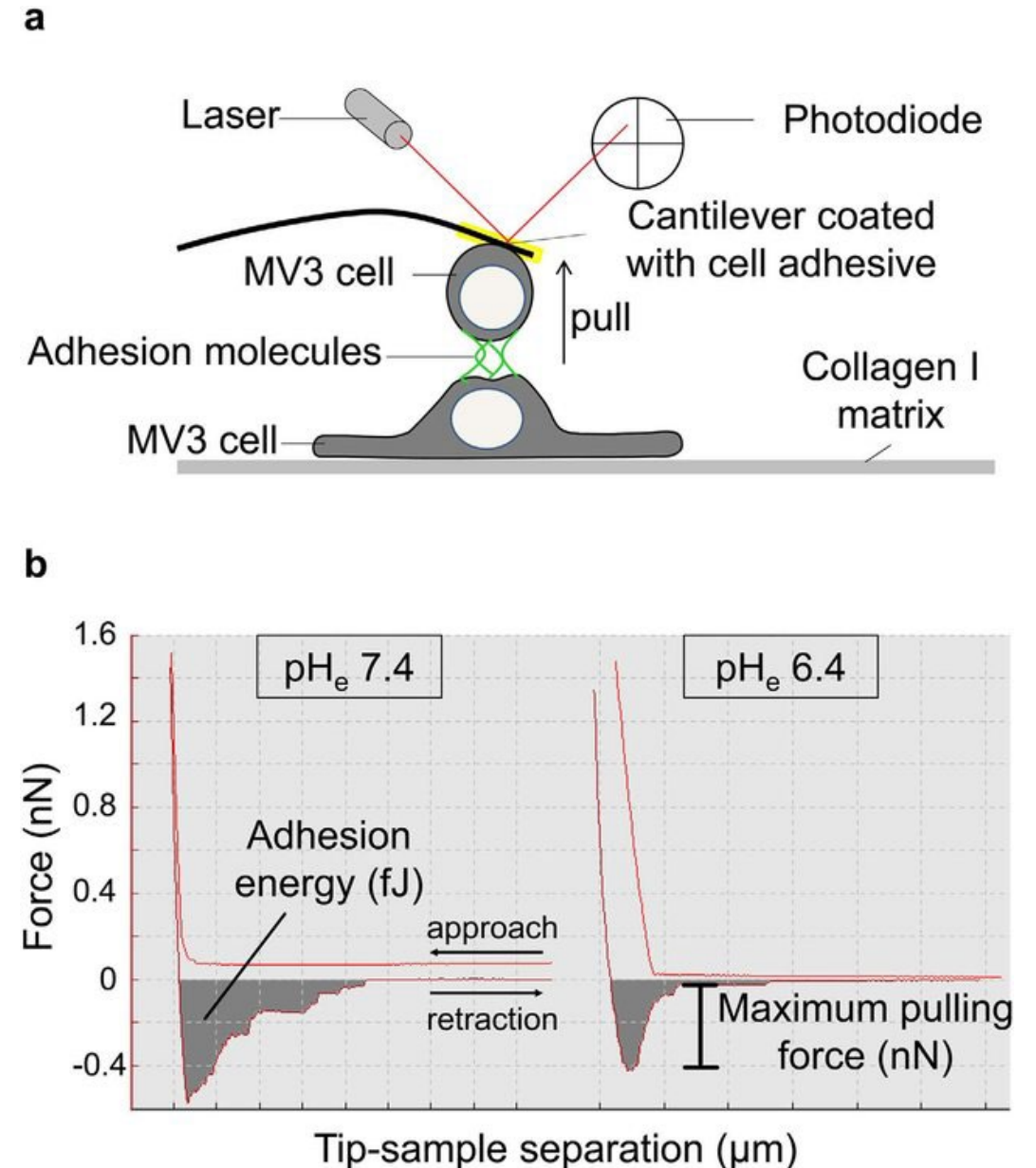


Illustration of cell-cell adhesion

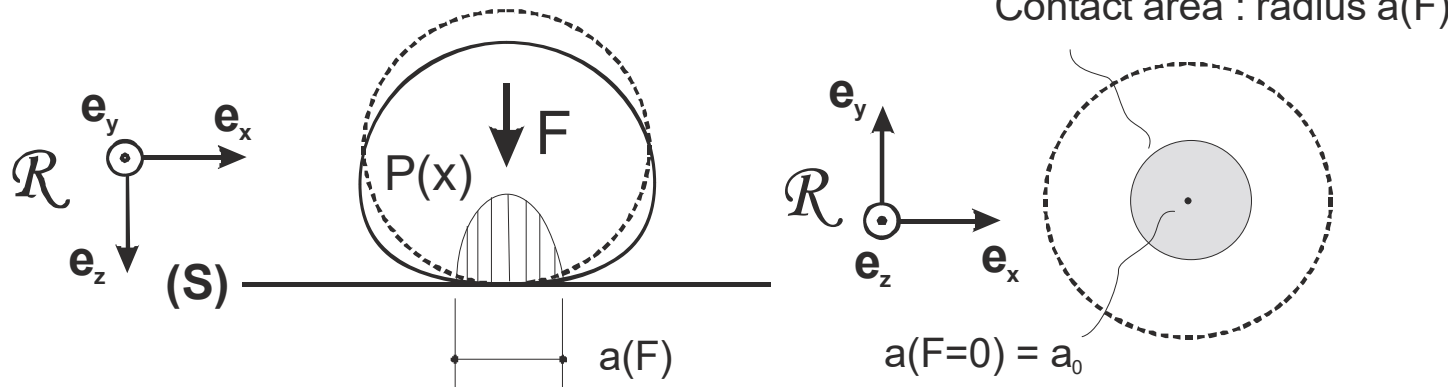
Schematic illustration of cell-cell adhesion analysis using AFM. (a) Single cell force spectroscopy. A single melanoma cell (MV3) attached to a flexible cantilever is brought into contact with another adherent melanoma cell of the same kind seeded on collagen



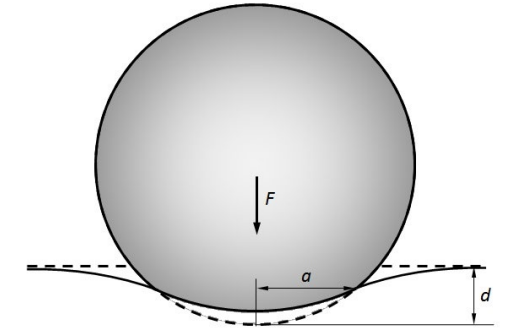
Hofschröer, V., et al. Extracellular protonation modulates cell-cell interaction mechanics and tissue invasion in human melanoma cells. *Sci Rep* 7, 42369 (2017). <https://doi.org/10.1038/srep42369>

Contact surfaces

- Importance in manufacturing => Choice of material in contact areas
- Without adhesion forces
 - Hertz model (sphere on a plane / sphere deforms)
 - [variation: Sneddon model (sphere on a plane / plane deforms)]



(Hertz model / sphere on a plane, assuming the sphere deforms)



(Sneddon model / sphere on a plane, assuming the plane deforms)

Sphere on a plane (Hertz/Sneddon)



- Assumes elastic deformation
- Small deformation

Pressure distribution

$$p(r) = p_0 \left[1 - \left(\frac{r}{a} \right)^2 \right]^{\frac{1}{2}}$$

Effective Young modulus of the elastic interface:

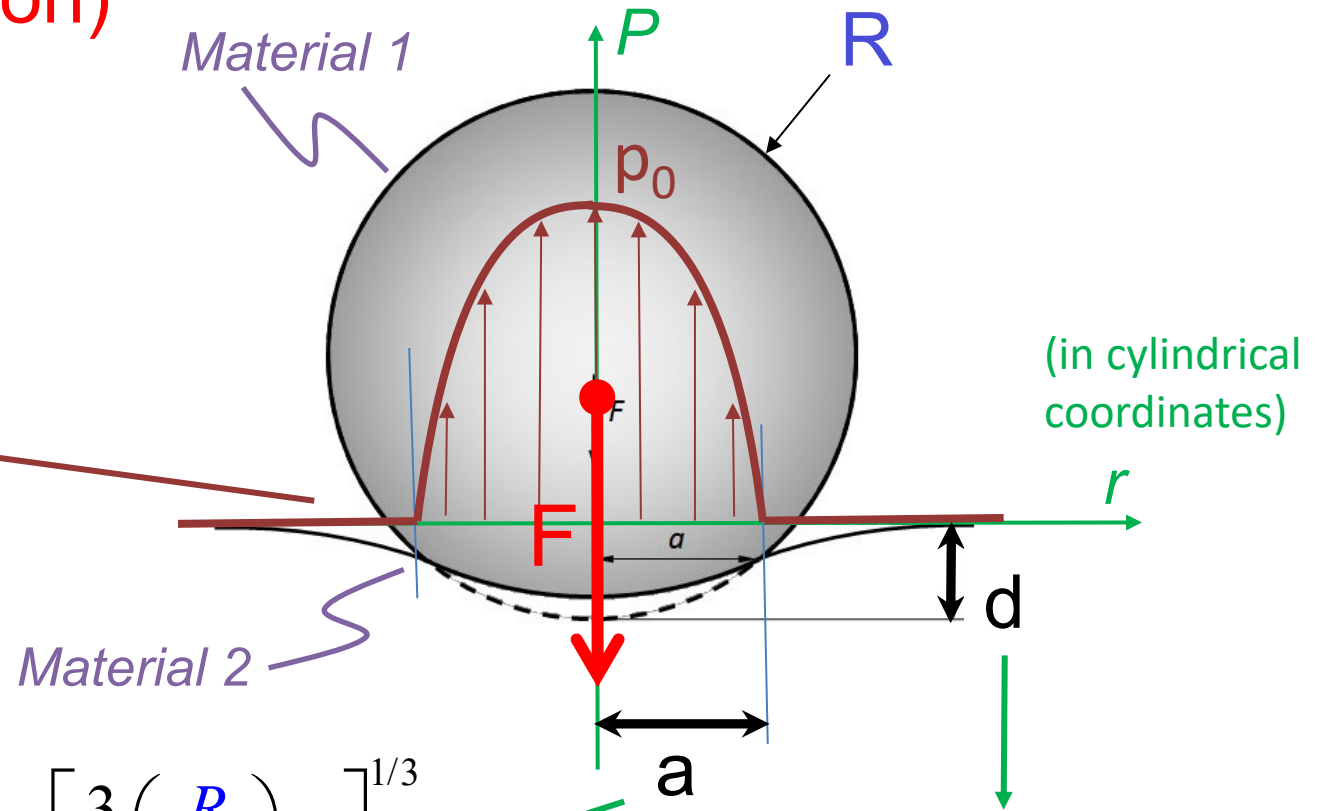
$$\frac{1}{E^*} = \underbrace{\left(\frac{1 - \nu_1^2}{E_1} \right)}_{\text{Material 1 } (E_1, \nu_1)} + \underbrace{\left(\frac{1 - \nu_2^2}{E_2} \right)}_{\text{Material 2 } (E_2, \nu_2)}$$

(ν Coefficient de Poisson)

$$a \approx \left[\frac{3}{2} \left(\frac{R}{E^*} \right) F \right]^{1/3}$$

$$d \approx \frac{a^2}{R} = \left[\left(\frac{2}{E^{*2} R} \right) F^2 \right]^{1/3}$$

$$F = \frac{4}{3} E^* R^{\frac{1}{2}} d^{\frac{3}{2}}$$



Sphere on a plane (Hertz/Sneddon)

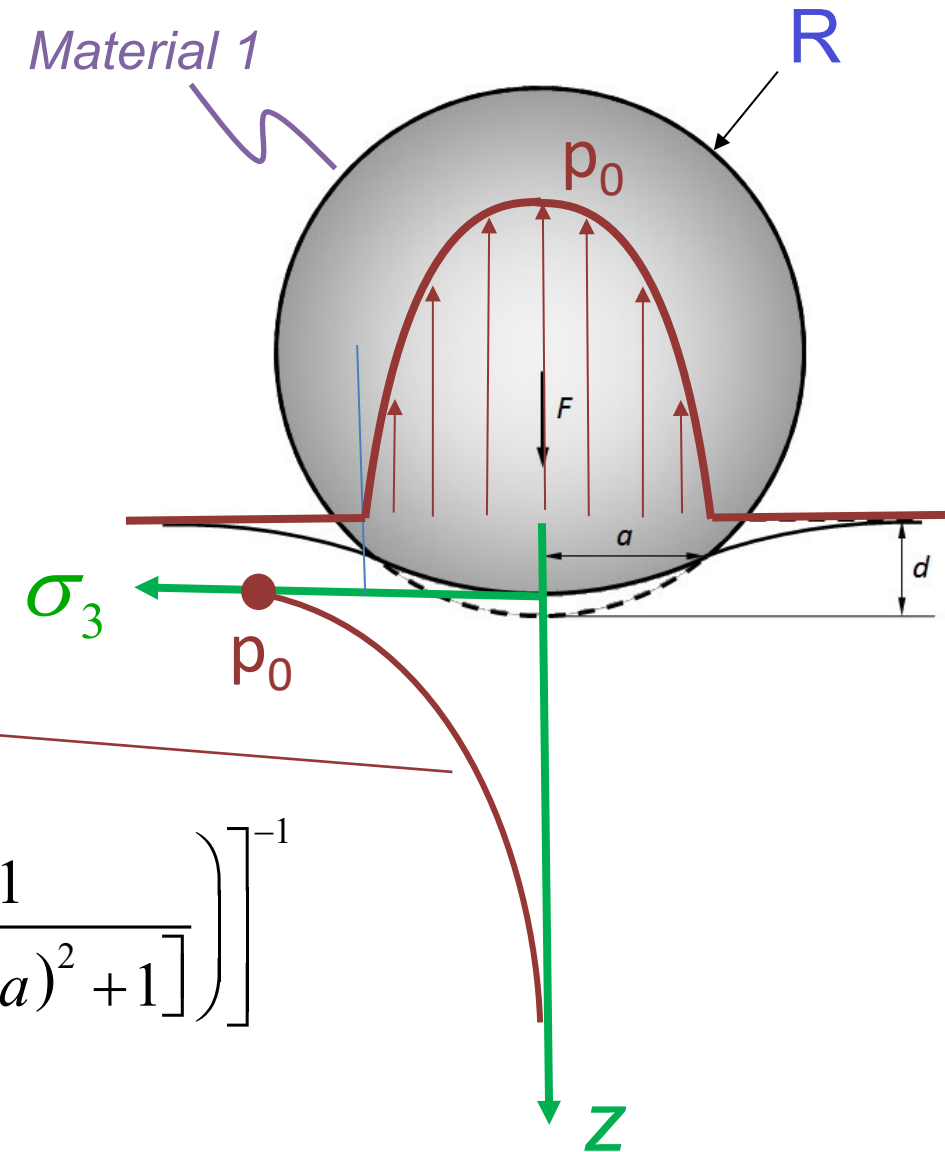
Principal stress (symmetric = cylindrical geometry)

$$\boldsymbol{\sigma} = \begin{pmatrix} \sigma_1 & 0 & 0 \\ 0 & \sigma_2 & 0 \\ 0 & 0 & \sigma_3 \end{pmatrix} = \begin{pmatrix} \sigma_{\perp} & 0 & 0 \\ 0 & \sigma_{\perp} & 0 \\ 0 & 0 & \sigma_{\parallel} \end{pmatrix}$$

$$\sigma_3 = \sigma_{\parallel}(z) = -p_0 \left[1 + \left(\frac{z}{a} \right)^2 \right]^{-1}$$

$$\sigma_1 = \sigma_2 = \sigma_{\perp}(z) = -p_0 \left[(1 + \nu_2) \left(1 - \left| \frac{z}{a} \right|^2 \tan^{-1} \left(\left| \frac{z}{a} \right| \right) - \frac{1}{2 \left[(z/a)^2 + 1 \right]} \right) \right]^{-1}$$

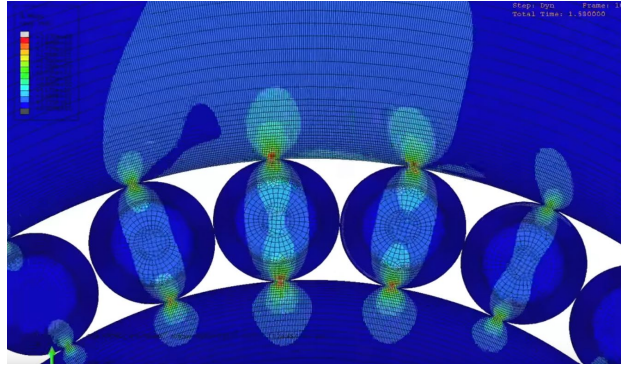
Principal shear stresses: $|\tau_1| = |\tau_2| = \tau_{\max} = \left| \frac{\sigma_{\perp} - \sigma_{\parallel}}{2} \right|$



Similar models exist for other contact configuration (cylinder on a plane, sphere on a sphere, etc.)

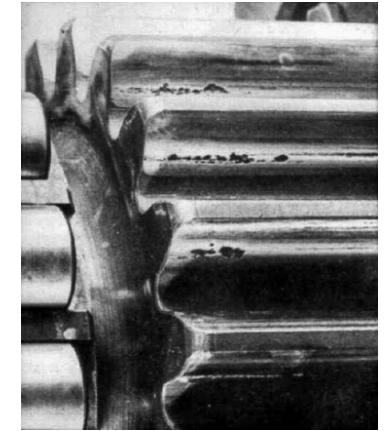
Importance in manufacturing: choice of materials/design for minimizing wear/high-contact force effects

Roller bearing

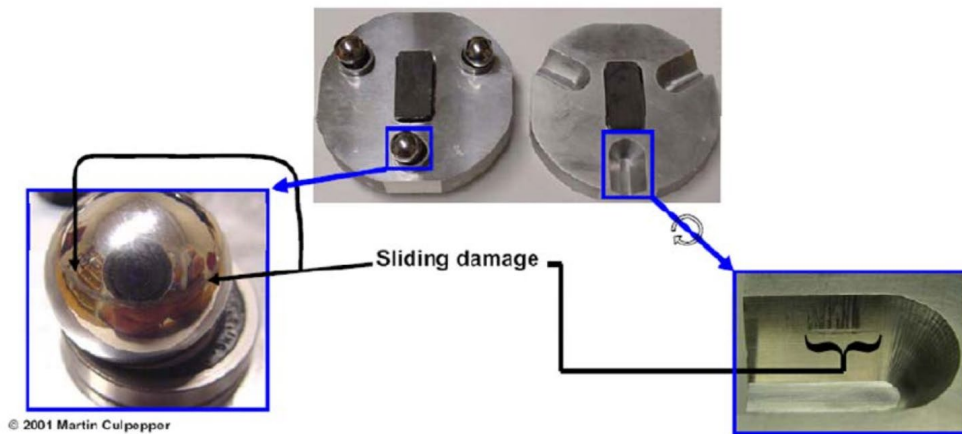


Source: <https://youtu.be/20exjzKSzB8>

Pressure on gear trains



Pressure on high precision reference elements



(source Martin Culpepper, MIT)

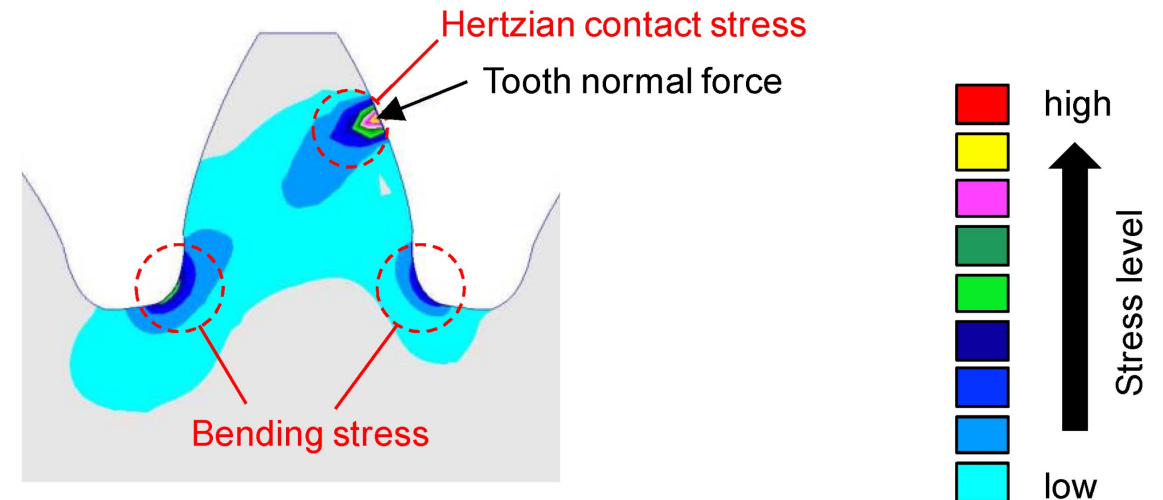
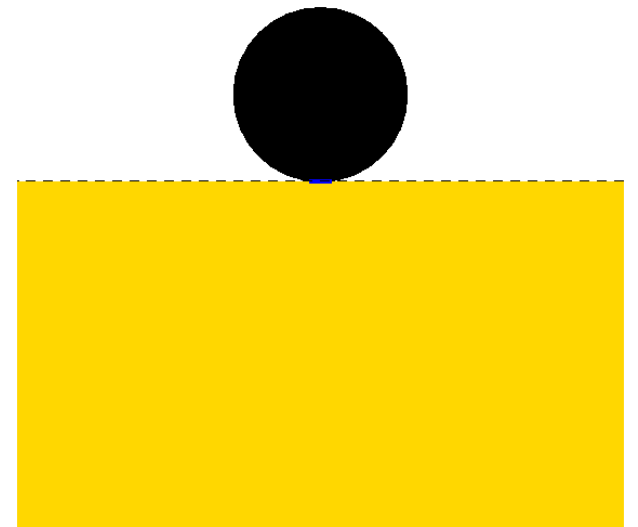


Illustration source: Tobie Thomas, et al. 2017. "Optimizing Gear Performance by Alloy Modification of Carburizing Steels" *Metals* 7, no. 10: 415. <https://doi.org/10.3390/met7100415>

Models of adhesion forces

Hertz contact theory assumes no contact forces. The presence of adhesion forces modifies the contact area and hence, how the stress is distributed and evolves.

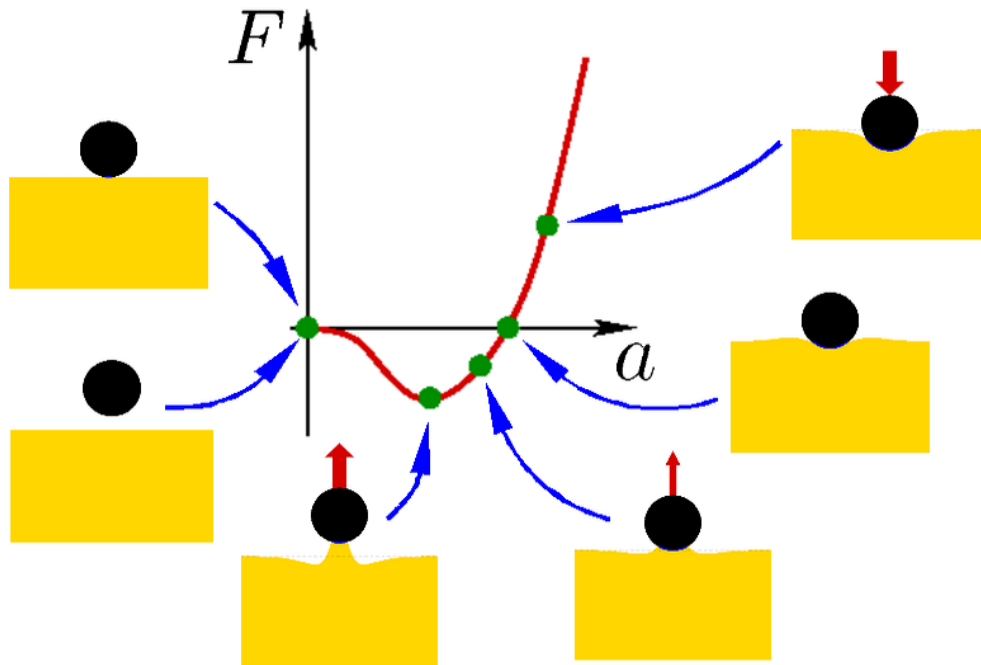
- Johnson-Kendall-Roberts (JKR)
 - Contact area (with adhesion forces **in** the contact area only)
- Derjaguin-Müller-Toporov (DMT)
 - Contact area (with uniform adhesion forces)
- Maugis / Dugdale
 - Contact area (with annular adhesion forces)



(illustration Wikipedia)

Johnson-Kendall-Roberts (JKR) model

- Adhesion in the contact area only



(source Wikipedia)

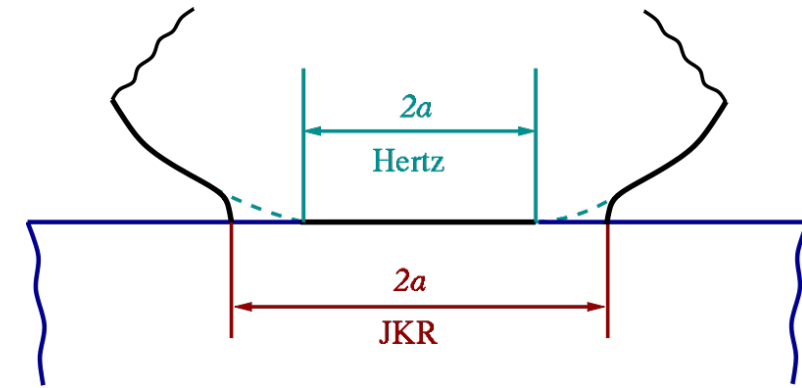
$$a^3 = \frac{3R}{4E^*} \left(F + \underbrace{6\pi\gamma R + \sqrt{12\pi\gamma RF + (6\pi\gamma R)^2}}_{\text{Effect of adhesion forces}} \right)$$

Hertz mode (sphere-sphere)

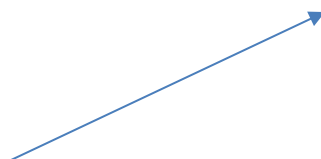

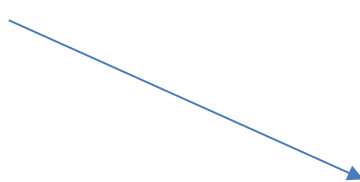
When no force is applied ($F=0$):

$$a^3 = \frac{9R^2\pi\gamma}{4E^*}$$

Pull-off force: $F_c = -3\gamma\pi R$



Nature of the adhesion forces

- Capillary forces  *Due to the presence of water
(moisture in the atmosphere)*
- Electrostatic  *Due to the presence of
electrostatic forces*
- Van der Waals  *Interaction at the near atomic
scale*

Capillary forces

- Vapor pressure is smaller on curve surface (Kelvin equation)
- Formation of liquid meniscus at interface
- Pressure difference vapor/liquid => Attractive force

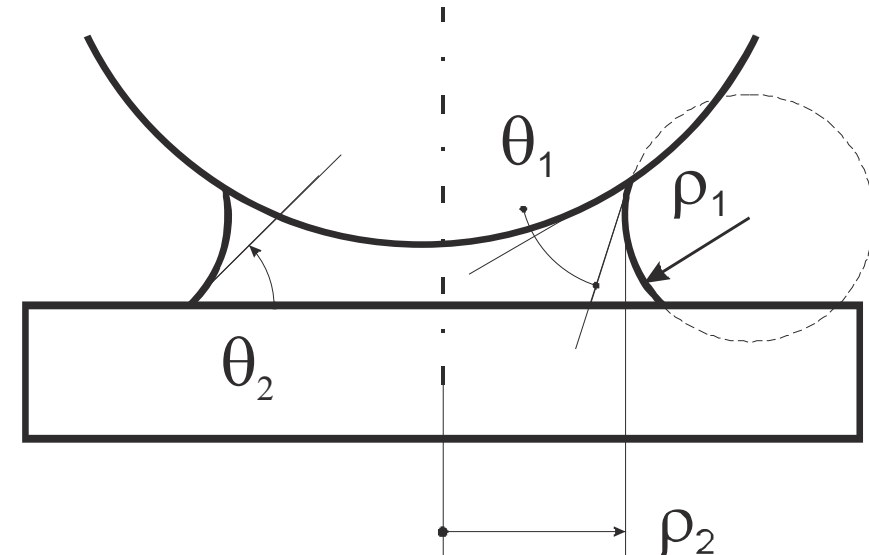
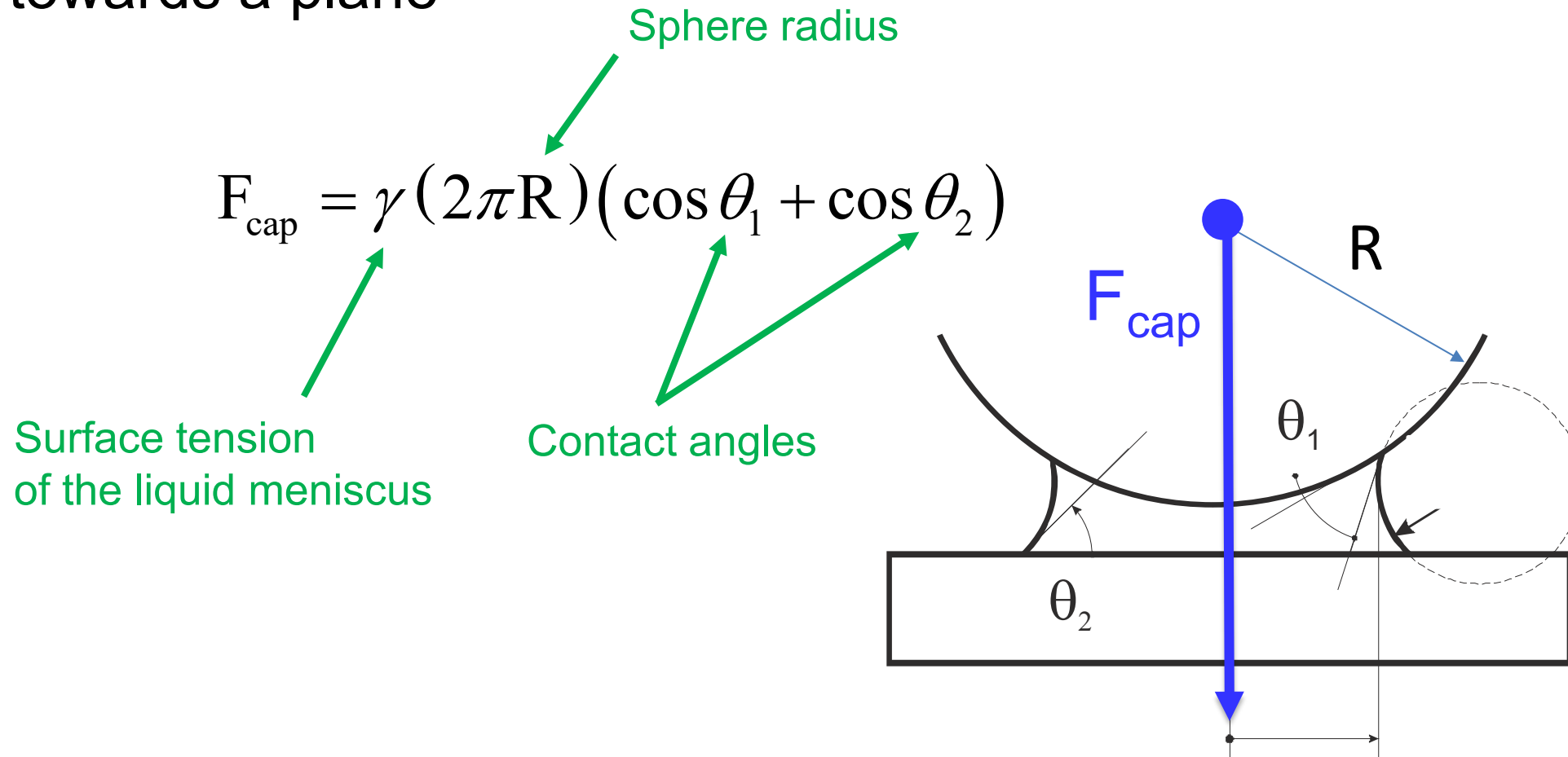


Illustration of capillary forces

- Example of a water meniscus that pulls a sphere towards a plane



Electrostatic forces

- Due to presence of surface charges
- Example: force due to a uniformed density of charges on a flat surface (from Gauss theorem)

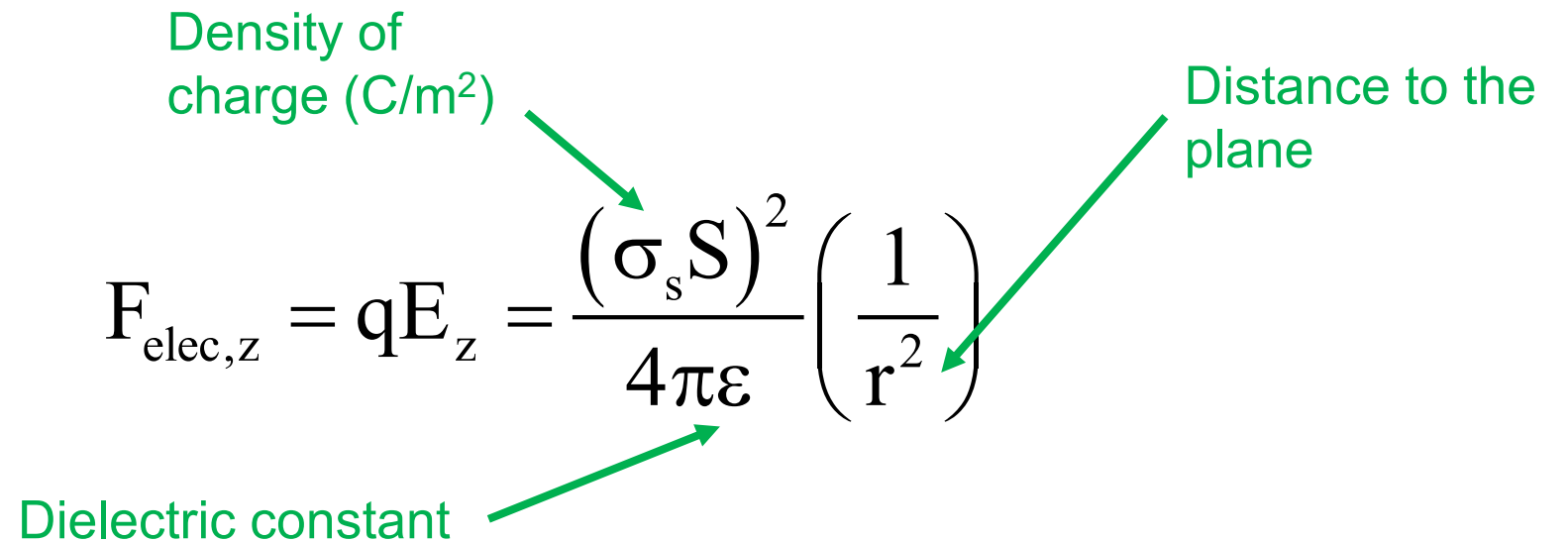


Diagram illustrating the formula for the electrostatic force $F_{\text{elec},z} = qE_z = \frac{(\sigma_s S)^2}{4\pi\epsilon} \left(\frac{1}{r^2} \right)$ with annotations:

- Density of charge (C/m²) points to σ_s .
- Distance to the plane points to r^2 .
- Dielectric constant points to ϵ .

- Pressure induced

$$p = \left(\frac{\sigma_s^2}{2\epsilon} \right)$$

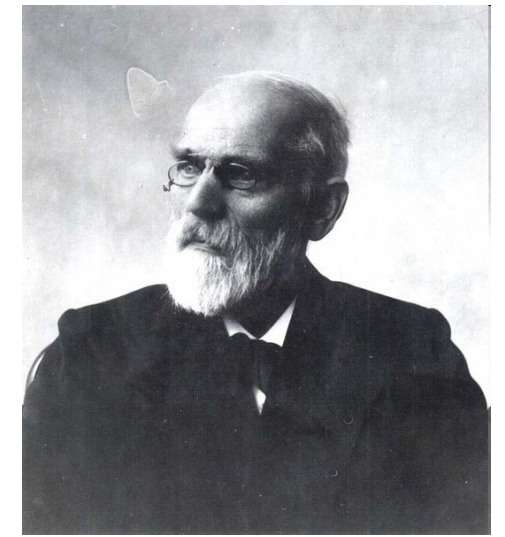
Electrostatic forces

Orders of magnitude

Air	$\sigma_s = 3 \cdot 10^{-5} \text{ C/m}^2$	$p \approx 50 \text{ Pa}$ (gap typ. $1 \mu\text{m}$)
Good insulator	$\sigma_s = 10 \text{ mC/m}^2$	$p \approx 1 \text{ MPa}$ (gap typ. $1 \mu\text{m}$)

Van der Waals forces

- Present in any solids
- Interaction between dipole moments of atoms
- Three components:
 - Keesom: dipole-dipole (C_K)
 - Debye: dipole-dipole induced (C_D)
 - Dispersion: instantaneous dipole-dipole induced (C_L)



Johannes Diderik van der Waals (1837 – 1923)

van der Waals Potential:

$$U_{\text{vdW}} = -\frac{C_K + C_D + C_L}{r^6}$$

Short distance interaction !
(rapidly decay)

Van der Waals forces (integrated forms for various geometries)

Geometry	Force
Two flat surfaces (per unit area dS)	$F = f \cdot dS \quad \text{with} \quad f = -\frac{A_H}{6\pi D^3}$
Two spheres (diameters R_1 and R_2)	$F = -\frac{A_H}{6D^2} \frac{R_1 R_2}{R_1 + R_2}$
Sphere (diameter R) – flat surface	$F = -\frac{A_H R}{6D^2}$
Cylinder (diameter R) – flat surface	$F = -\frac{A_H R^2}{6D^3}$

A_H is the Hamaker constants (material dependant)